

Tutorial on short pulse generation with VECSELs and MIXSELs

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SPIE LASE, Vertical External Cavity Surface Emitting Lasers (VECSELs) X

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Acknowledgements



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Oliver Sieber (2013)



Valentin Wittwer (2012)



Martin Hoffmann (2011)



Dr. Thomas Südmeyer (2011)



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Aude-Reine Bellancourt (2009)



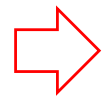
Jacob Nürnberg



Dr. Matthias Golling



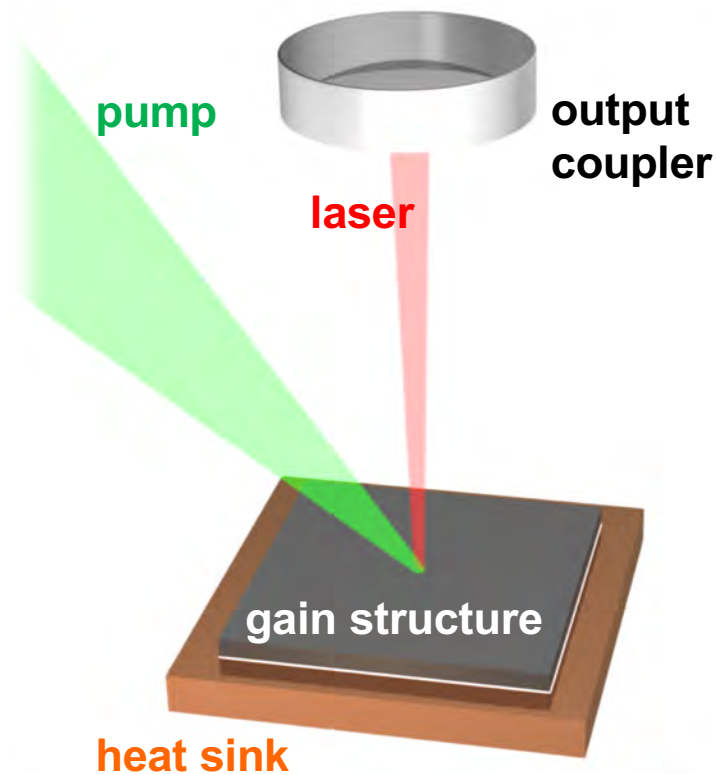
Deran Maas (2008)



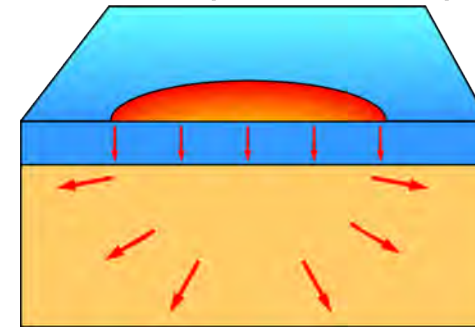
- 1. Introduction to ultrafast semiconductor disk lasers**
- 2. SESAM-modelocked VECSELs**
- 3. MIXSEL**
- 4. 100-fs VECSEL**
- 5. 139-fs MIXSEL**
- 6. Outlook**

OP-VECSEL = **O**ptically **P**umped **V**ertical-**E**xternal-**C**avity
Surface-**E**mitting Semiconductor **L**aser

M. Kuznetsov et al., *IEEE Photon. Technol. Lett.* **9**, 1063 (1997)



- Semiconductor gain structure with reduced thickness ($\approx 10 \mu\text{m}$)

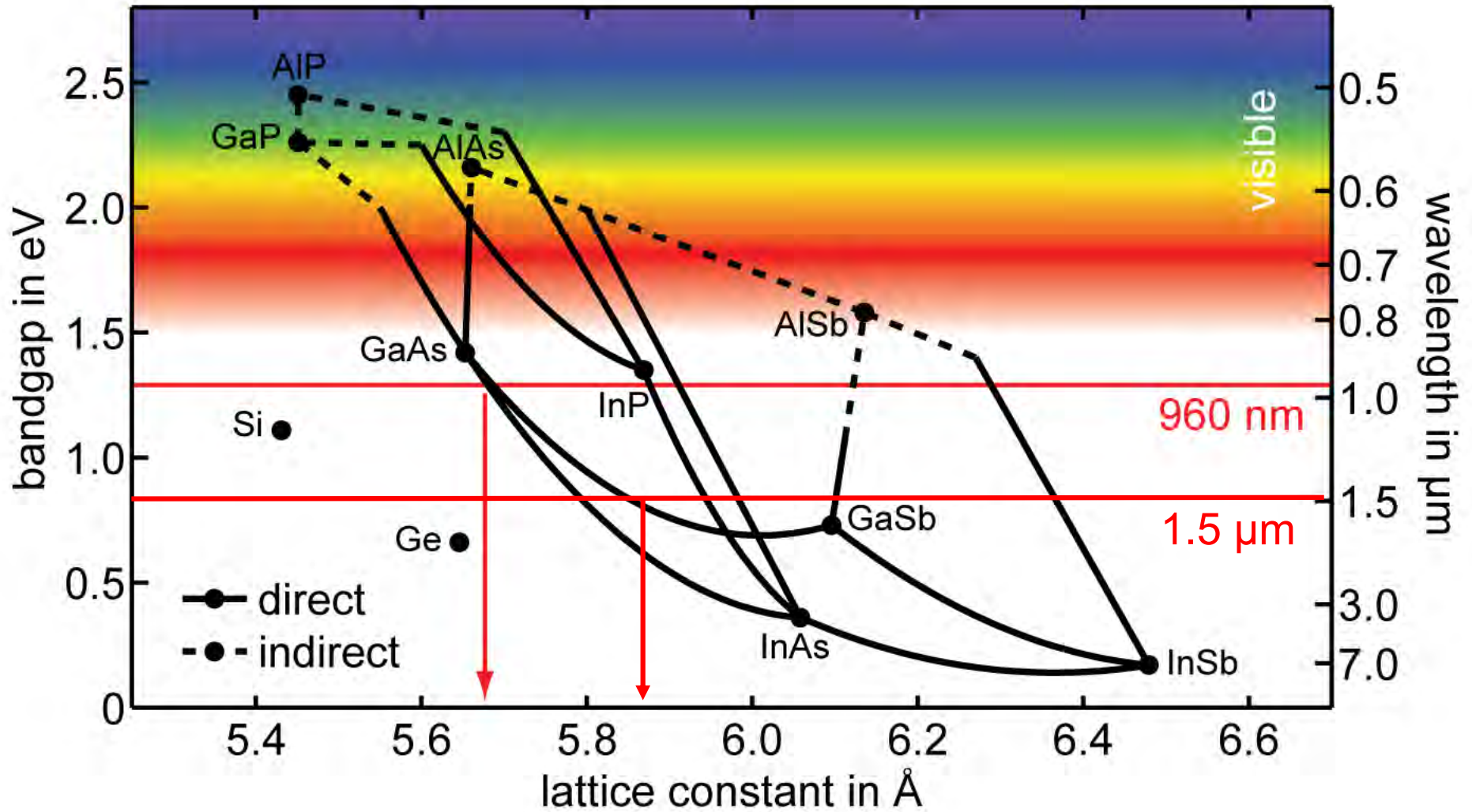


IEEE JQE 38, 1268 (2002)

SDLs = semiconductor disk lasers

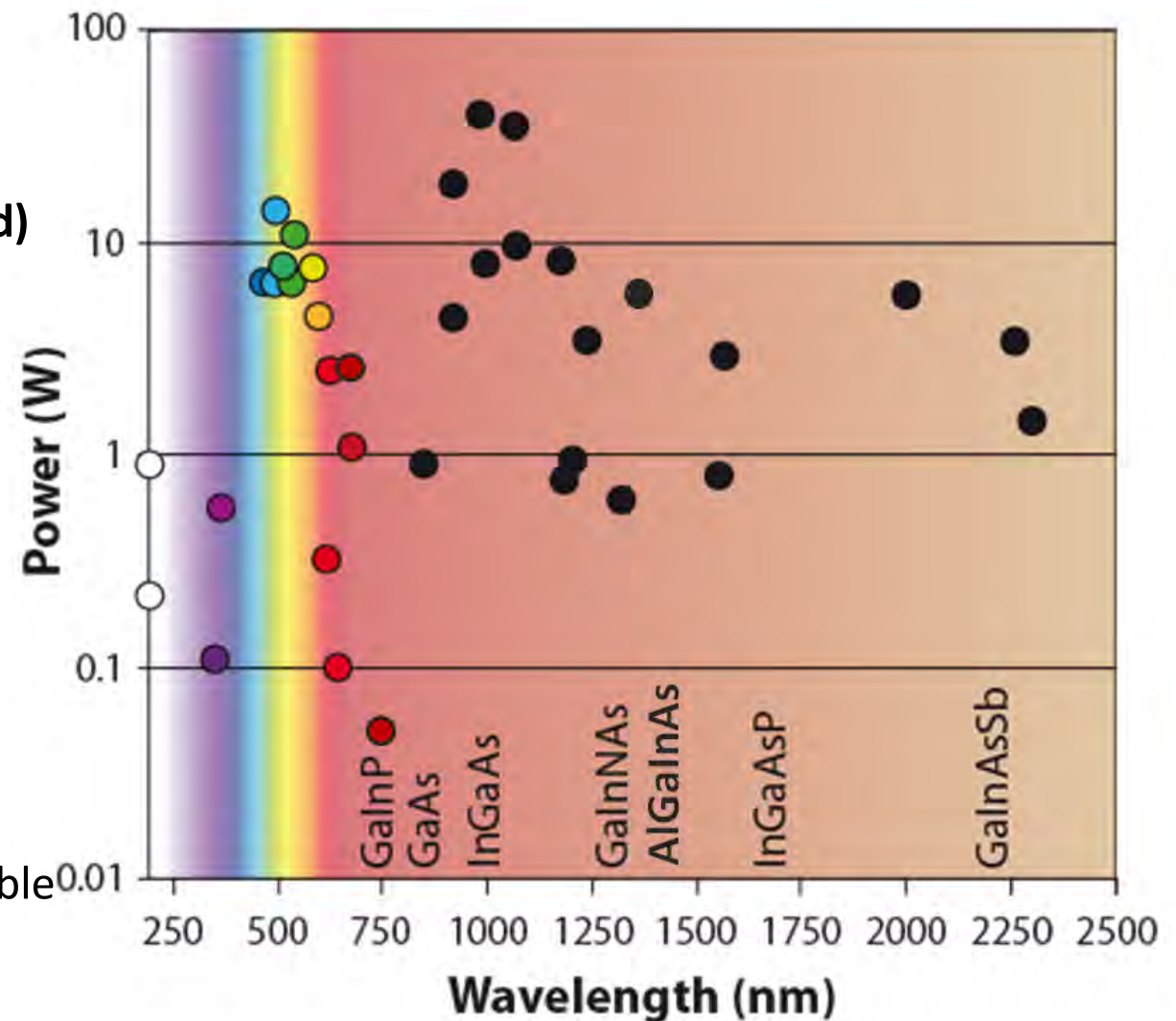
- Maybe a bad idea coming from semiconductor diode lasers?
- But for sure a good idea coming from diode-pumped solid-state lasers:
 - more flexibility in operation wavelengths
 - broad tunability
 - efficient mode conversion from low-beam-quality high-power diode lasers
 - modelocking possible with SESAMs
 - waferscale integration - cheaper ultrafast lasers in the GHz pulse repetition rate regime

ETH Semiconductor materials: bandgap engineering



VECSELs: cw spectral coverage (Jennifer Hastie, 2013)

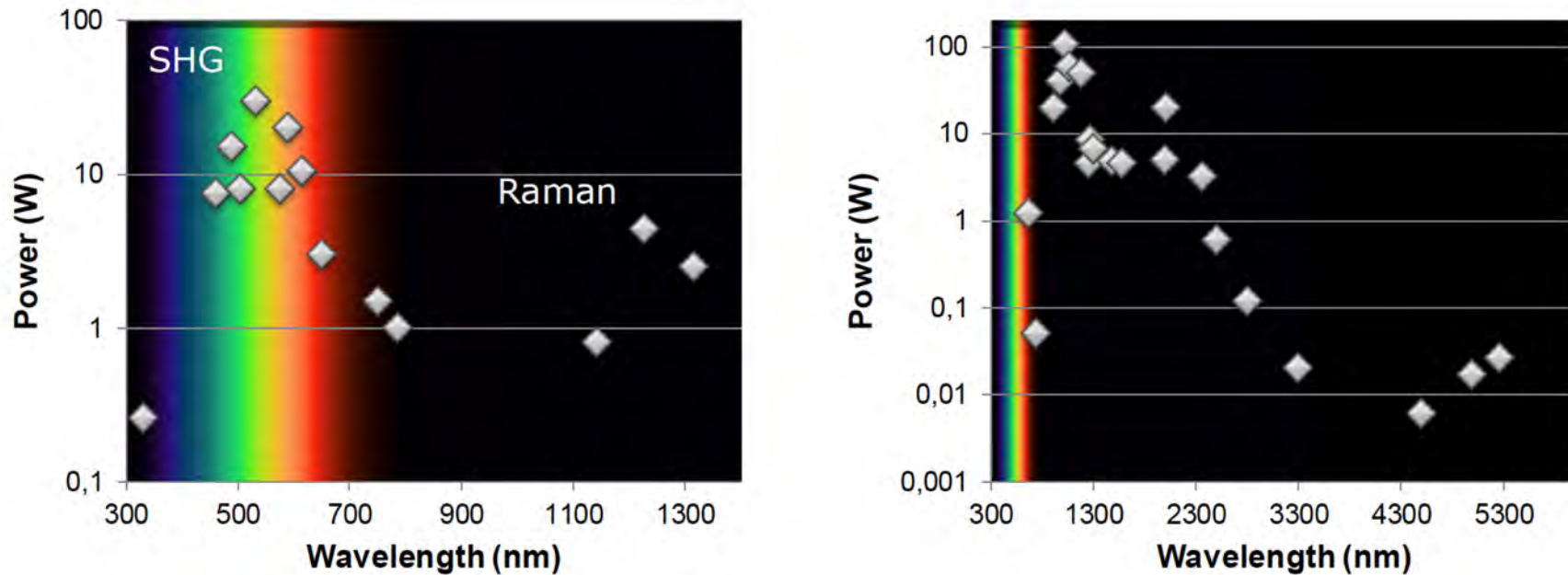
- 2-2.8 μm – GaInAsSb / AlGaAsSb
- 1.5 μm – InGaAs / InGaAsP
- **1.2-1.5 μm – AlGaInAs / InP (fused)**
- 1.2-1.3 μm – GaInNAs / GaAs
- 1-1.3 μm – InAs QDs
- **0.9-1.18 μm – InGaAs / GaAs**
- 850-870 nm – GaAs / AlGaAs
- 700-750 nm – InP QDs
- 640-690 nm – InGaP / AlGaInP
- **Frequency-doubled** VECSELs have been reported throughout the visible and into the UV



Infrared review: N. Schulz et al., *Laser & Photonics Reviews* **2**, 160 (2008)

Visible and UV review: S. Calvez et al., *Laser & Photonics Reviews* **3**, 407 (2009)

2013 updated by Jennifer Hastie, University of Strathclyde, group of Prof. Martin Dawson



*Figure 1: Output powers vs. wavelength covered by major types of VECSEL technologies: **left** - frequency converted (second harmonic generation - SHG, and Raman shifting); and **right** - fundamental emission.*

M. Guina et al., "Optically pumped VECSELs: review of technology and progress"
J. Phys. D: Appl. Phys. **50**, 383001 (2017)

SDLs = semiconductor disk lasers



OPSLs = OP-VECSELs

Optically Pumped Semiconductor Lasers

POWER. PRECISION. PERFORMANCE.
— BASED ON SEMICONDUCTOR LASERS



Superior Reliability & Performance

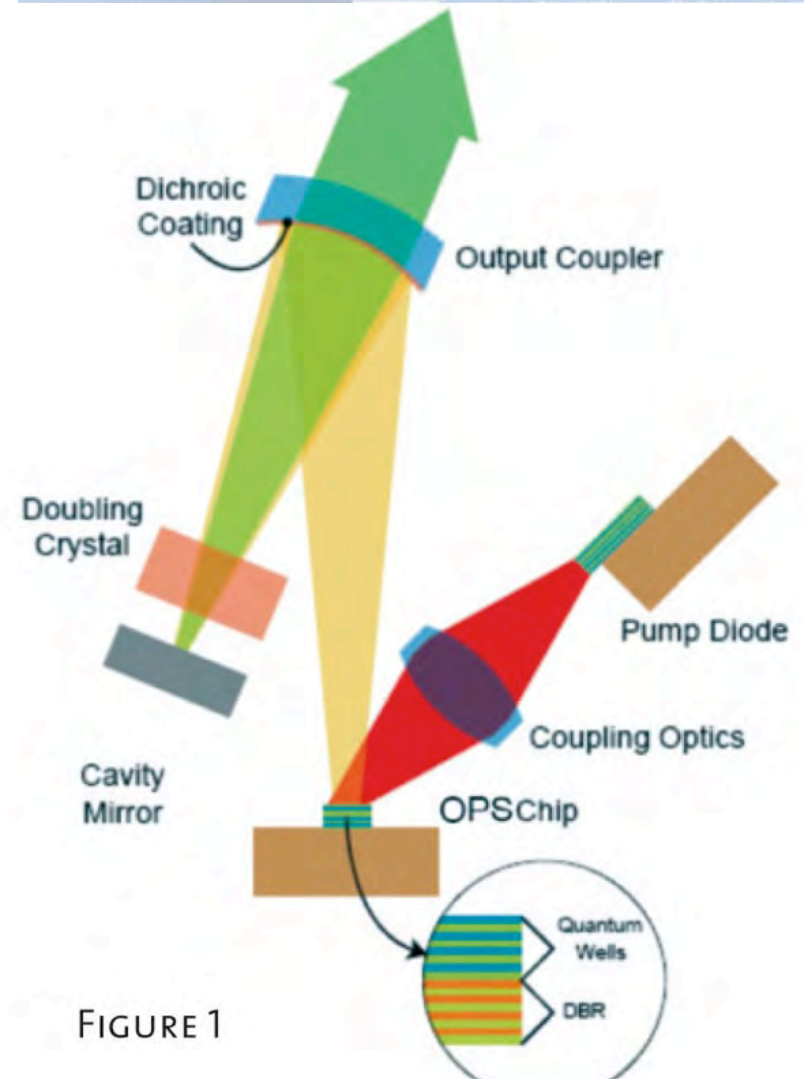


FIGURE 1





OPSLs = OP-VECSELS

Optically Pumped Semiconductor Lasers

Dichroic Coating

Output Coupler

10 cm

Pump Diode

Coupling Optics

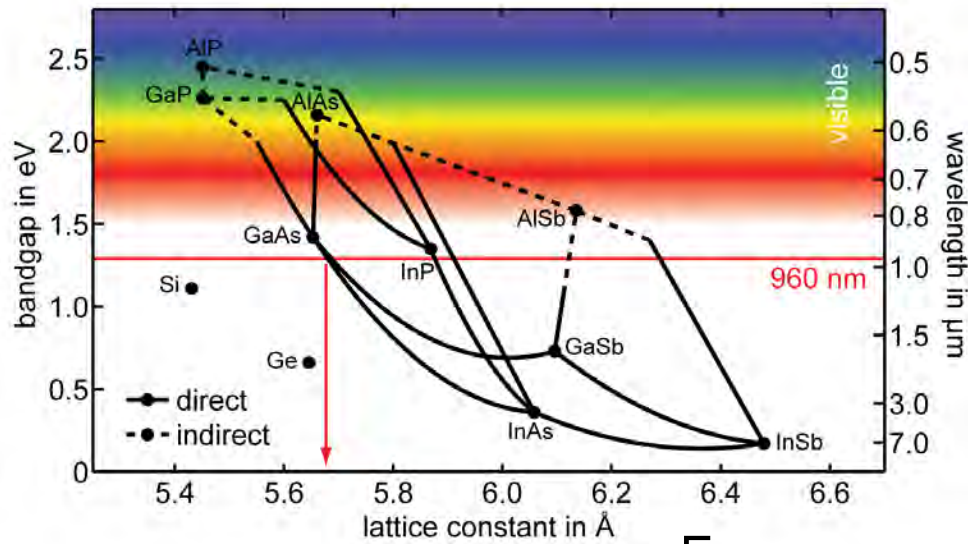
Quantum Wells

DBR

Coherent - CW - VECSEL

Superior Reliability & Performance

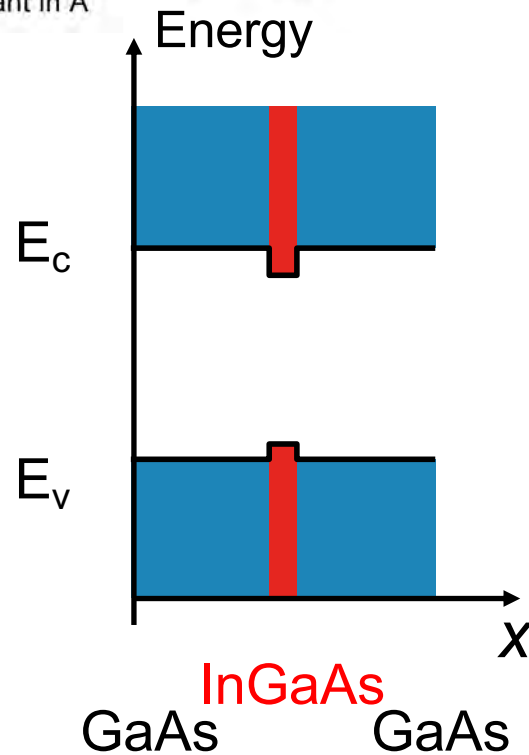




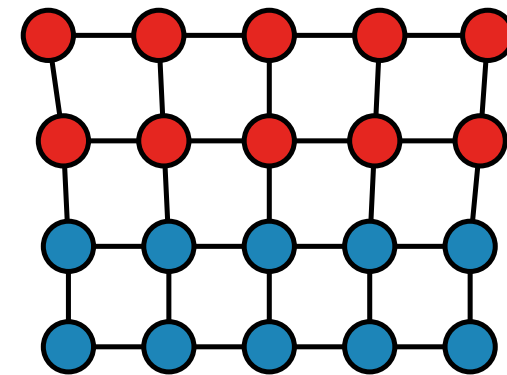
InGaAs Quantum well

Conduction band

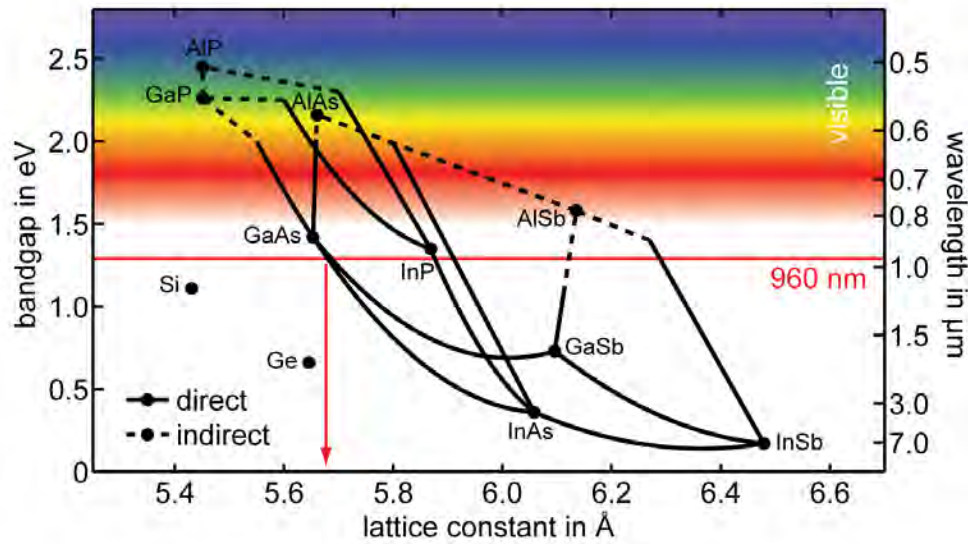
Valence band



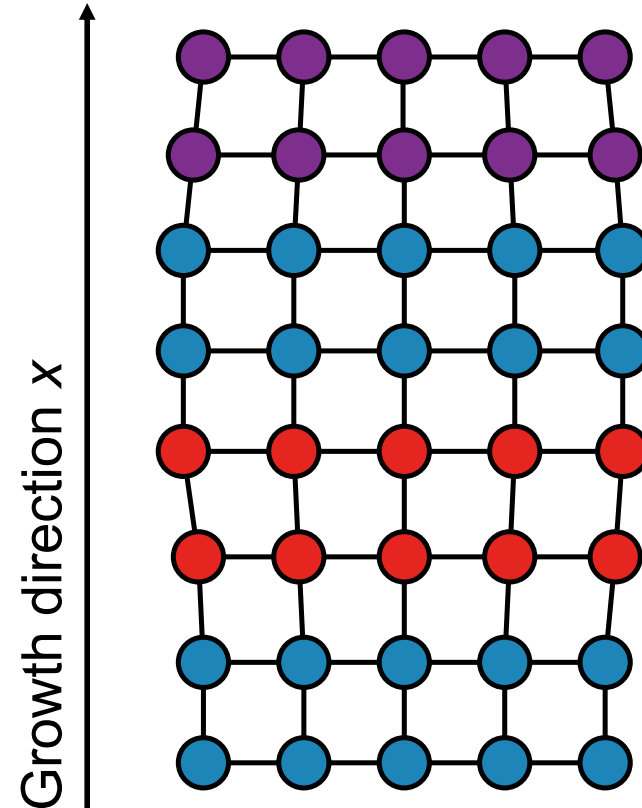
Growth direction x



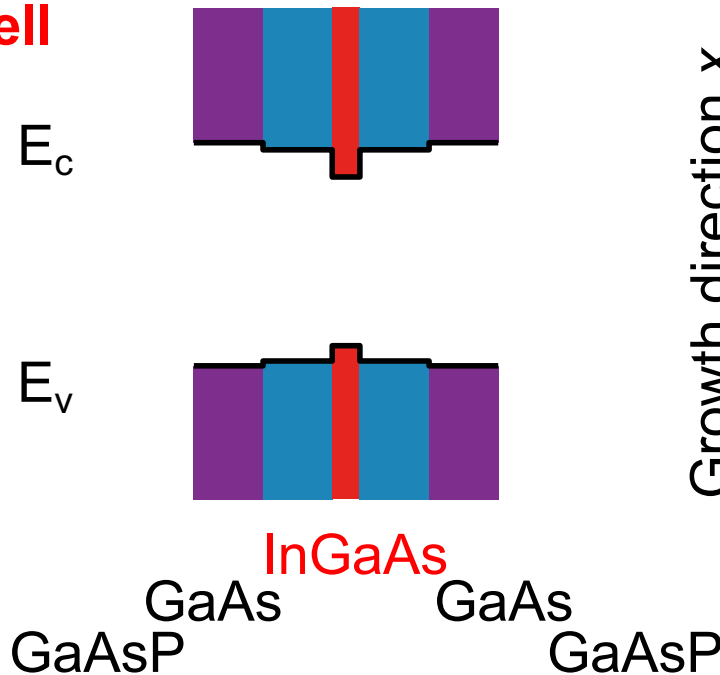
Strain

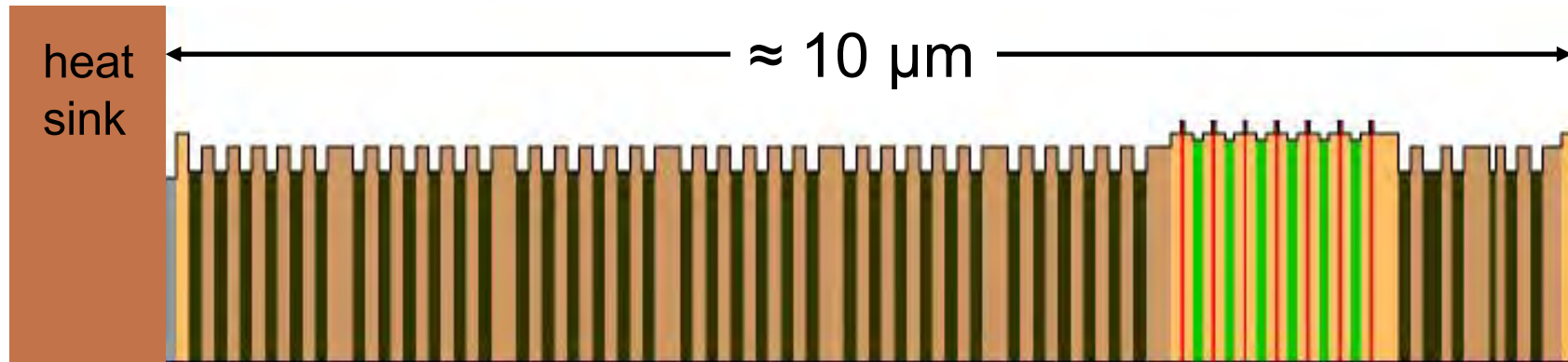


Strain-compensation

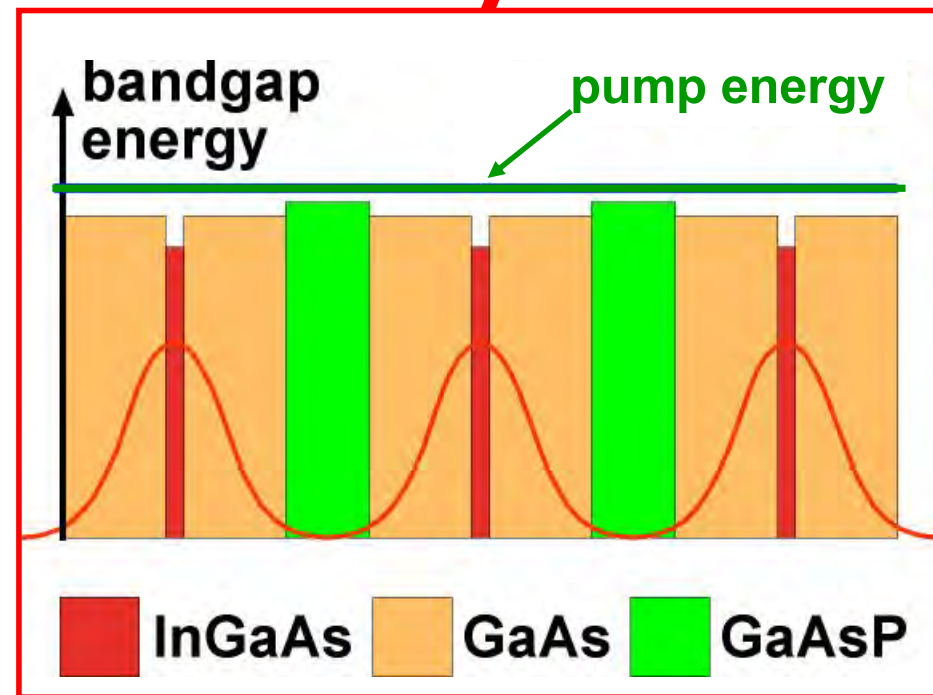


InGaAs Quantum well



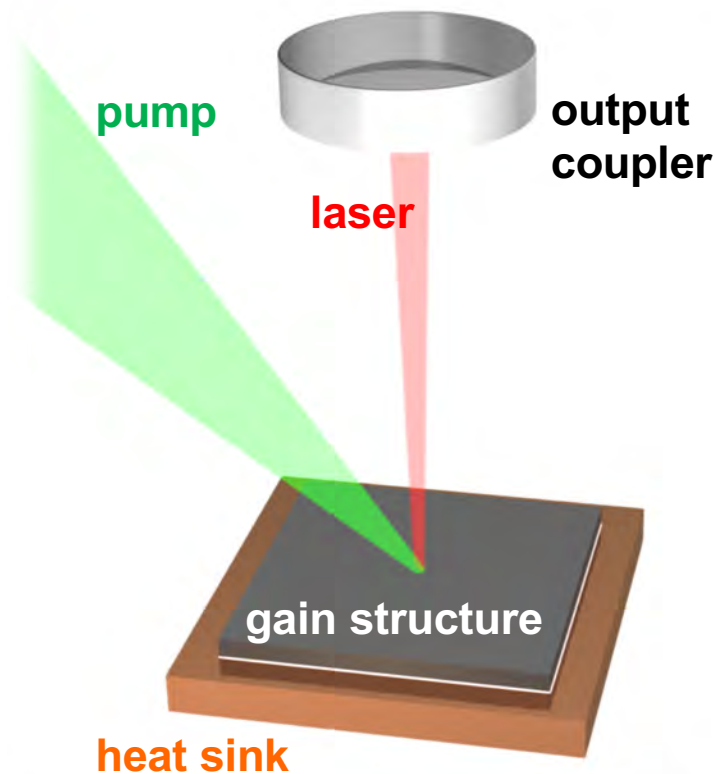


- 7 $\text{In}_{0.13}\text{Ga}_{0.87}\text{As}$ QWs (8 nm) in anti-nodes of standing-wave pattern, designed for gain at ≈ 960 nm
- GaAs spacer layers
- Strain-compensating $\text{GaAs}_{0.94}\text{P}_{0.06}$ layers
- Pump at 808 nm

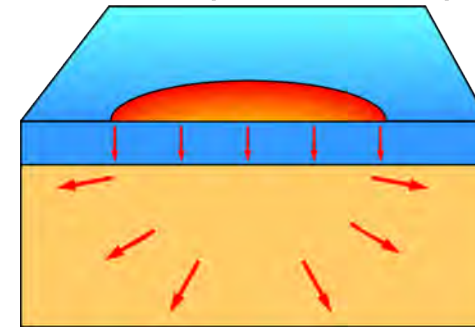


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M. Kuznetsov et al., *IEEE Photon. Technol. Lett.* **9**, 1063 (1997)



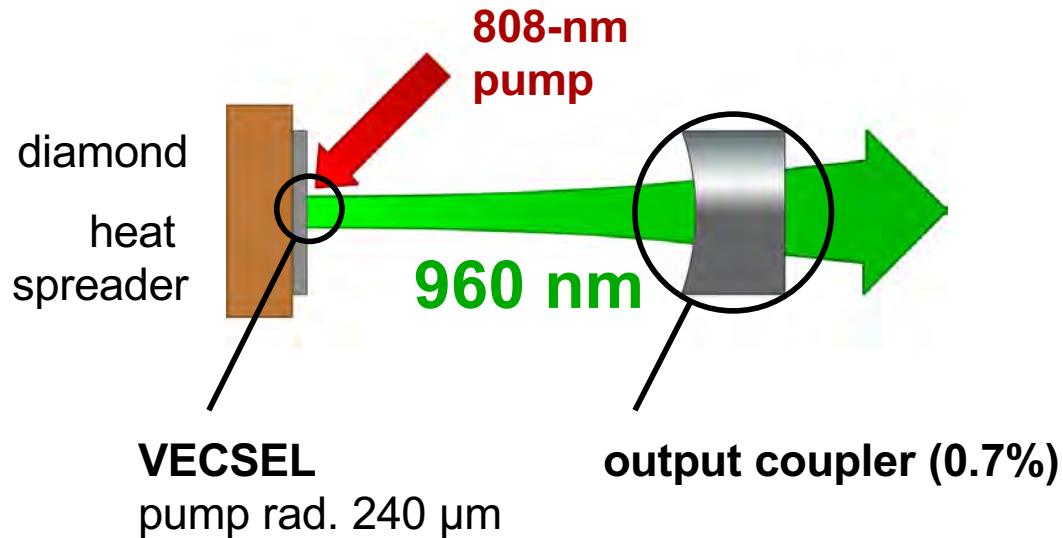
- Semiconductor gain structure with reduced thickness ($\approx 10 \mu\text{m}$)



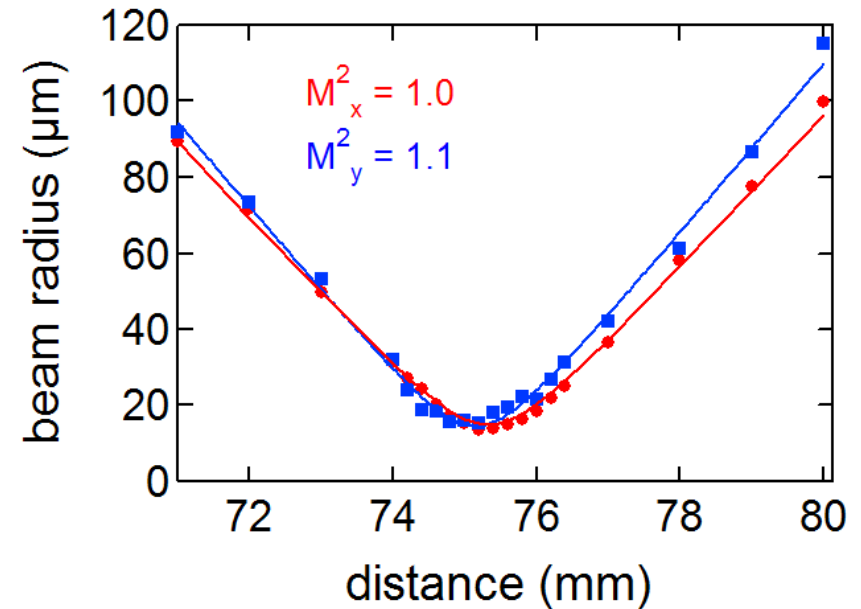
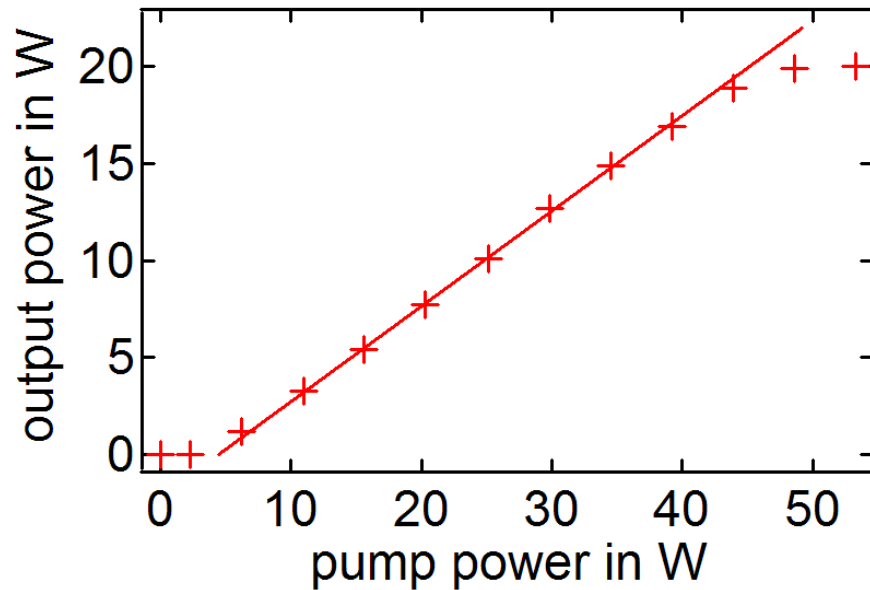
IEEE JQE 38, 1268 (2002)

- Pump: high power diode bar
- External cavity for diffraction-limited output

SDLs = semiconductor disk lasers

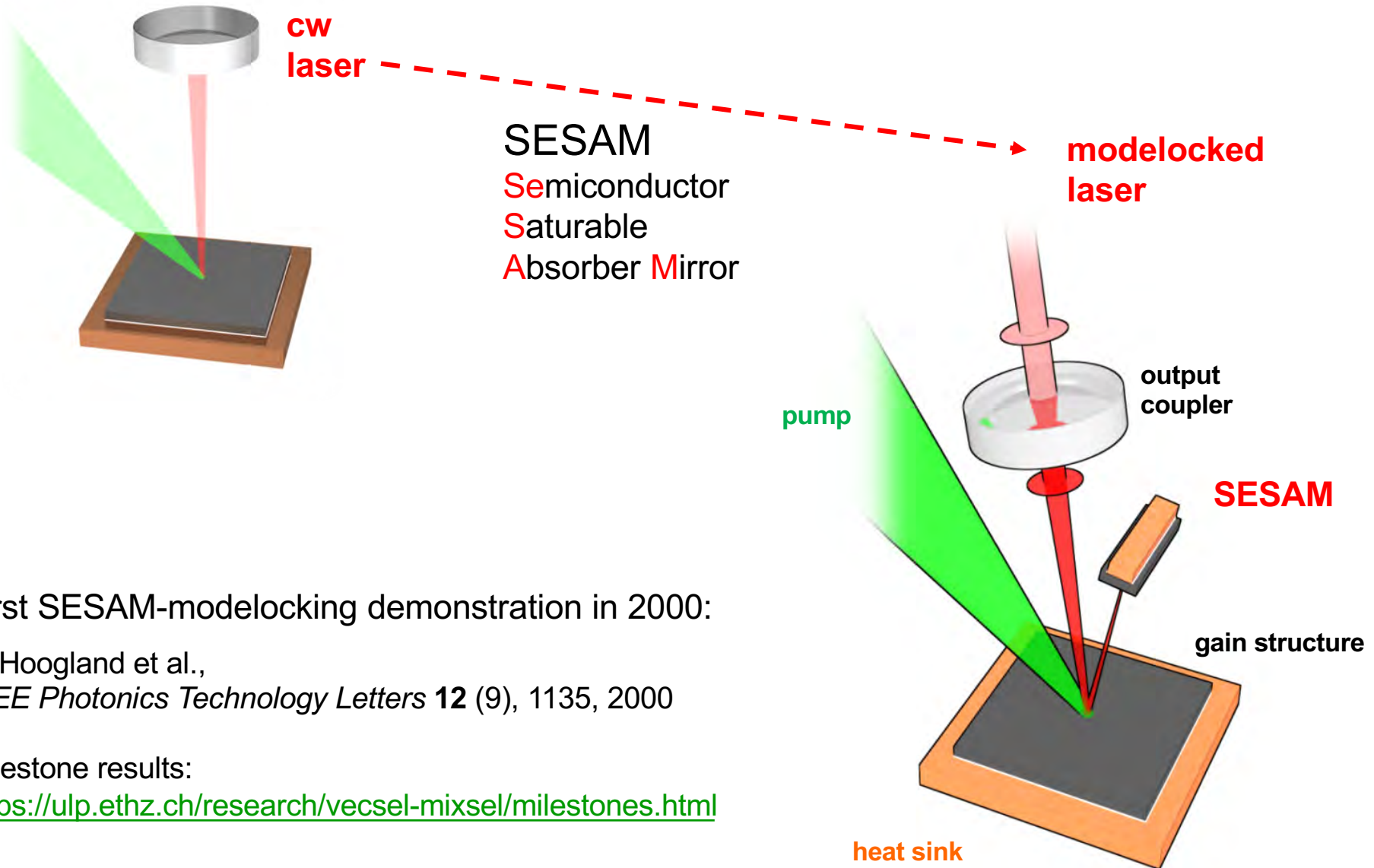


- Maximum power $P = 20.2 \text{ W}$
- opt.-to-opt. efficiency up to 43%
- $M^2 < 1.1$



B. Rudin, A. Rutz, M. Hoffmann, D. J. H. C. Maas, A. R. Bellancourt, E. Gini, T. Südmeyer, U. Keller
Opt. Lett. **33**, 2719 (2008)

Ultrafast VECSELs: Modelocking with SESAMs



First SESAM-modelocking demonstration in 2000:

S. Hoogland et al.,
IEEE Photonics Technology Letters **12** (9), 1135, 2000

Milestone results:

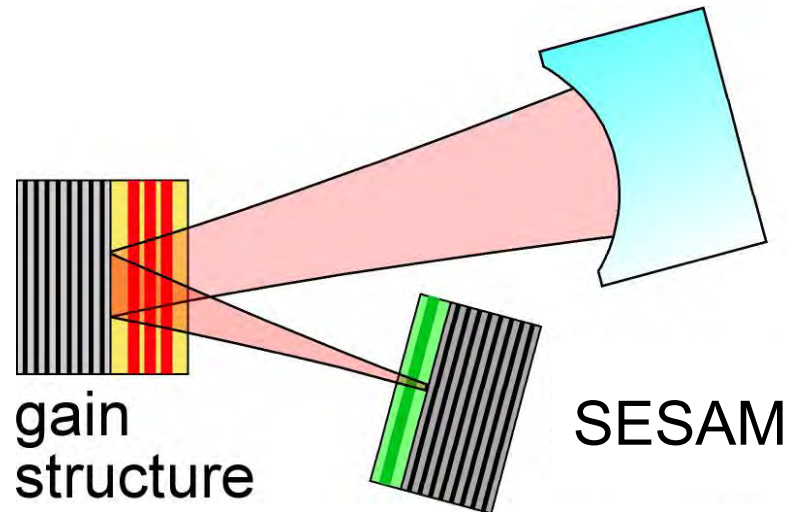
<https://ulp.ethz.ch/research/vecsel-mixsel/milestones.html>

Review article for VECSELs: U. Keller and A. C. Tropper, *Physics Reports* **429**, Nr. 2, pp. 67-120, 2006



Motivation for semiconductor lasers: Wafer scale integration

2015 Review: B. W. Tilma *et al.*, “Recent advances in ultrafast semiconductor disk lasers”, *Light Sci Appl* **4**, e310 (2015)

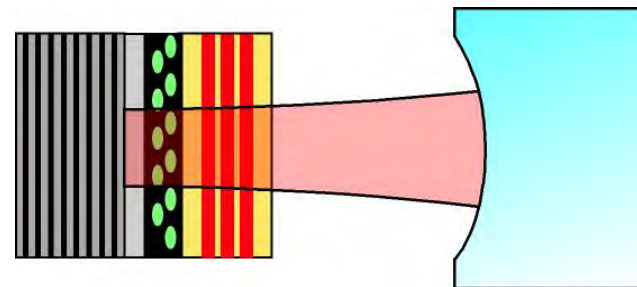
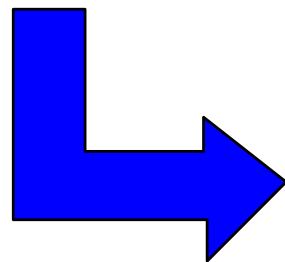


Passively modelocked VECSEL

vertical **e**xternal **c**avity **s**urface **e**mitting **l**aser

D. Lorensen *et al.*, *Appl. Phys. B* **79**, 927, 2004

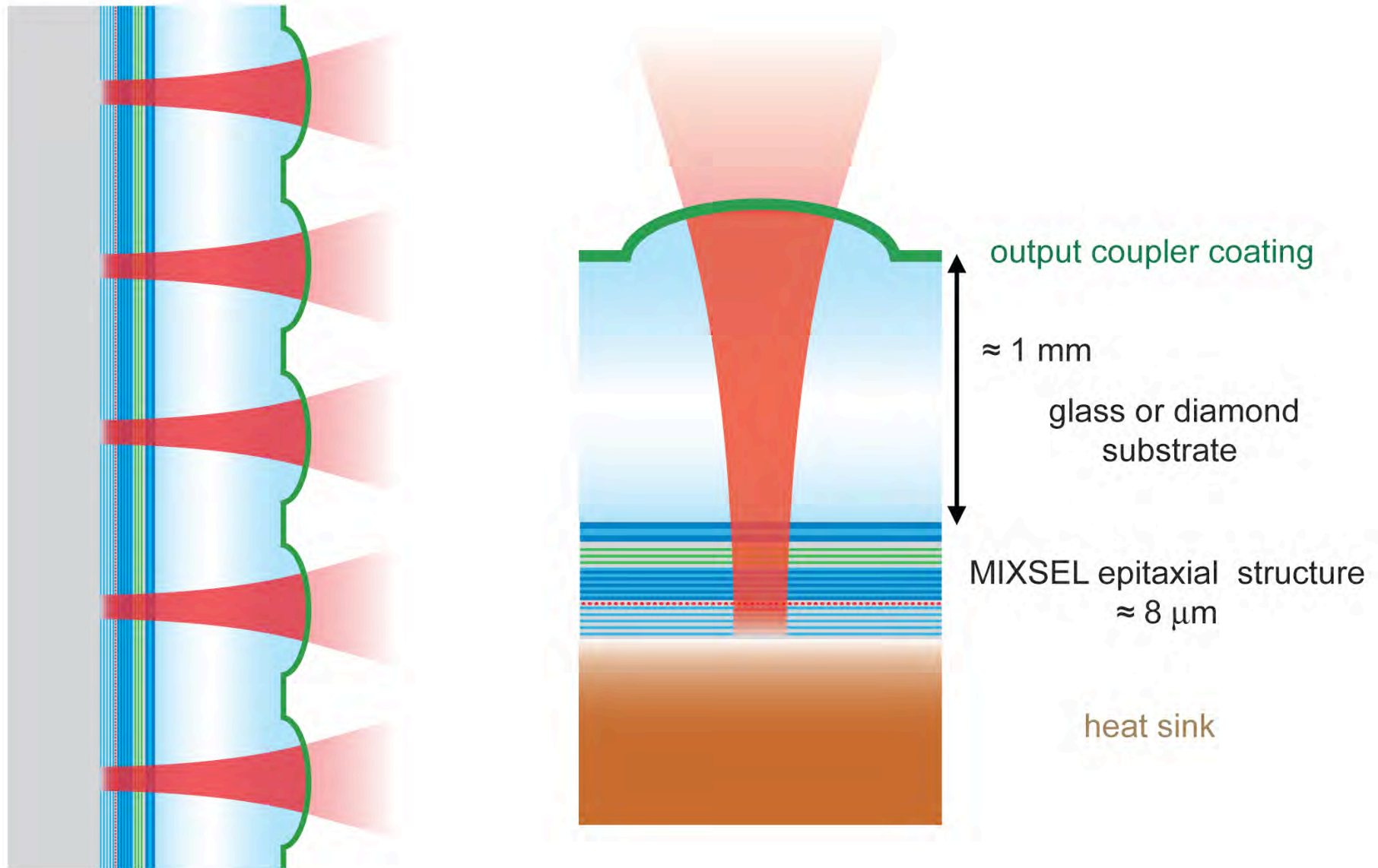
Review: *Physics Reports* **429**, 67-120, 2006



MIXSEL

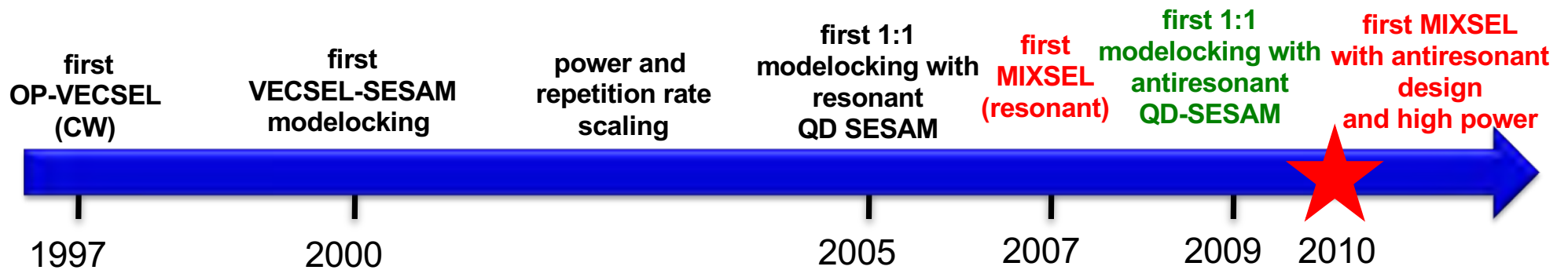
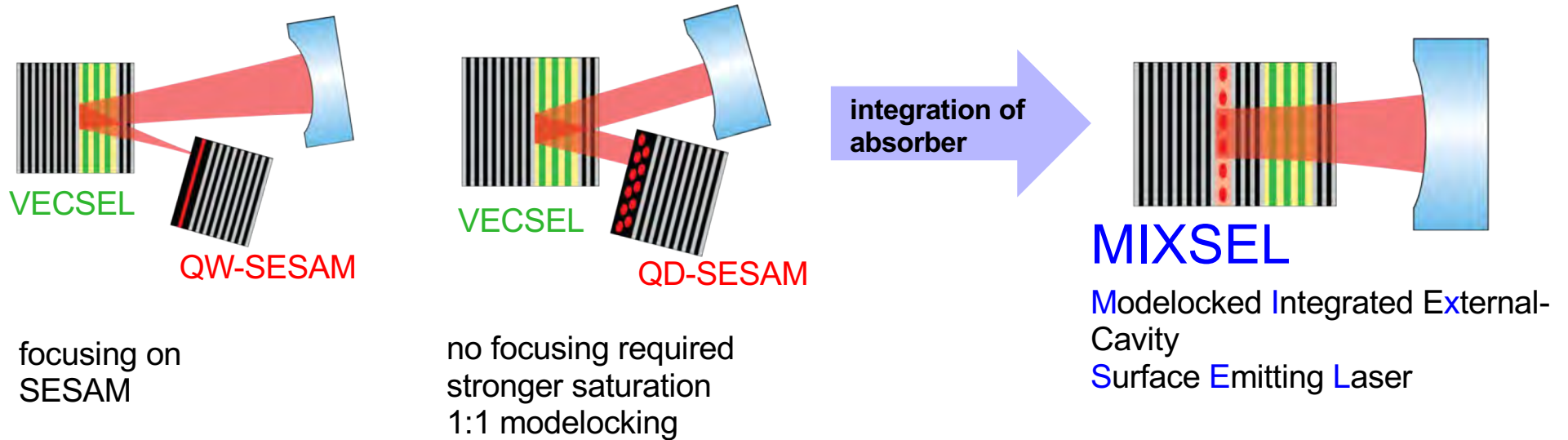
modelocked **i**ntegrated **e**xternal-cavity **s**urface **e**mitting **l**aser

D. J. H. C. Maas *et al.*, *Appl. Phys. B* **88**, 493, 2007



A. R. Bellancourt et al., "Modelocked integrated external-cavity surface emitting laser"
IET Optoelectronics, vol. 3, Iss. 2, pp. 61-72, 2009 (invited paper)

Development to the MIXSEL



VECSEL CW
>0.5 W
M. Kuznetsov et al., *IEEE PTL* 9, 1063 (1997)
not ETH Zurich

Quantum-Well SESAM
4 GHz, **2.1 W**, 4.7 ps
A. Aschwanden et al., *Opt. Lett.* 30, 272 (2005)

Quantum-Dot SESAM
50 GHz, 102 mW, 3.3 ps
D. Lorenser et al., *IEEE JQE*, 42, 838 (2006)

(Antiresonant) MIXSEL
2.5 GHz, **6.4 W**, 28 ps
March 2010
B. Rudin et al., *Opt. Express* in prep.

Ti:sapphire

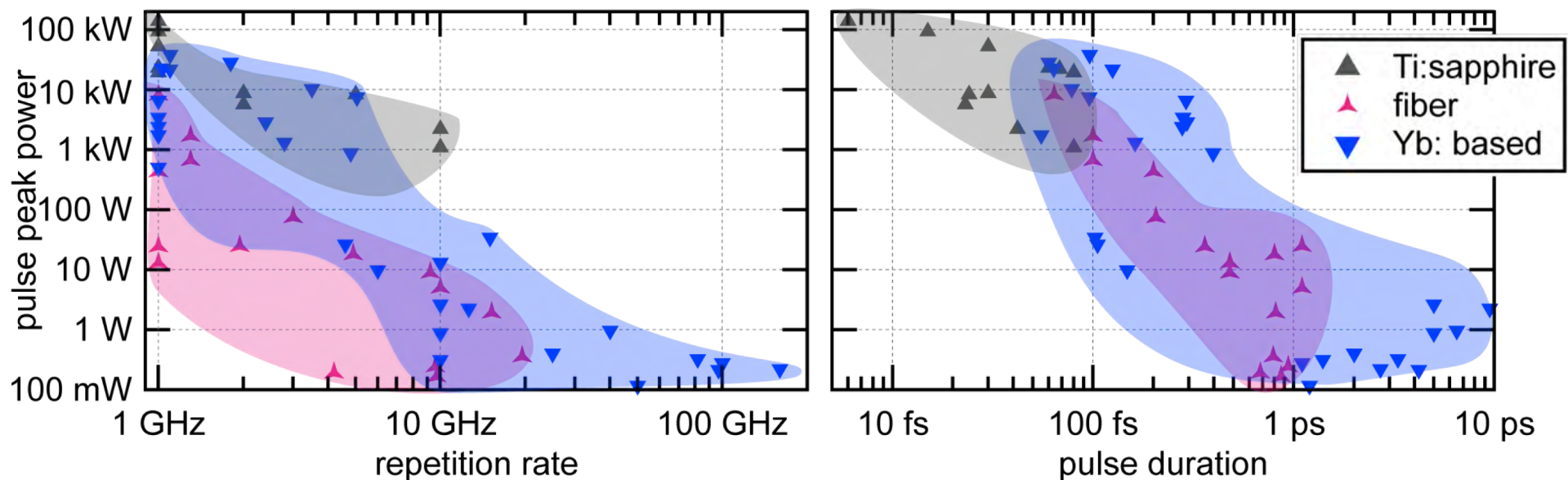
✓ performance

fiber lasers

• performance

Yb-based lasers

✓ performance



Ti:sapphire

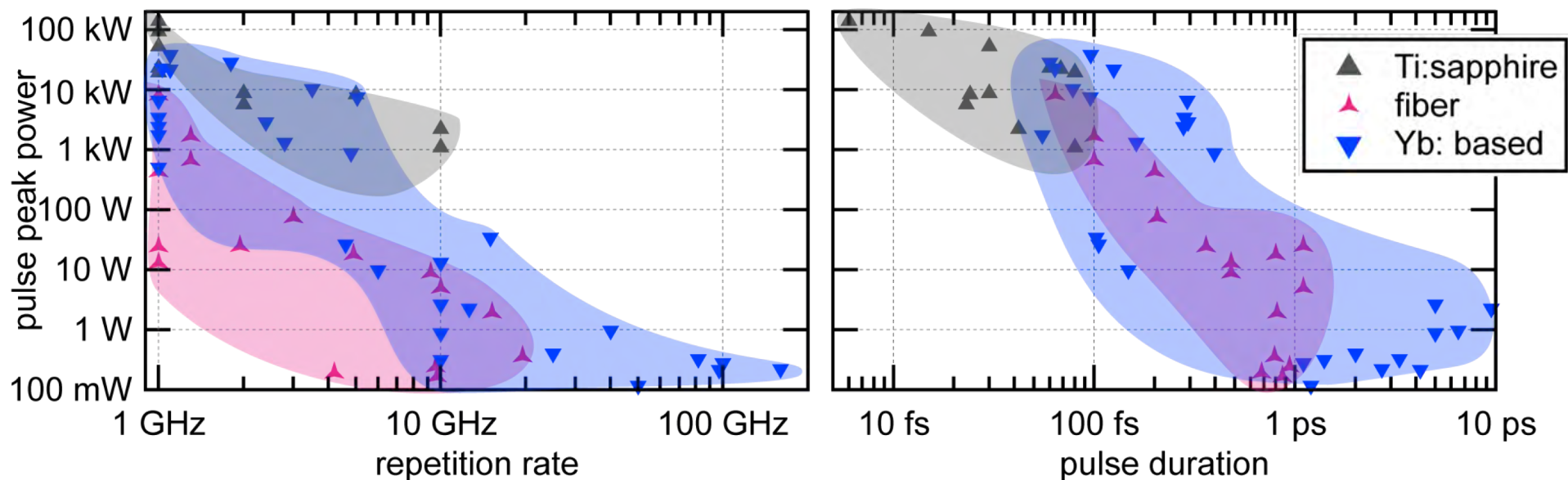
- ✓ performance
- ✗ complexity
- ✗ cost
- spectral flexibility

fiber lasers

- performance
- complexity
- cost
- spectral flexibility

Yb-based lasers

- ✓ performance
- ✓ complexity
- cost
- spectral flexibility



Ti:sapphire

- ✓ performance
- ✗ complexity
- ✗ cost
- spectral flexibility

fiber lasers

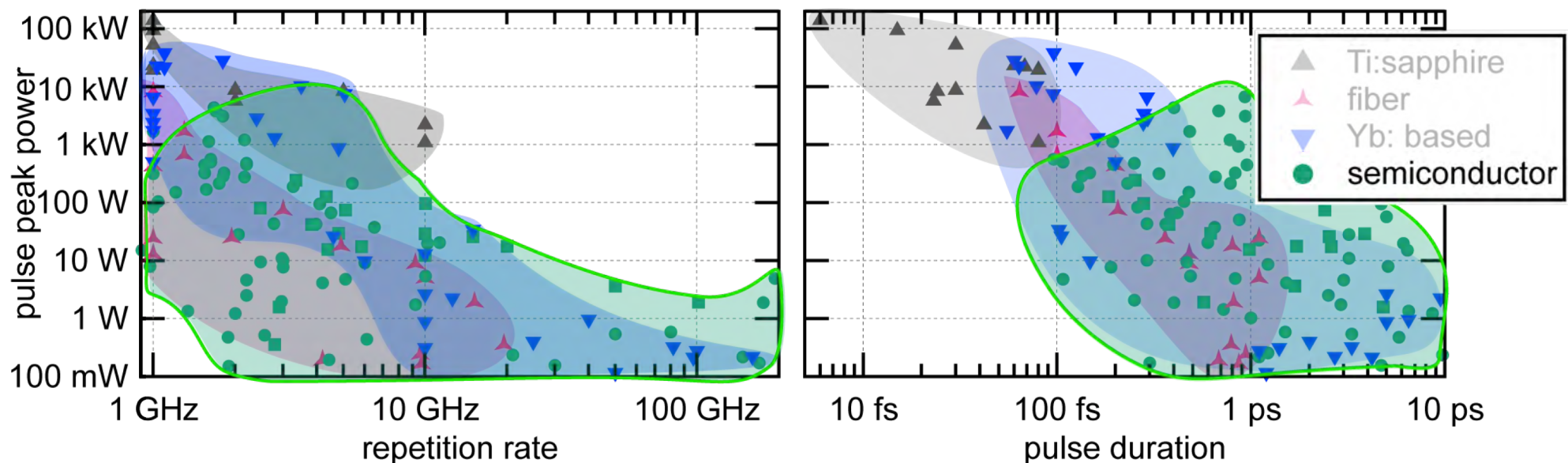
- performance
- complexity
- cost
- spectral flexibility

Yb-based lasers

- ✓ performance
- ✓ complexity
- cost
- spectral flexibility

Optically pumped ultrafast semiconductor disk lasers

- performance
- ✓ complexity
- ✓ cost
- ✓ spectral flexibility



1. Introduction to ultrafast semiconductor disk lasers



2. SESAM-modelocked VECSELs

3. MIXSEL

4. 100-fs VECSEL

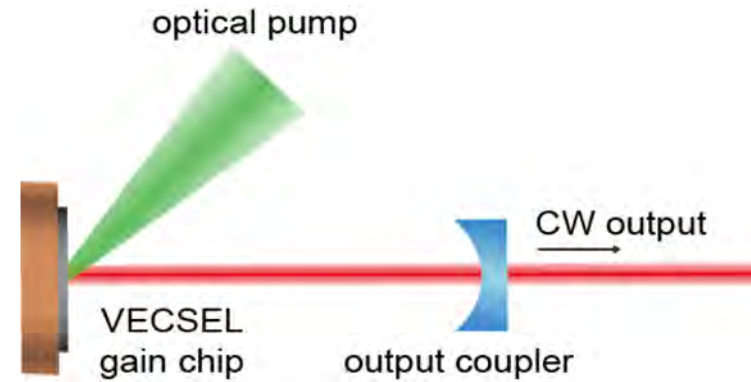
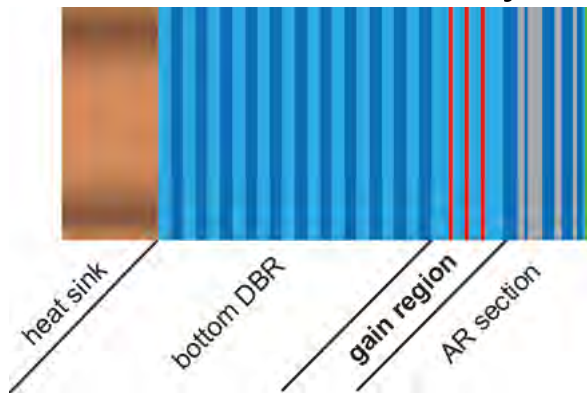
5. 139-fs MIXSEL

6. Outlook



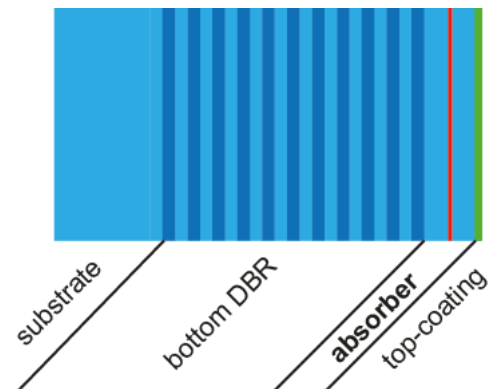
VECSEL

vertical external-cavity surface-emitting laser



SESAM

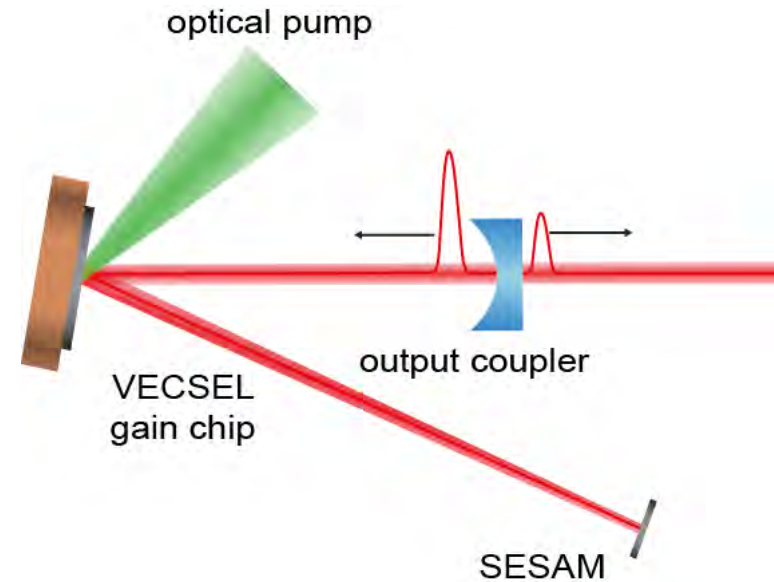
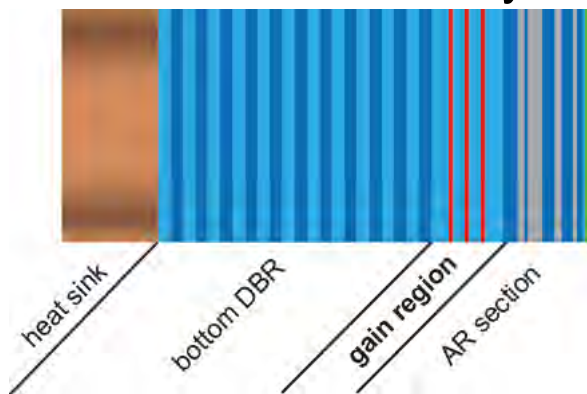
semiconductor saturable absorber mirror



3-GHz pulse repetition rate: cavity length of ≈ 5 cm

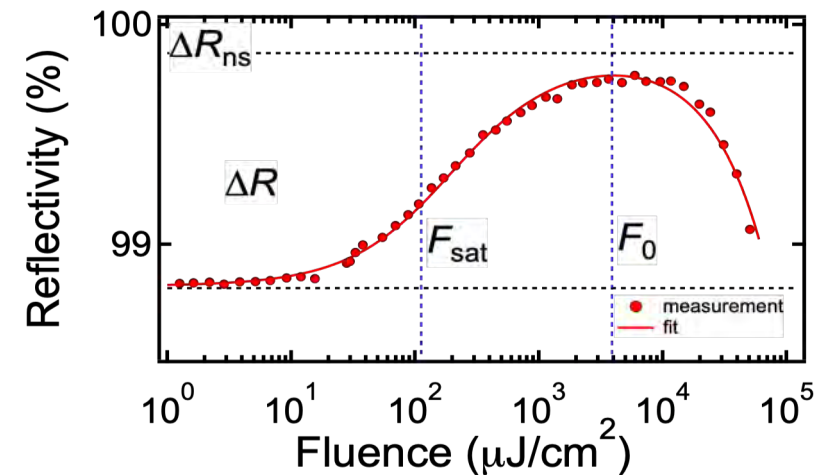
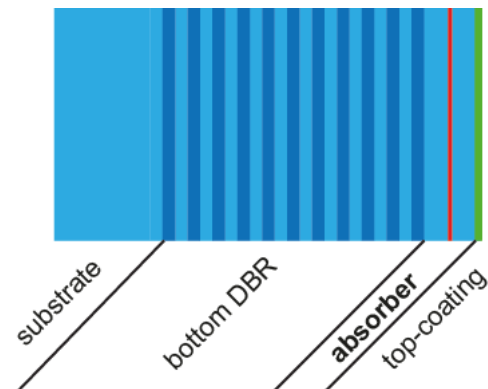
VECSEL

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SESAM

semiconductor saturable absorber mirror

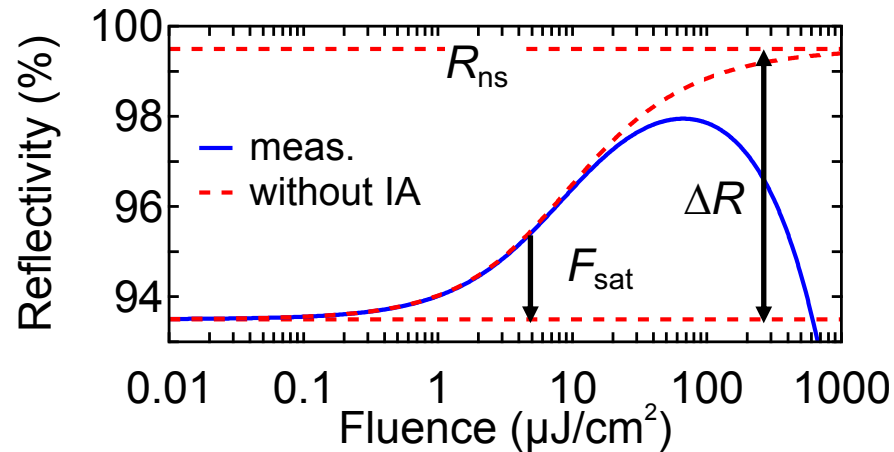


SESAM Semiconductor saturable absorber mirror

U. Keller et al., *Optics Lett.* **17**, 505 (1992)

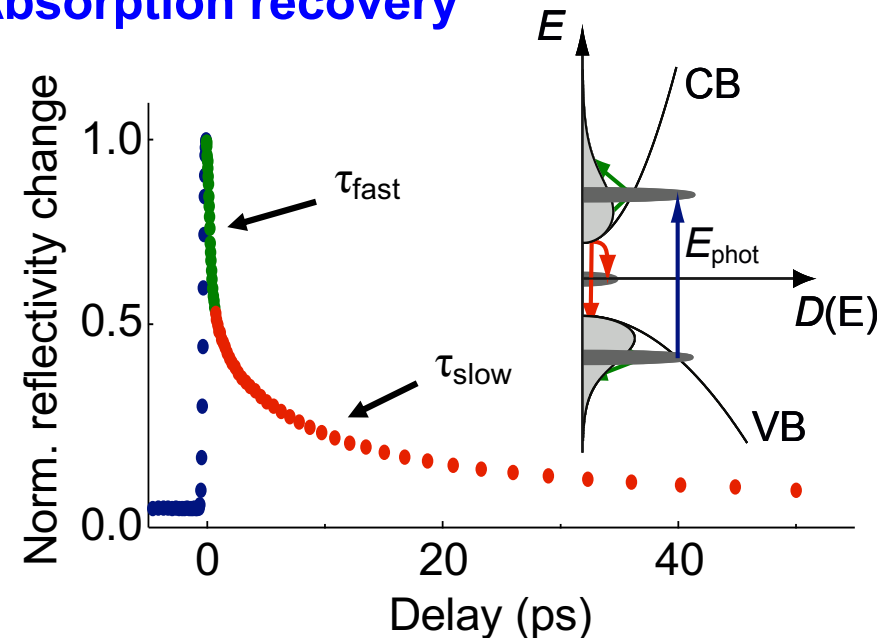
U. Keller et al., *IEEE J. Sel. Top. Quant.* **2**, 435 (1996)

Nonlinear reflectivity



- F_{sat} : **Saturation fluence**
(fluence at which reflectivity increases by 37 %)
- ΔR : **Modulation depth**
- ΔR_{ns} : Non-saturable losses
- **Induced absorption (IA)** effects lead to roll-over at high fluences

Absorption recovery



Excitation

Intraband thermalization

$$\tau_{\text{fast}} < 500 \text{ fs}$$

Interband & mid-gap defect state recombination

$$\tau_{\text{slow}} > 5 \text{ ps}$$

2005


1) SESAMs with low saturation fluence:

Appl. Phys. B 81, 27–32 (2005)

DOI: 10.1007/s00340-005-1879-1

Applied Physics B

Lasers and Optics

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S. SCHÖN¹
U. KELLER¹, 

Semiconductor saturable absorber mirror structures with low saturation fluence

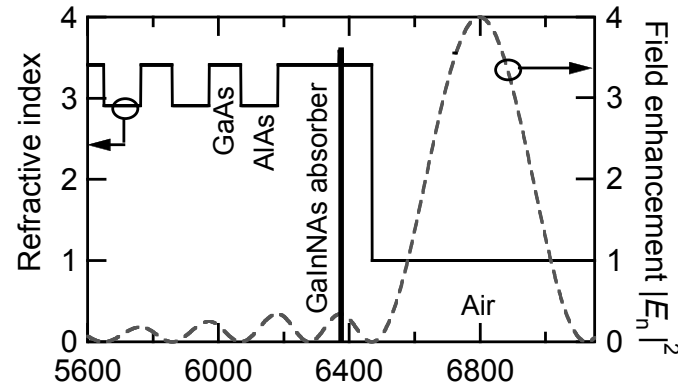
¹ETH Zurich, Physics Department, Institute of Quantum Electronics, Wolfgang-Pauli-Strasse 16, 8093 Zürich, Switzerland

²Time-Bandwidth Products, GigaTera Product Group, Technoparkstr. 1, 8005 Zürich, Switzerland

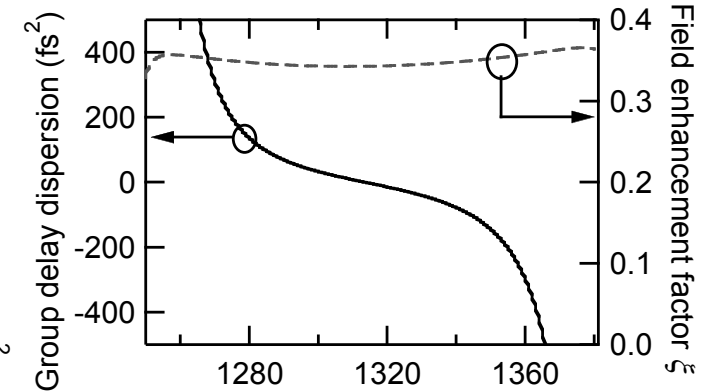


antiresonant

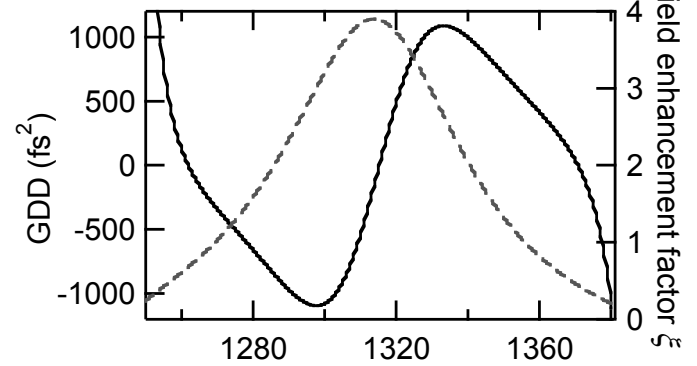
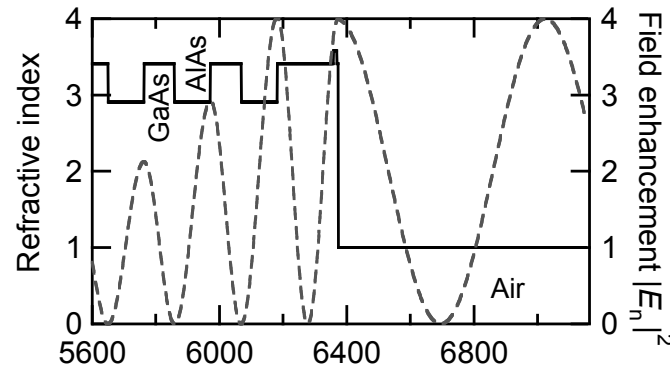
Standing wave pattern



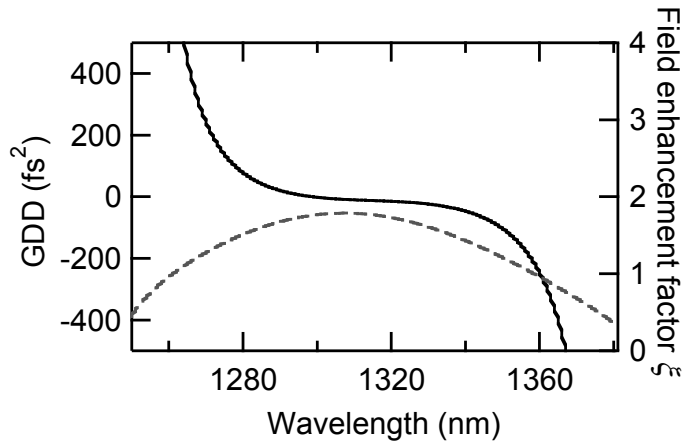
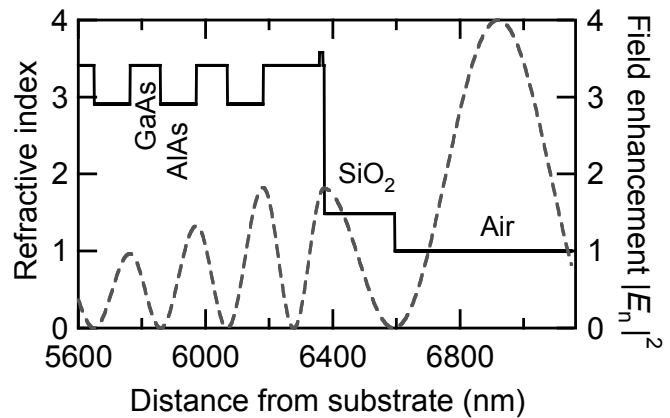
GDD and field enhanc. factor



resonant



E-SESAM




2005

1) SESAMs with low saturation fluence:

Appl. Phys. B 81, 27–32 (2005)
DOI: 10.1007/s00340-005-1879-1

Applied Physics B
Lasers and Optics

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Semiconductor saturable absorber mirror structures with low saturation fluence


¹ETH Zurich, Physics Department, Institute of Quantum Electronics, Wolfgang-Pauli-Strasse 16, 8093 Zürich, Switzerland

²Time-Bandwidth Products, GigaTera Product Group, Technoparkstr. 1, 8005 Zürich, Switzerland

2) SESAMs with inverse saturable absorption:

Appl. Phys. B 80, 151–158 (2005)
DOI: 10.1007/s00340-004-1622-3

Applied Physics B
Lasers and Optics

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O. OSTINELLI^{2,3}
U. KELLER¹

New regime of inverse saturable absorption for self-stabilizing passively mode-locked lasers

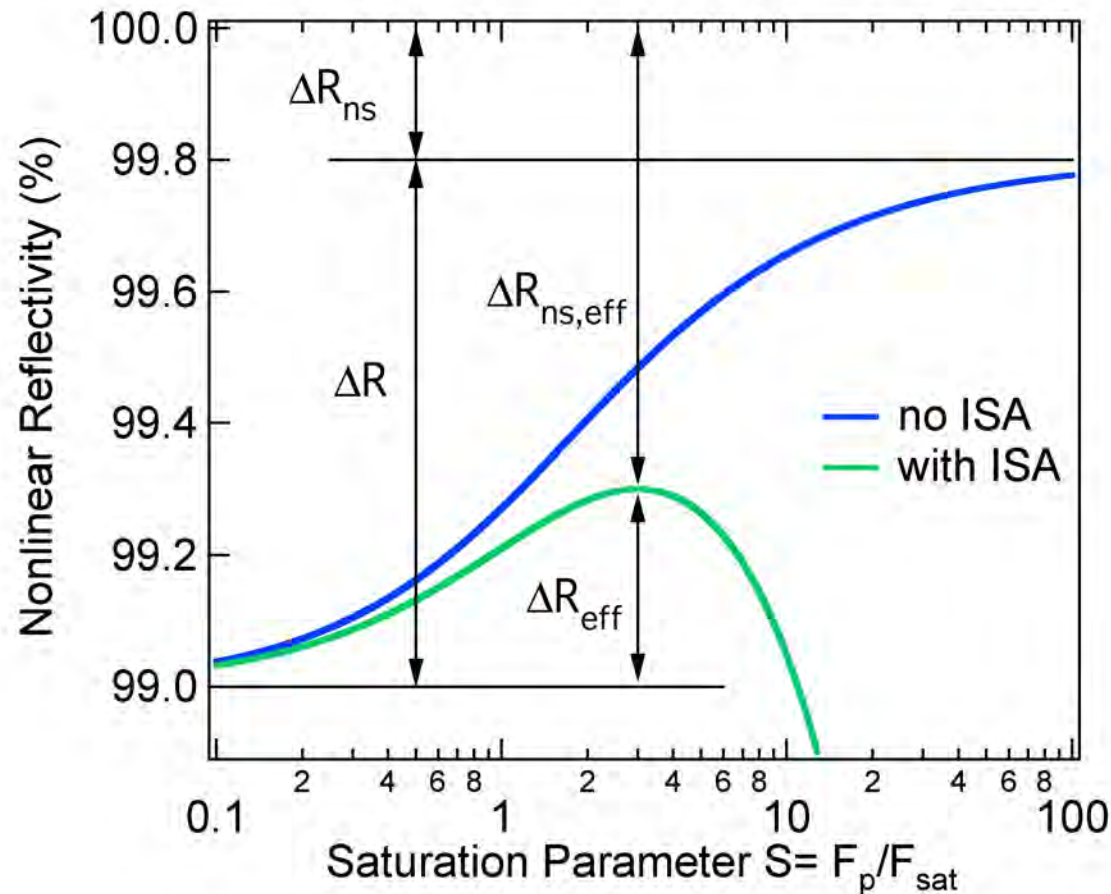
¹Institute of Quantum Electronics, Physics Department, Swiss Federal Institute of Technology (ETH), ETH Zürich Hönggerberg, Wolfgang-Pauli-Str. 16, 8093 Zürich, Switzerland

²Avalon Photonics, Badenerstrasse 569, P.O. Box, 8048 Zürich, Switzerland

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SESAM reflectivity for a pulse fluence F_p



the reflectivity decreases
at higher pulse energies

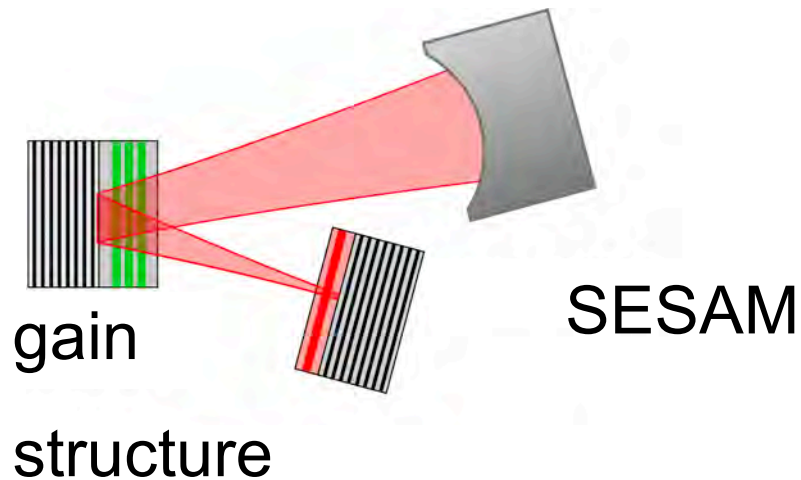


the roll-over =
inverse saturable absorption

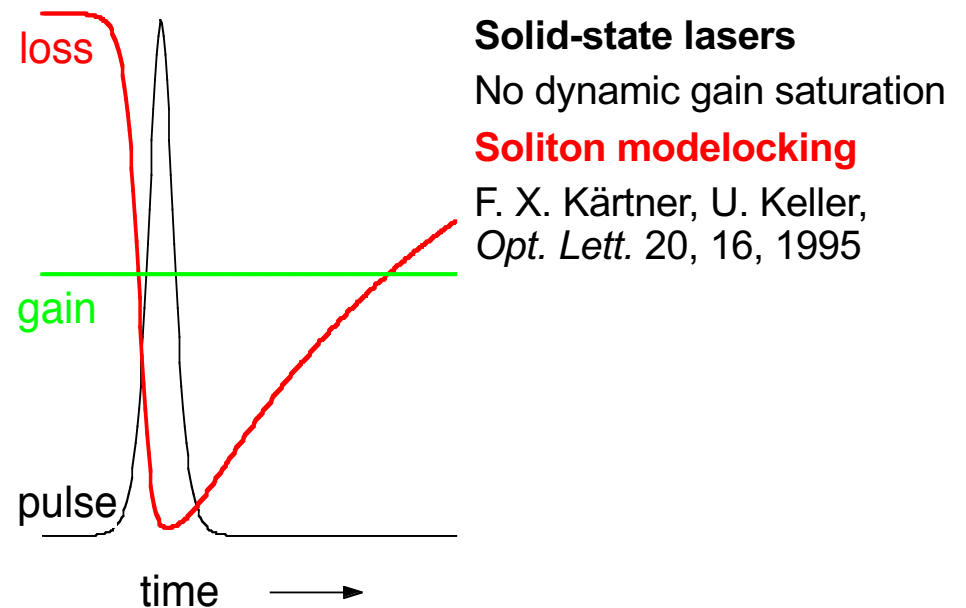
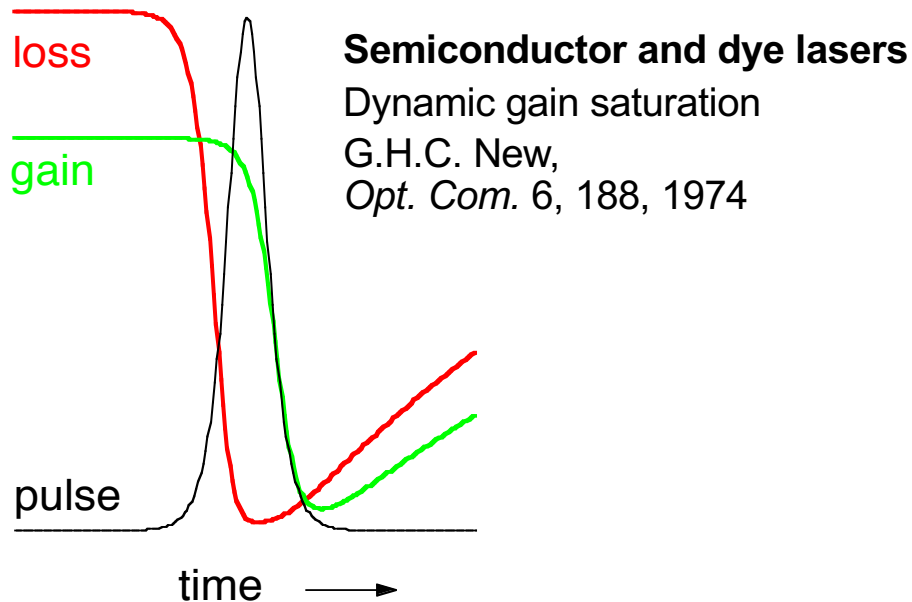
$$R_{\text{ISA}}(F_p) = R_P(F_p) - \frac{F_p}{F_2}$$

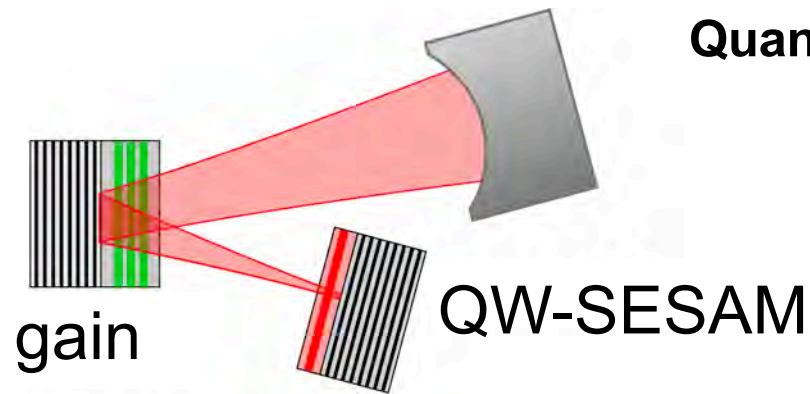
- F_2 is the inverse slope of the roll over
- The smaller F_2 , the stronger is the roll-over

ETH Dynamic gain saturation in semiconductor lasers



Important difference between semiconductor lasers and diode-pumped solid-state lasers





Quantum-well (QW) SESAM-modelocked VECSEL

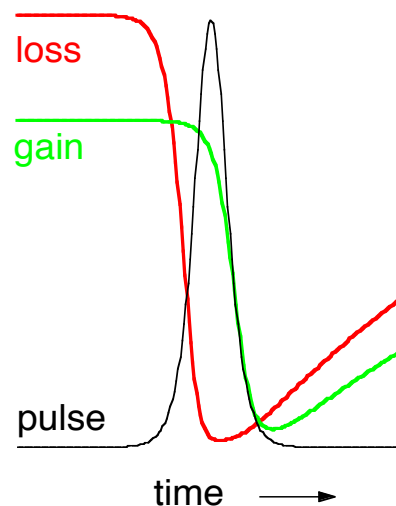
1.5 GHz	2.2 W	6 ps	[1]
4 GHz	2.1 W	4.7 ps	[1]
10 GHz	1.4 W	6.1 ps	[2]

[1] A. Aschwanden et al., *Optics Lett.* **30**, 272, 2005

[2] A. Aschwanden et al., *Appl. Phys. Lett.* **86**, 131102, 2005

structure

$$\frac{E_{sat,a}}{E_{sat,g}} = \frac{F_{sat,a}}{F_{sat,g}} \left(\frac{A_a}{A_g} \right) < 1$$



typically 1/4 – 1/20 for QW-SESAMs

example: 2.2 W, 6 ps QW-VECSEL

$$\frac{A_a}{A_g} = \frac{\pi \cdot (40\mu\text{m})^2}{\pi \cdot (175\mu\text{m})^2} = 0.052$$

- **First room temperature VECSEL:**

20 μW average power:

J.V. Sandusky et al., IEEE Photon. Technol. Lett. **8**, 313 (1996)

- **High-power cw operation:**

0.5 W in TEM₀₀ beam: M. Kuznetsov et al., *IEEE Photon. Technol. Lett.* **9**, 1063 (1997)

1.5 W: W. J. Alford et al., *J. Opt. Soc. Am. B* **19**, 663 (2002)

30 W: J. Chilla et al., *Proc. SPIE* **5332**, 143 (2004) - Coherent

20 W in TEM₀₀ beam: B. Rudin et al., *Optics Lett.* **33**, 2719, 2008

- **Passive mode locking with SESAM:**

20 mW: S. Hoogland et al., *IEEE Photon. Technol. Lett.* **12**, 1135 (2000)

200 mW: R. Häring et al., *Electron. Lett.* **37**, 766 (2001)

950 mW: R. Häring et al., *IEEE JQE* **38**, 1268 (2002)

2.1 W, 4.7 ps, 4 GHz, 957 nm

2.2 W, 6 ps, 1.5 GHz, 957 nm

A. Aschwanden et al., *Opt. Lett.* **30**, 272 (2005)

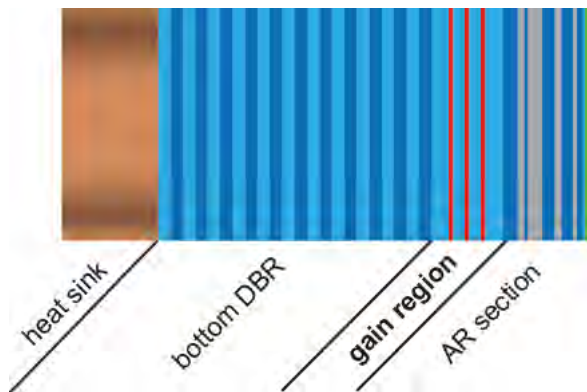
Modelocked VECSEL review: *Physics Reports* **429**, 67, 2006



1. Introduction to ultrafast semiconductor disk lasers
2. SESAM-modelocked VECSELs
3. MIXSEL
4. 100-fs VECSEL
5. 139-fs MIXSEL
6. Outlook

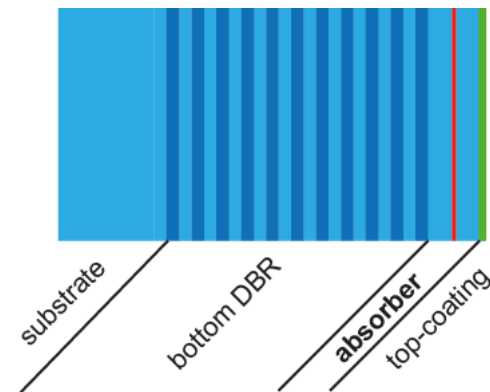
3-GHz pulse repetition rate: cavity length of ≈ 5 cm

VECSEL



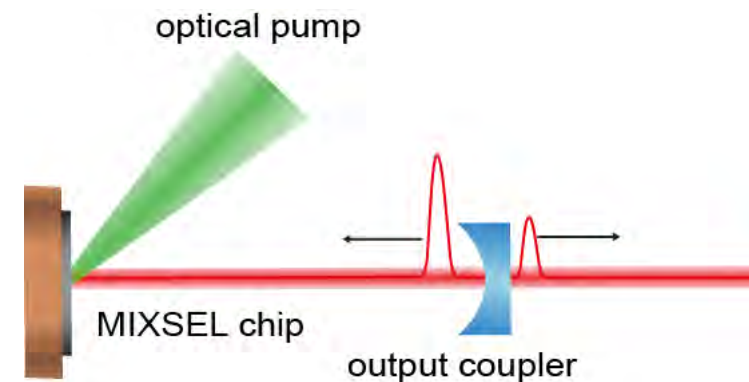
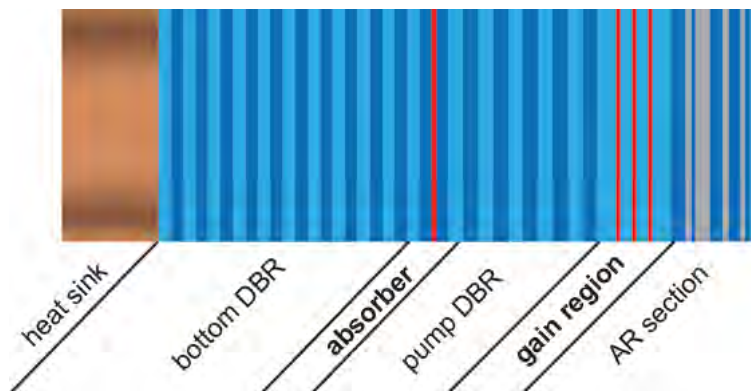
&

SESAM

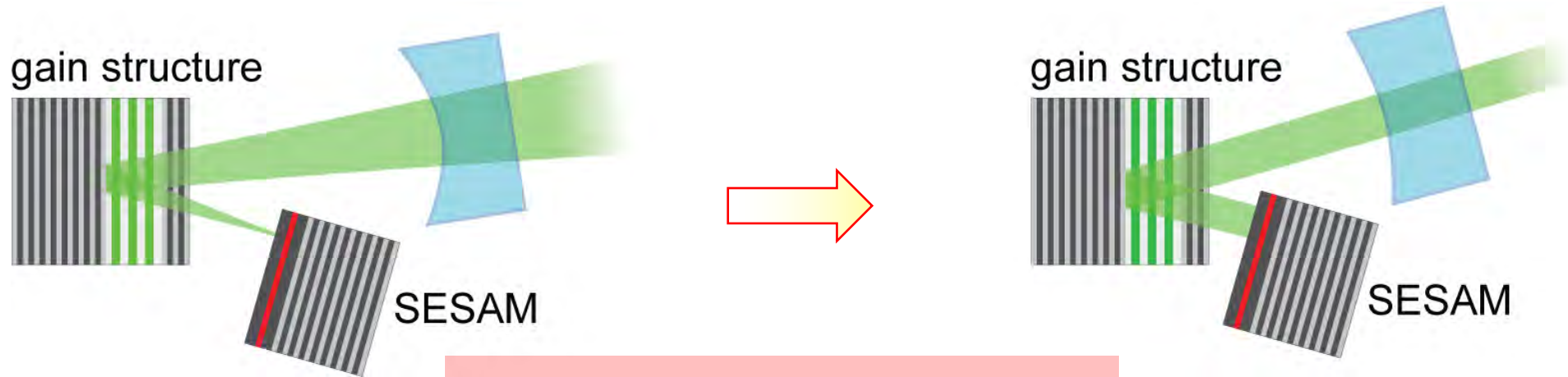


MIXSEL

modelocked integrated external-cavity surface-emitting laser



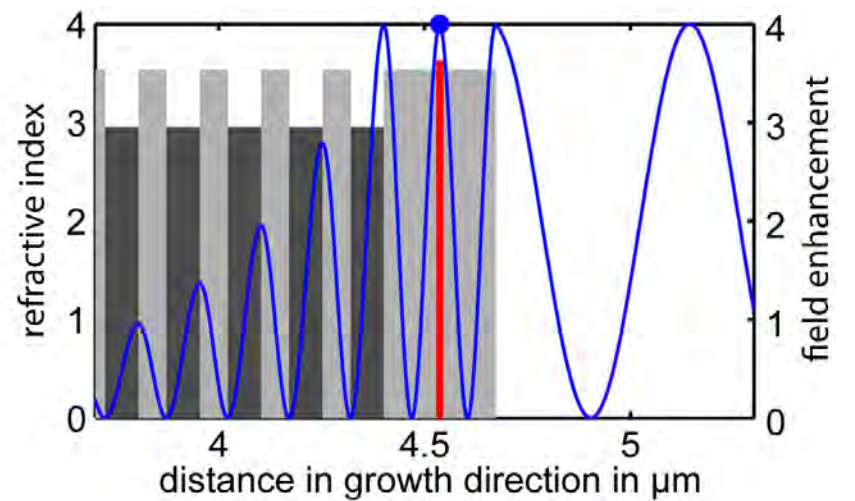
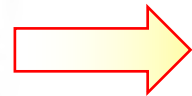
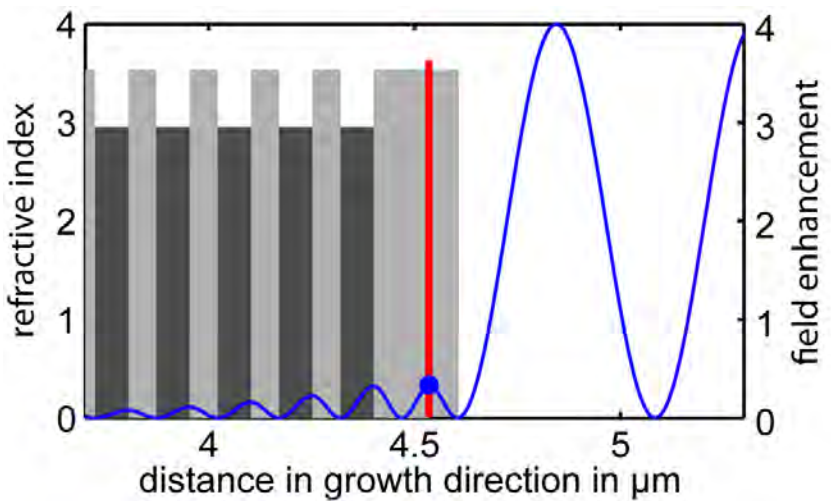
D. J. H. C. Maas et al., *Appl. Phys. B* **88**, 493, 2007



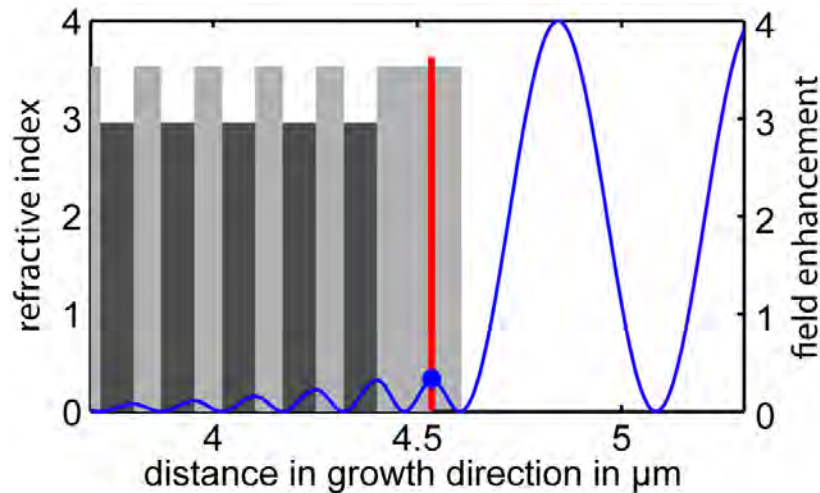
Challenge 1
 Reduction of saturation fluence
 → Increase field in absorber

$$\frac{E_{sat,a}}{E_{sat,g}} = \frac{F_{sat,a} A_a}{F_{sat,g} A_g} < 0.1$$

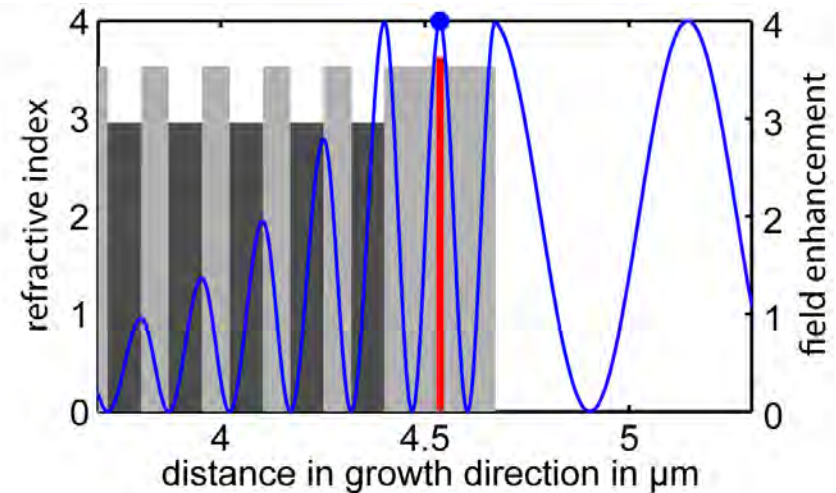
$$\frac{E_{sat,a}}{E_{sat,g}} = \frac{F_{sat,a} A_a}{F_{sat,g} A_g} < 0.1$$



antiresonant SESAM



resonant SESAM



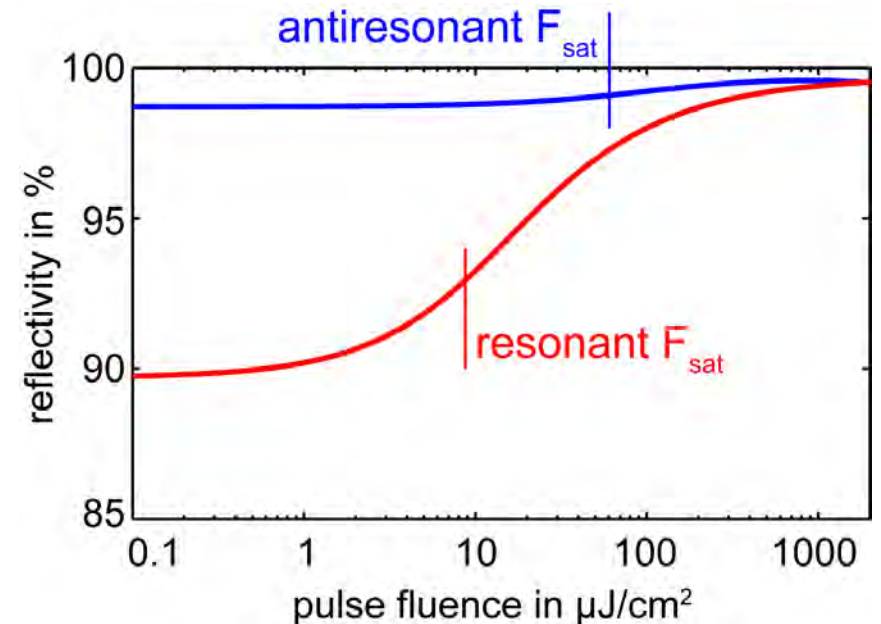
Challenge 2

Problem: increase of modulation depth

$$F_{\text{sat}} \cdot \Delta R = \text{const.}$$

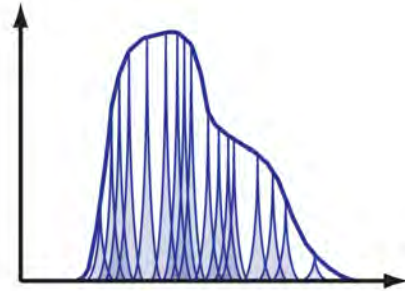
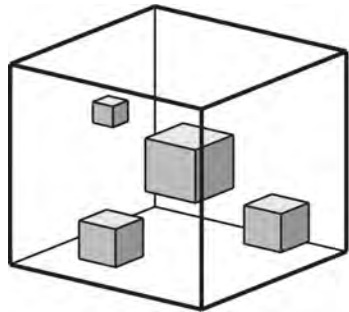
No possibility for uncoupled F_{sat} and ΔR
for QW SESAMs

What can we do?



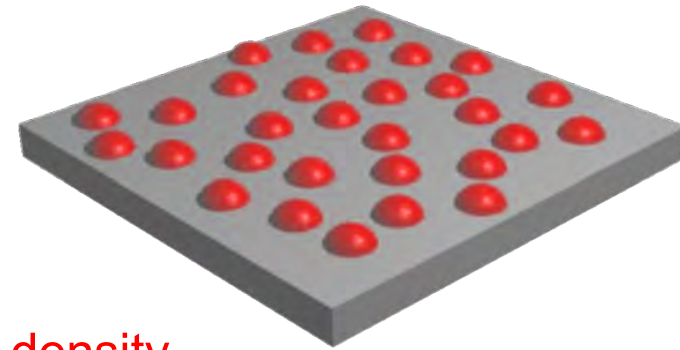
Towards Absorber Integration: Quantum Dots (QDs)

QDs absorbers offer more growth parameters than QWs absorbers



QD size and size distribution

⇒ determine absorption spectrum



QD density

⇒ determines modulation depth

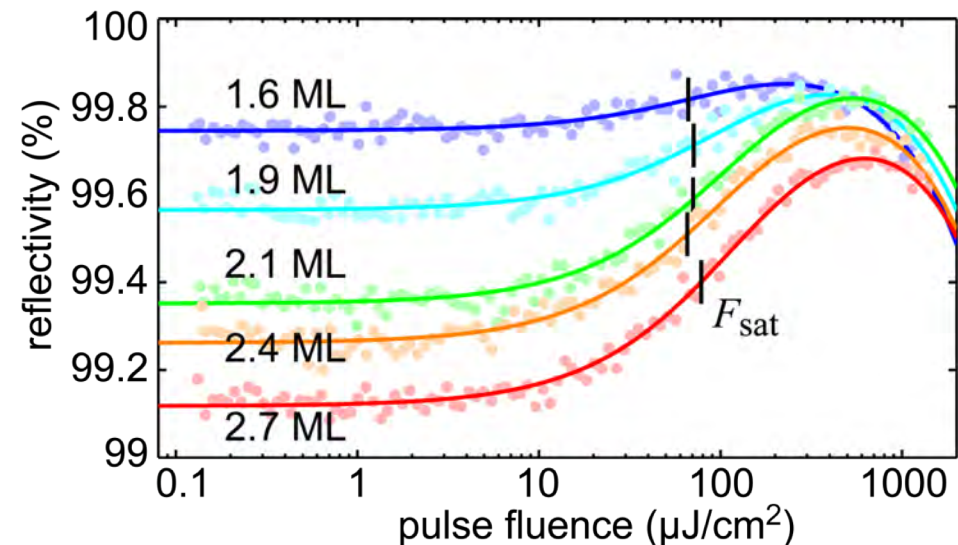
QD growth

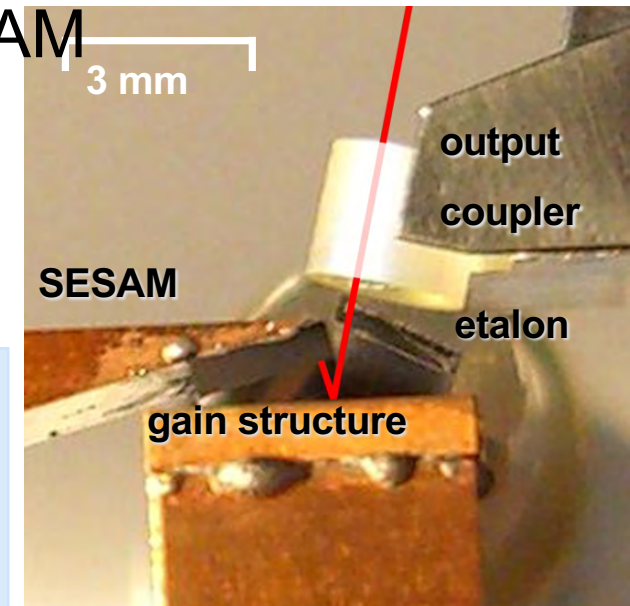
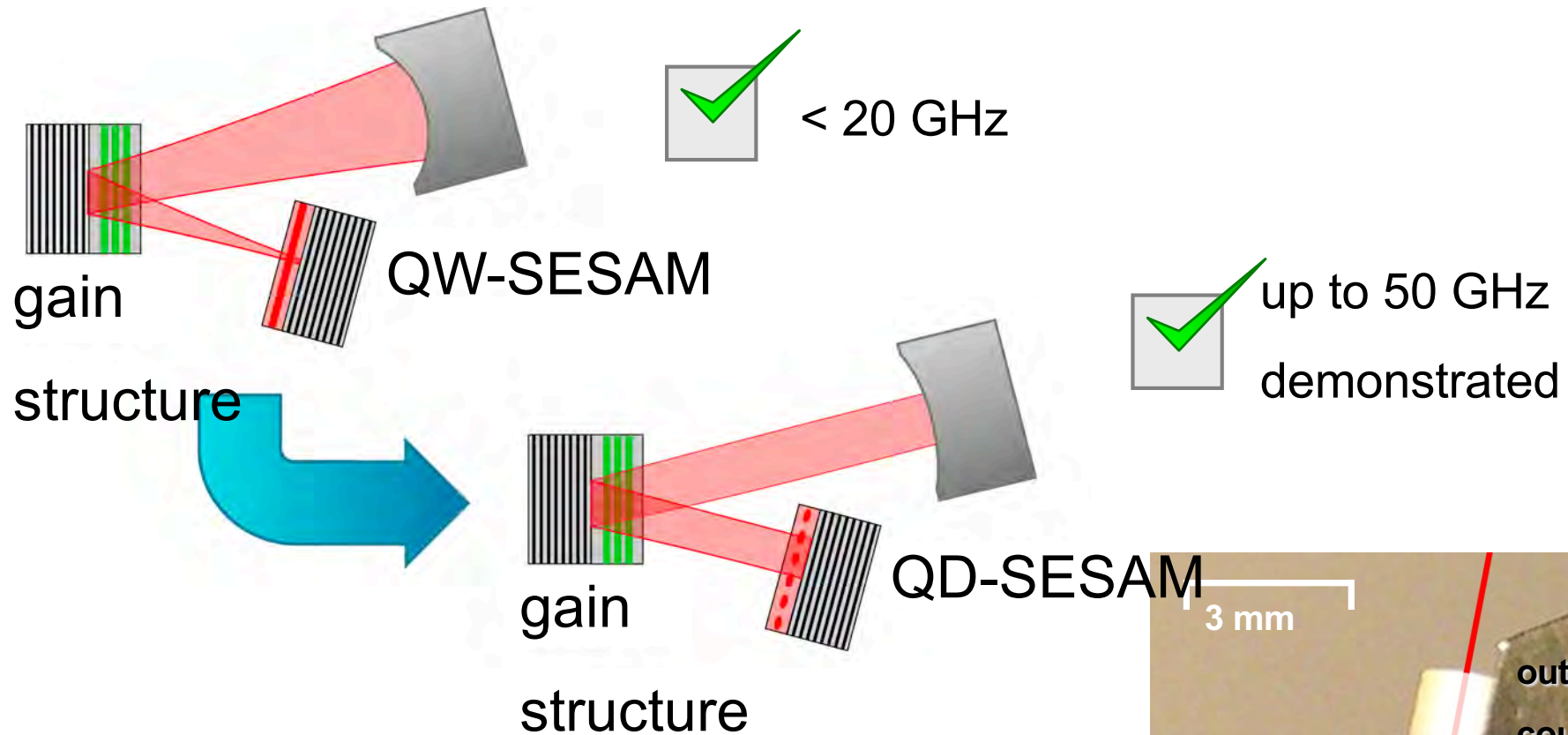
- Stranski-Krastanov growth on MBE
- InAs on GaAs substrate
- In ML coverage determines density

Self-assembled QD formation:



ΔR can be tuned with dot density, while F_{sat} stays constant!





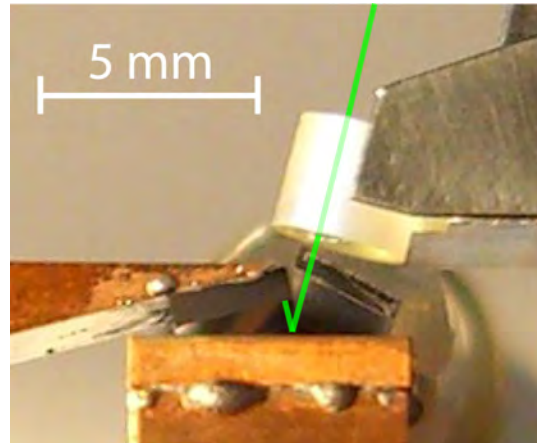
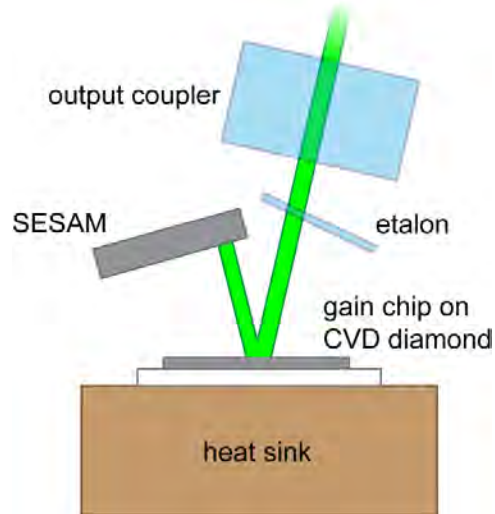
QD-SESAM modelocking: up to 50 GHz repetition rate

D. Lorensen et al., IEEE J. Quantum Electron. **42**, 838-847, 2006

- **102 mW** average power, center wavelength 958.5 nm
- **3.3 ps** pulse duration

Towards Absorber Integration: “1:1 modelocking”

Modelocking with identical mode sizes on gain and absorber:

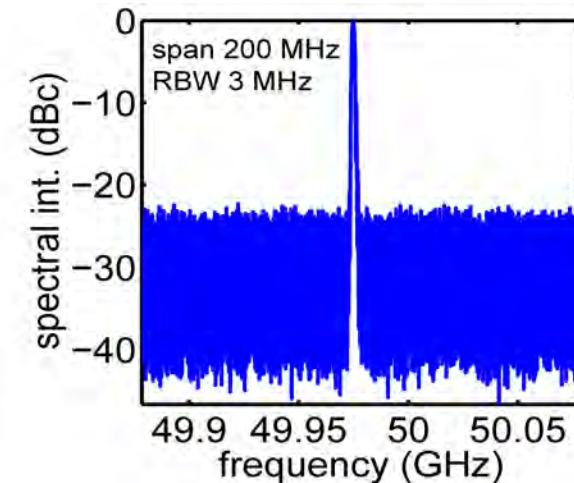
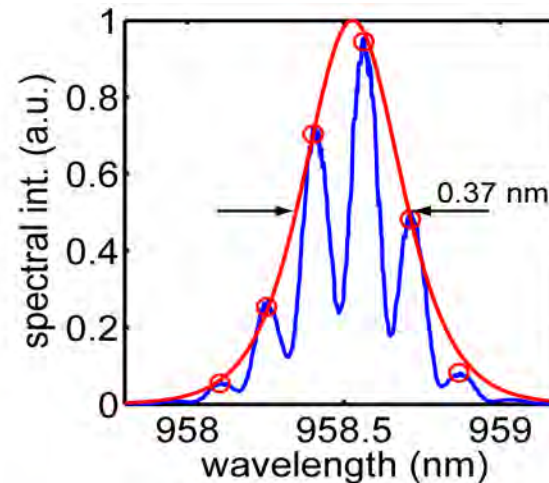
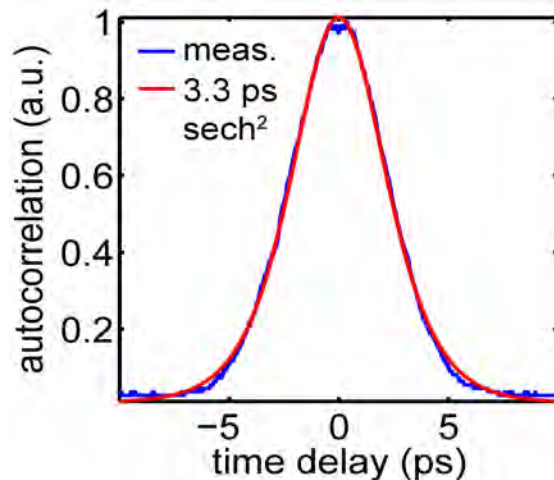


Resonant QD SESAM:

- $\Delta R = 1\%$
- $F_{\text{sat}} = 2 \mu\text{J}/\text{cm}^2$

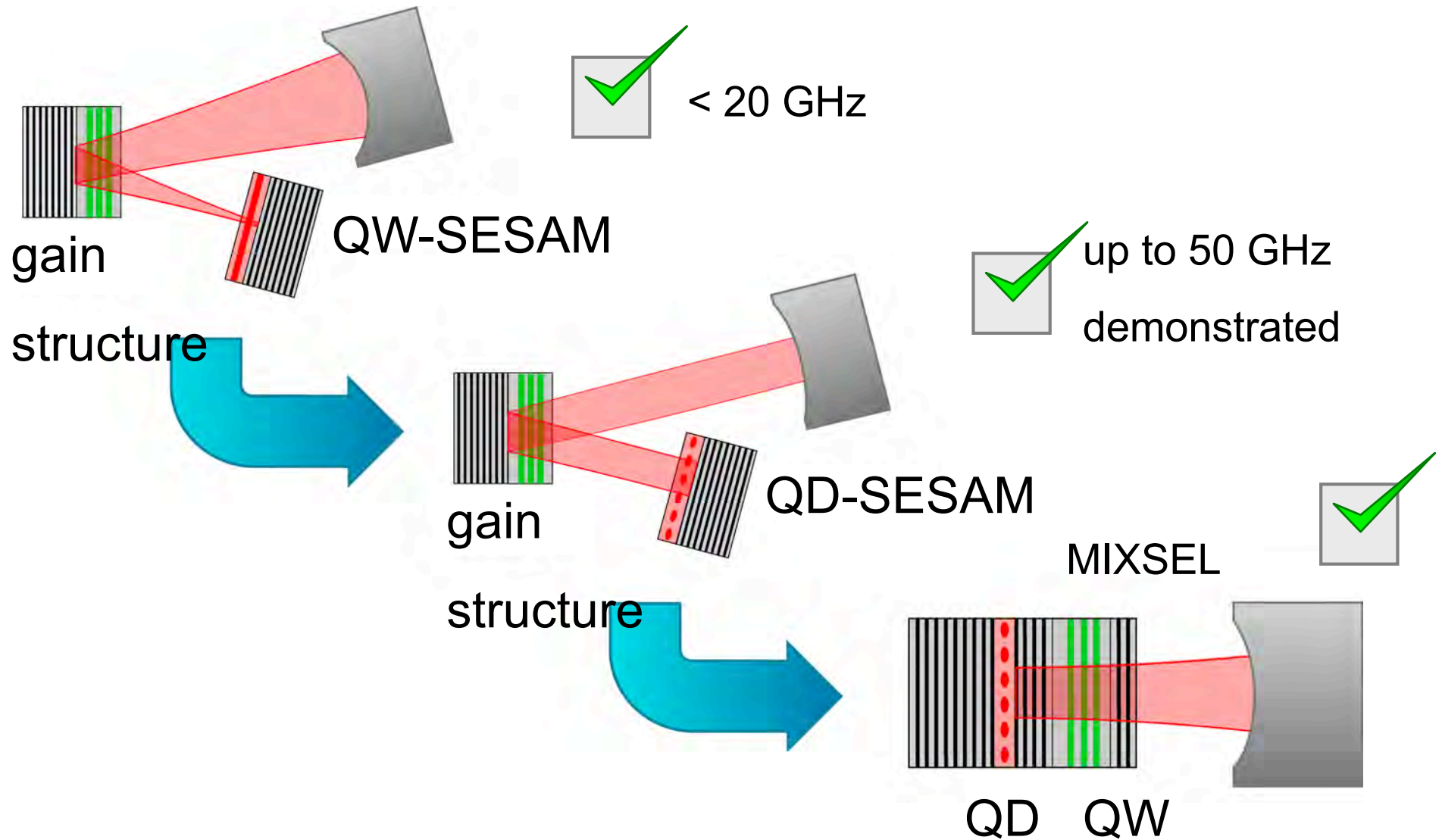
Laser output:

- $P_{\text{out}} = 102 \text{ mW}$
- $\tau_p = 3.3 \text{ ps}$
- $f_{\text{rep}} = 50 \text{ GHz}$



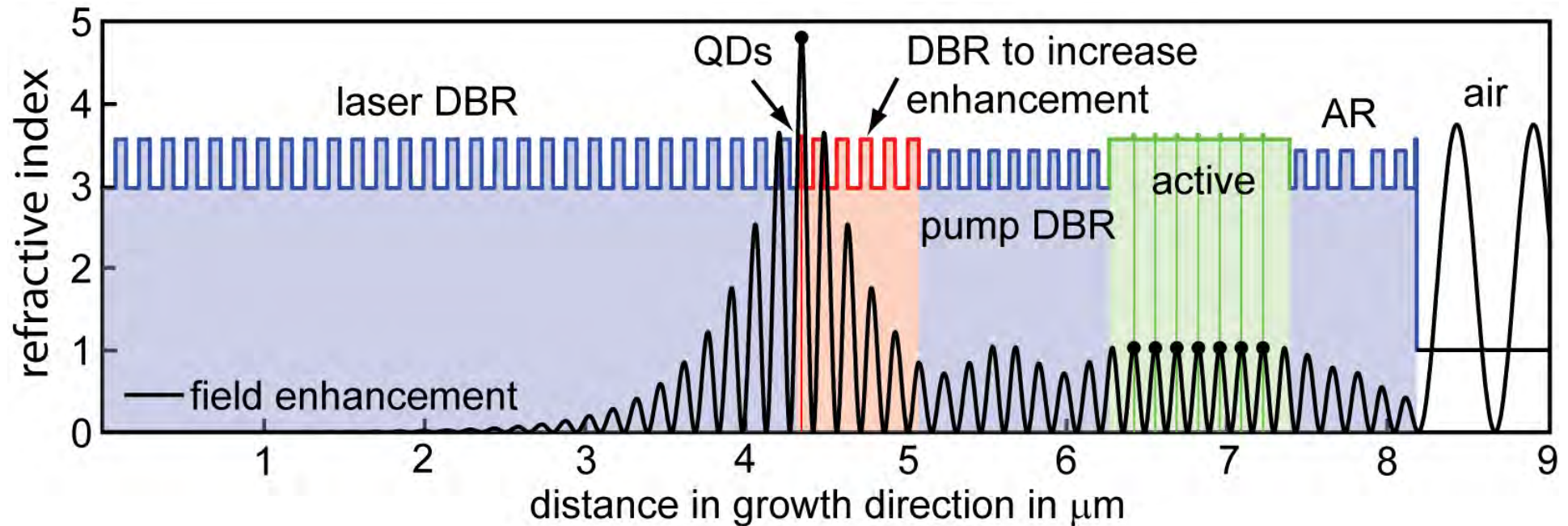
➔ Integration of absorber is now conceptually possible!

D. Lorensen et al., IEEE J. Quantum Electron. **42**, 838-847 (2006)



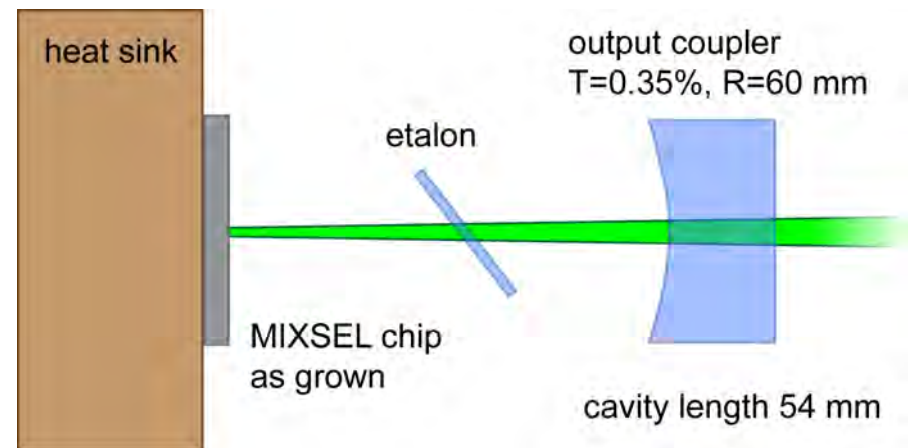
First MIXSEL demonstration: 35 ps, 40 mW, 2.8 GHz

Resonant design



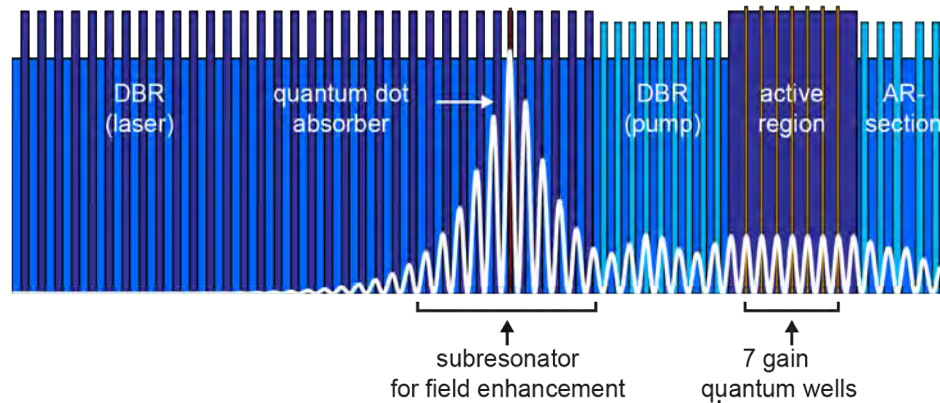
Sections:

- 30 pair bottom mirror for the laser
- 1 layer of self-assembled InAs QD
- DBR to increase field in absorber
- 9 pair mirror for the pump
- active region with 7 InGaAs QWs
- AR coating

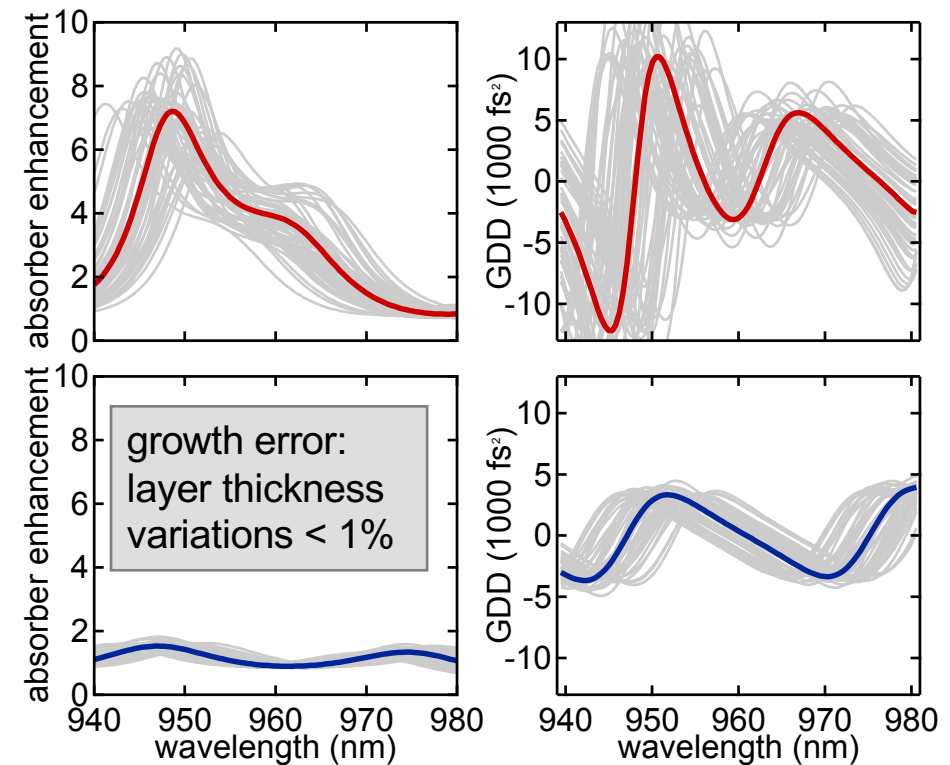
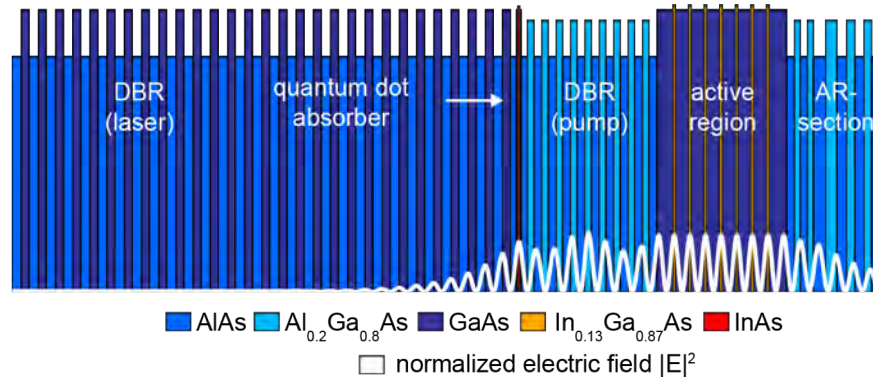


D. J. H. C. Maas et al., Applied Physics B **88**, 493-497 (2007)

resonant MIXSEL structure



antiresonant MIXSEL structure



Advantages

- less variations in absorber enhancement
- reduced GDD for shorter pulses
- less sensitive to growth errors

Requirement

- QDs with strong saturation
- study on QD-growth parameters optimization of growth temperature and post-growth annealing

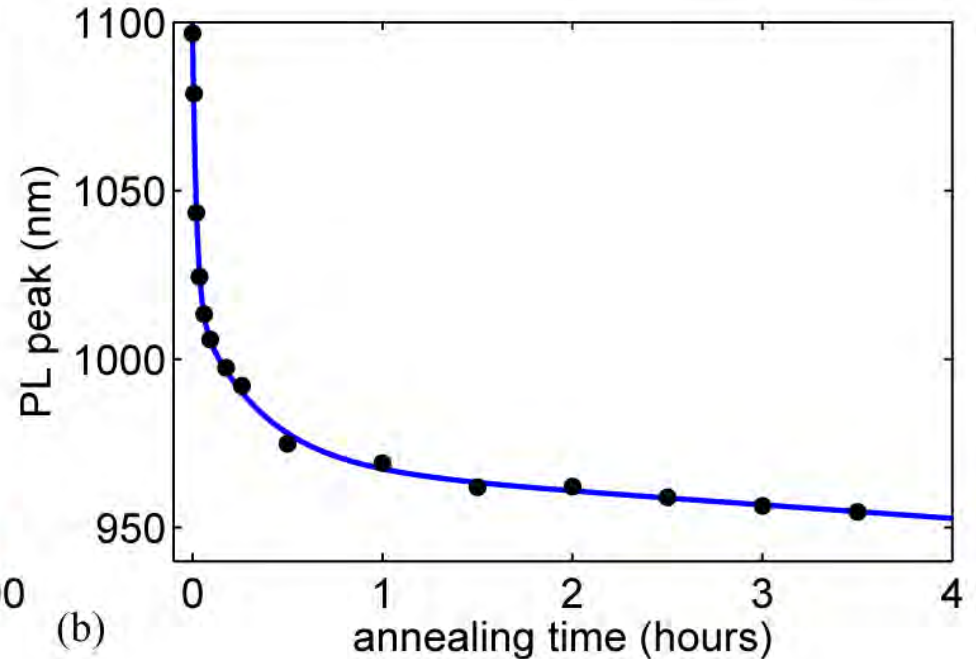
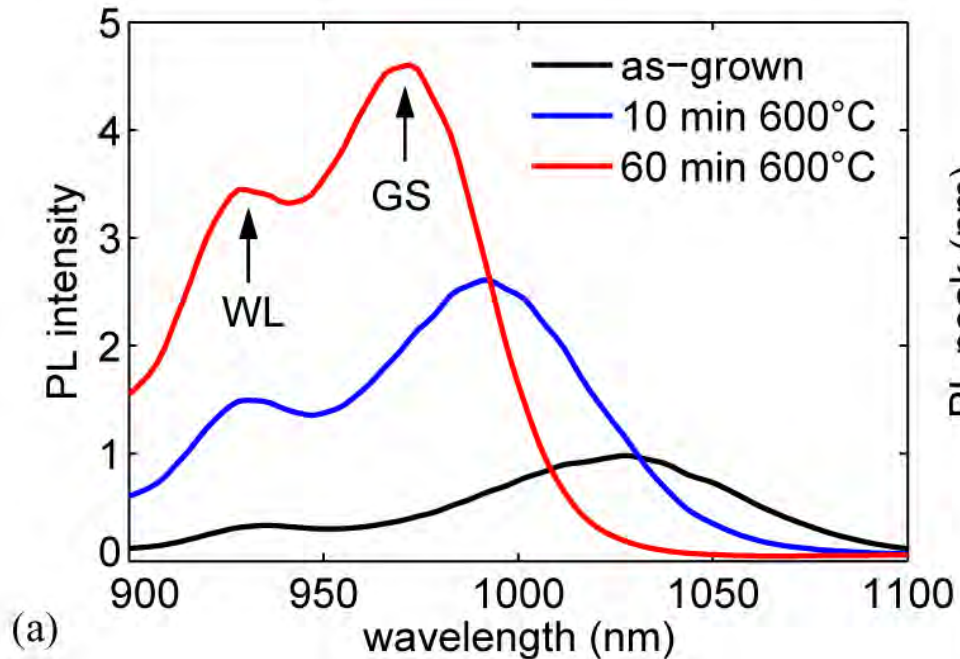
A.-R. Bellancourt, Y. Barbarin, D. J. H. C. Maas, M. Shafiei, M. Hoffmann, M. Golling, T. Südmeyer, U. Keller, *OE*, 17, 12, (2009)
 D. J. H. C. Maas, A. R. Bellancourt, M. Hoffmann, B. Rudin, Y. Barbarin, M. Golling, T. Südmeyer, U. Keller, *OE*, 16, 23, (2008)

Photoluminescence (PL) shift during annealing

The QDs are annealed in the growth of a MIXSEL:

Strong blueshift of the PL peak

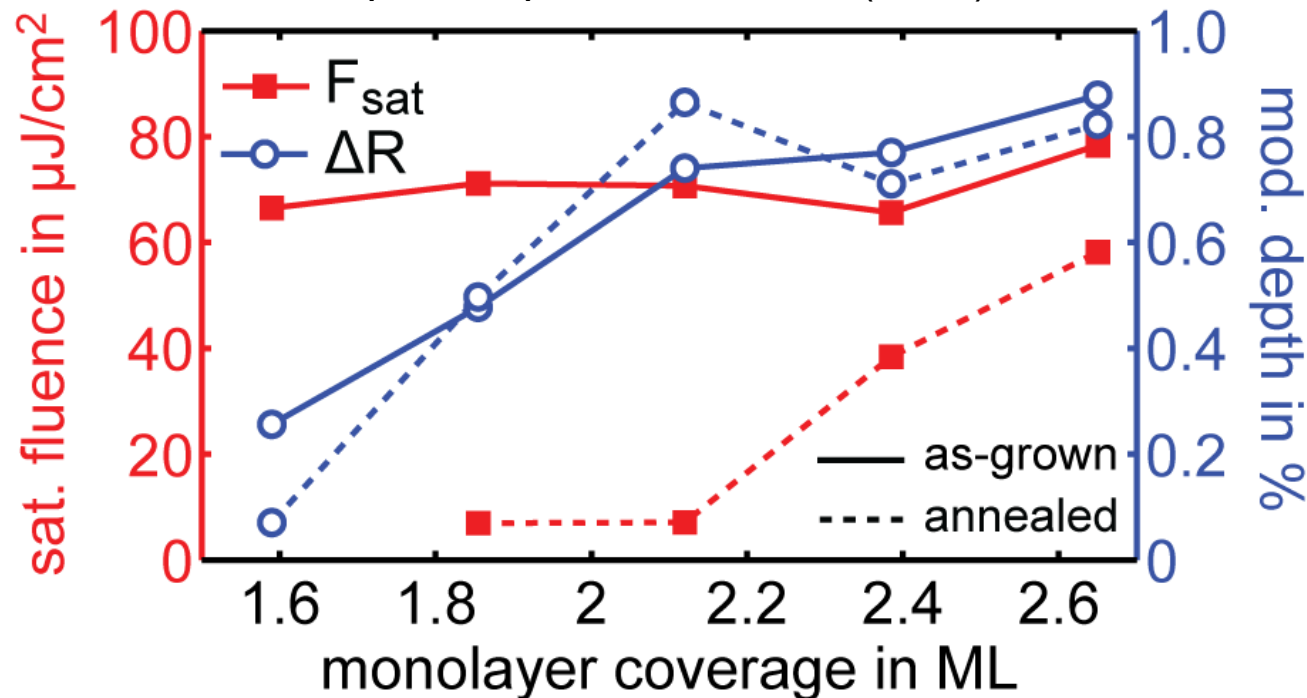
Case with 1.6 ML InAs coverage



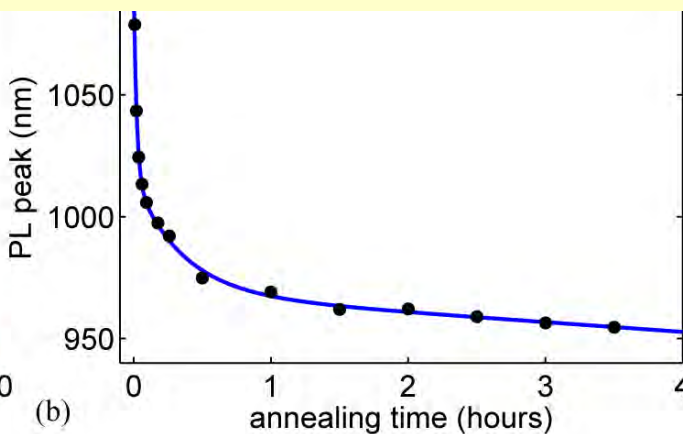
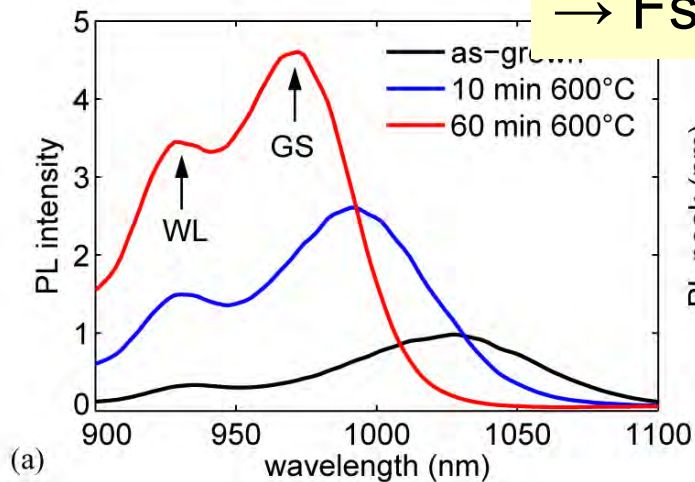
D.J.H.C. Maas, A.-R. Bellancourt, M. Hoffmann, B. Rudin, Y. Barbarin, M. Golling, T. Südmeyer, and U. Keller, *Optics Express* **16**, 18646 (2008)



Optics Express **16**, 18646 (2008)



→ F_{sat} decreased by annealing and $\Delta R \approx \text{constant}$

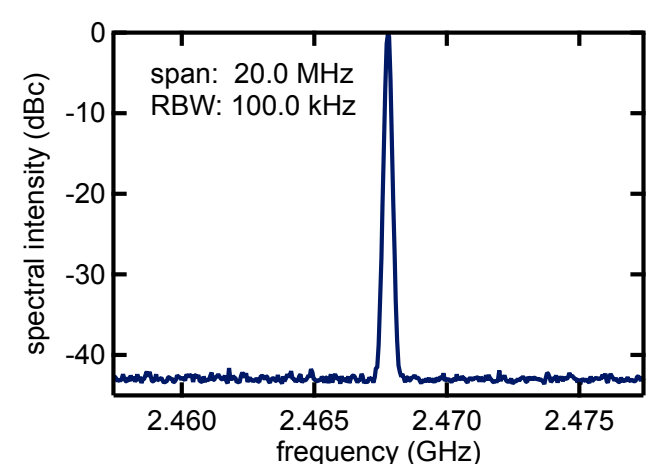
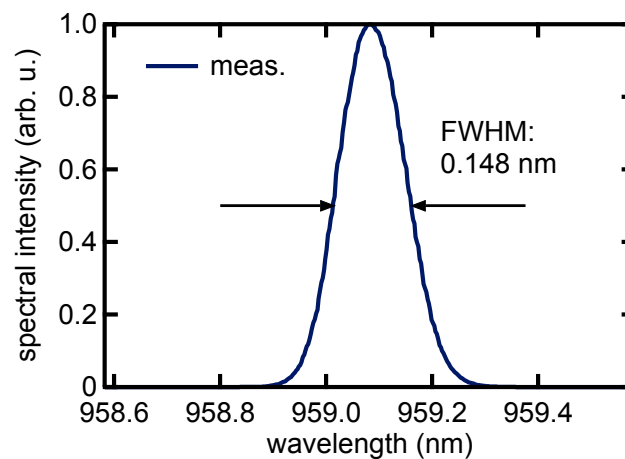
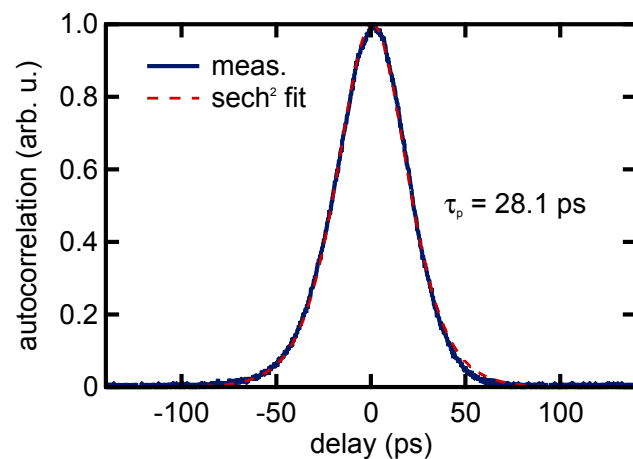
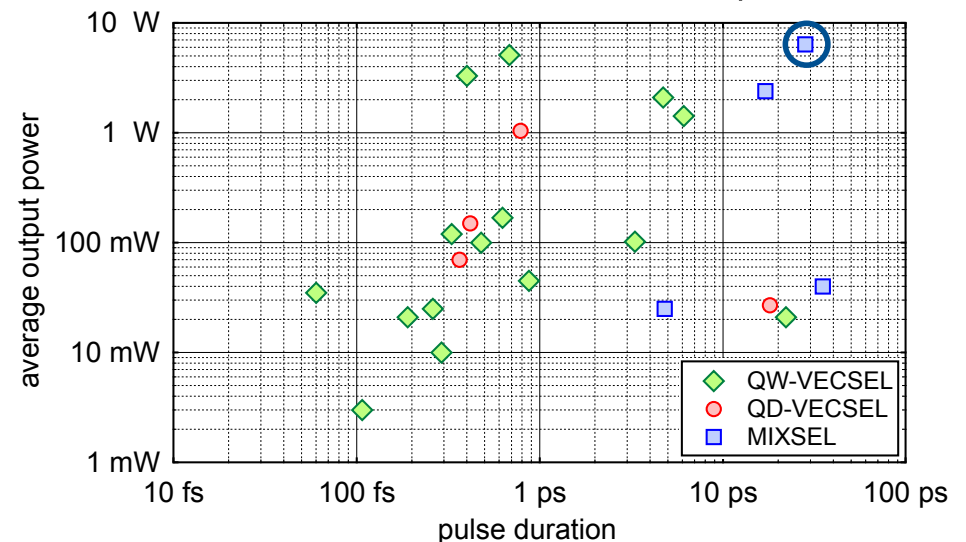


Average power	6.4 W
Center wavelength	959.1 nm
Pulse duration	28.1 ps
FWHM spectral width	0.15 nm

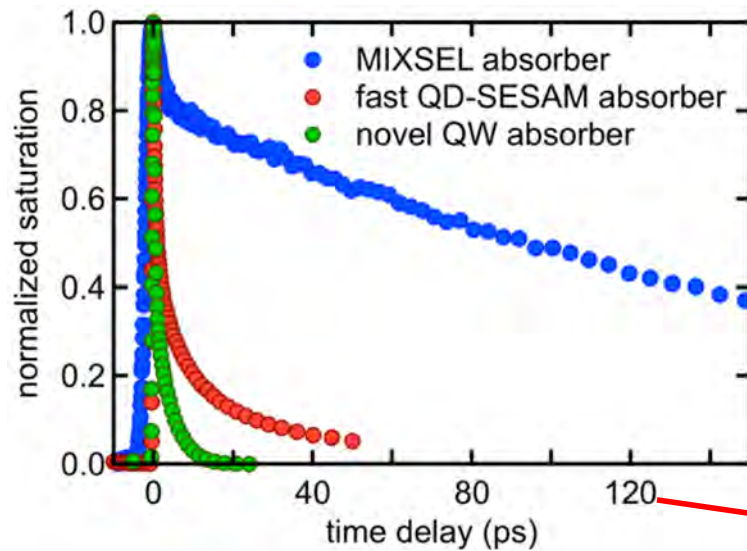
- optical pumping **36.7 W** at **808 nm**
- pump / laser spot radius: $\approx 215 \mu\text{m}$
- cavity length: **60.8 mm** \Rightarrow **2.47 GHz**
- fluence on the MIXSEL : **252 $\mu\text{J}/\text{cm}^2$**

highest average power from an
ultrafast semiconductor laser

Optics Express **18**, 27582 (2010)

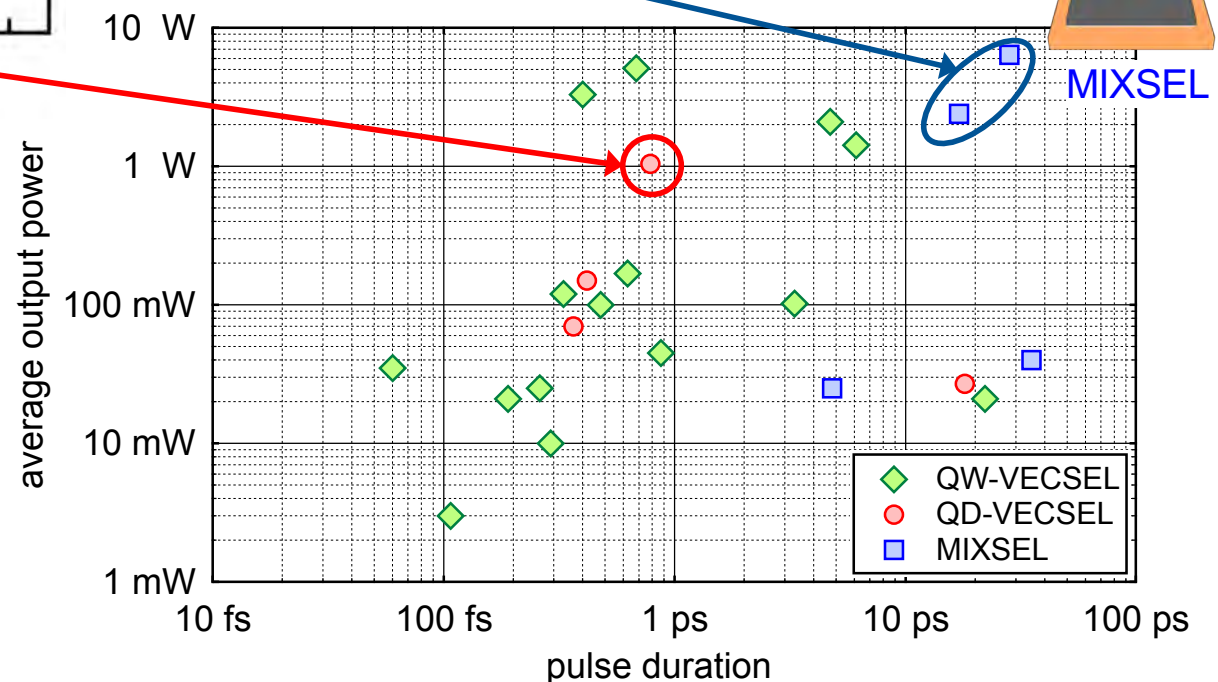
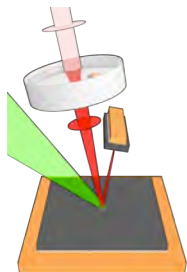


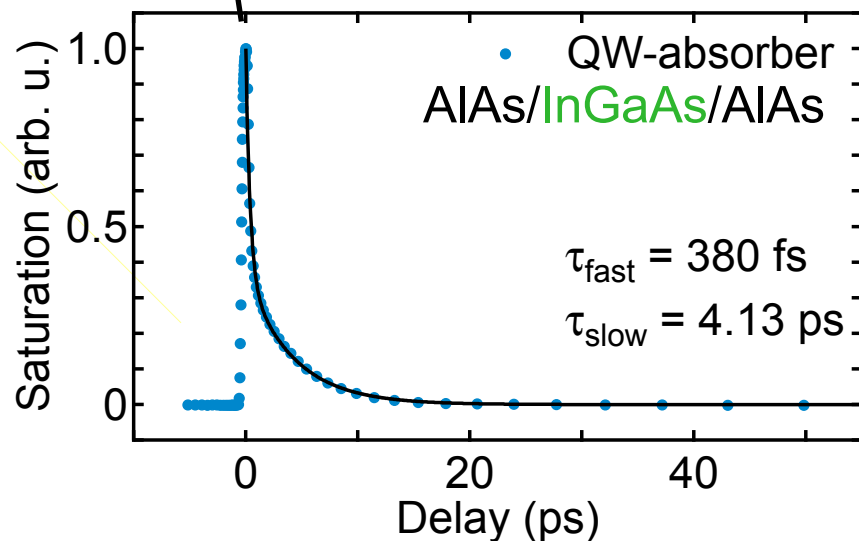
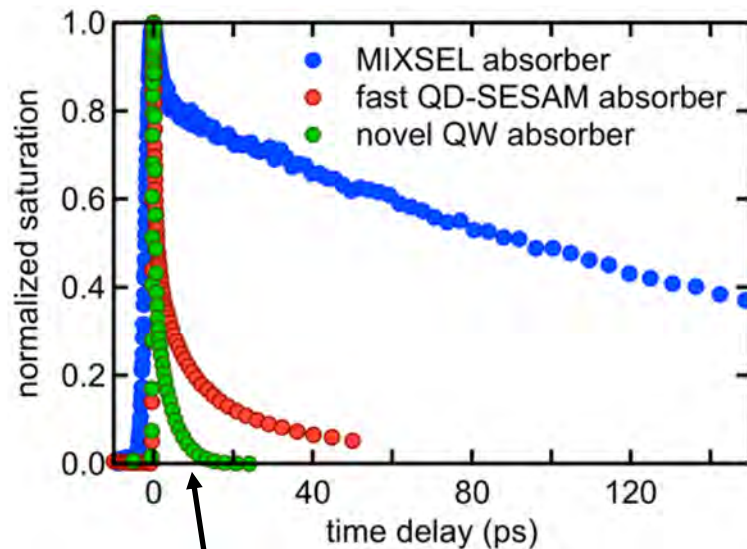
absorber recombination



- slow recombination of the QD absorber in the MIXSEL *Optics Express* **18**, 27582 (2010)
- compared to the absorber in the QD SESAM for femtosecond pulses
- challenging to integrate (annealing study needed)

SESAM-modelocked QD-VECSEL:
M. Hoffmann et al.,
Opt. Express **19**, 8108 (2011)





Saturable absorber

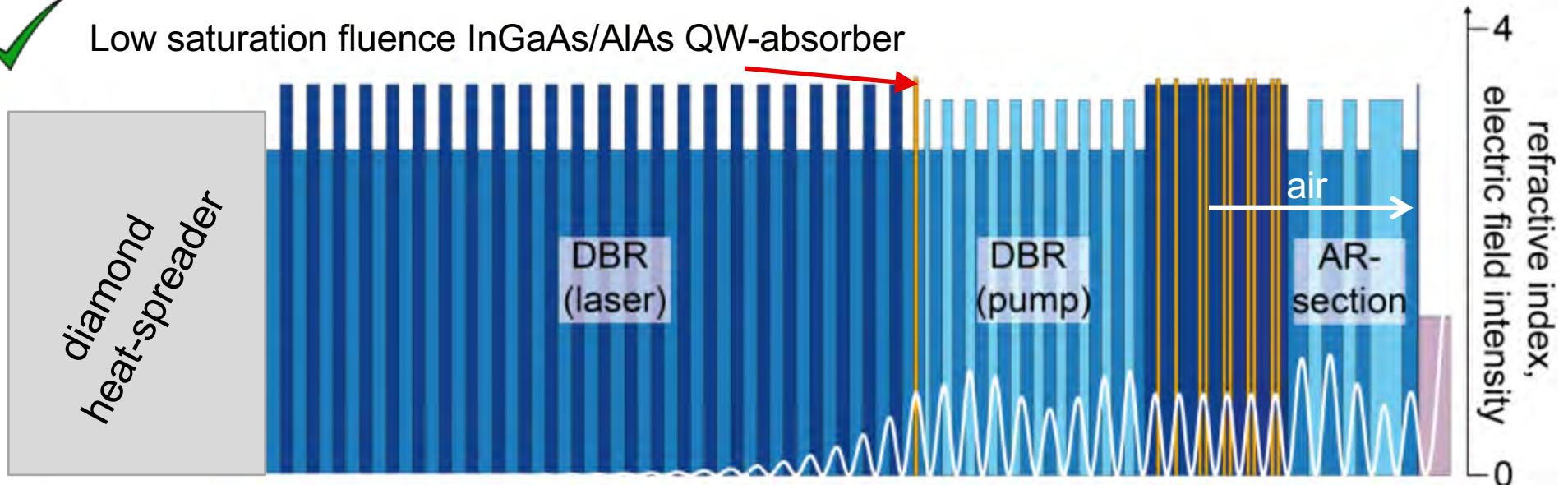
- Single **InGaAs** quantum well
- Embedded in **AIAs**
- Grown by molecular beam epitaxy (MBE)
- Low-temperature grown ($< 300^\circ \text{ C}$)
- Operated close to the **bandedge**

Absorbers for integration

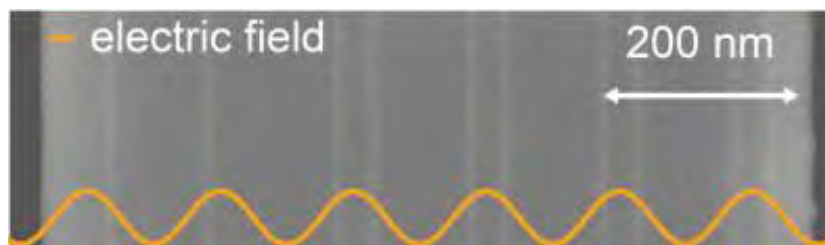
	InGaAs QWs	InAs QDs
Low saturation fluence	+	+
Fast recovery dynamics	+	-
Simple fabrication	+	-
Non-saturable losses	+	+
Temperature sensitivity	-	+
Design freedom	-	+



Low saturation fluence InGaAs/AlAs QW-absorber

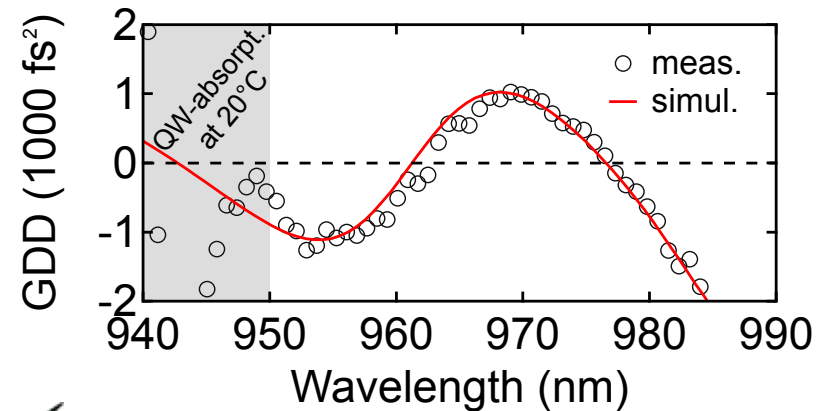


10 quantum well active region



Higher gain saturation fluence and more broadband gain

Anti-reflection section

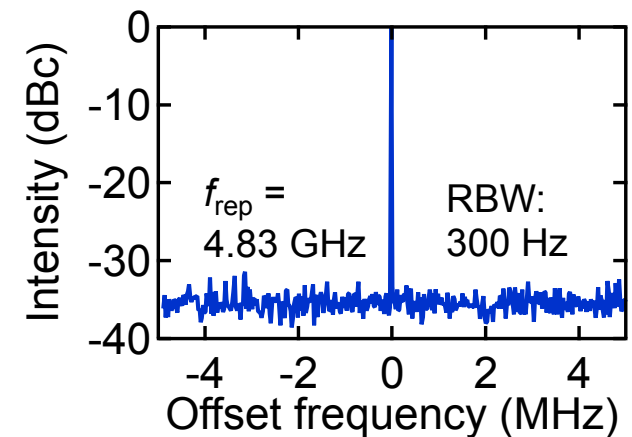
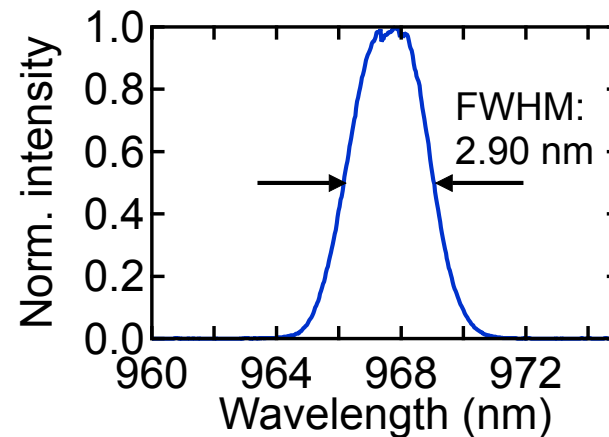
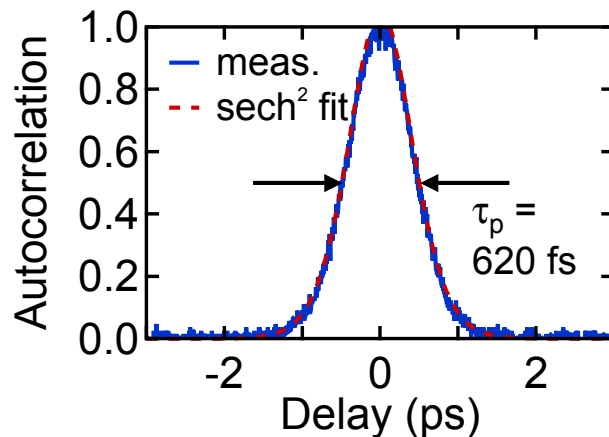
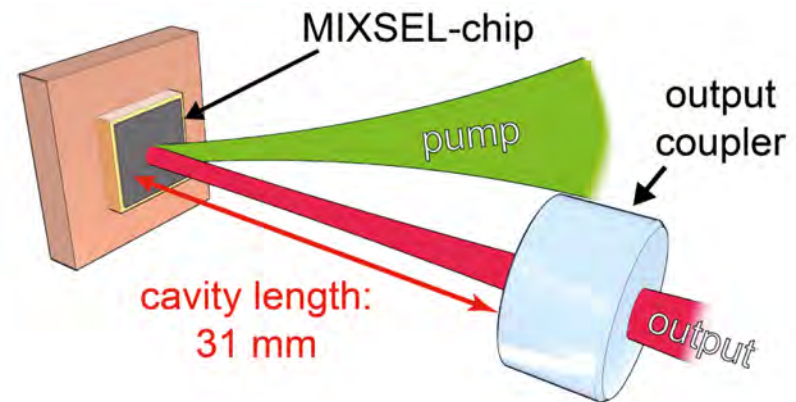


Low and flat group-delay dispersion

M. Mangold et al., *Opt. Express* **21**, 24904 (2013)



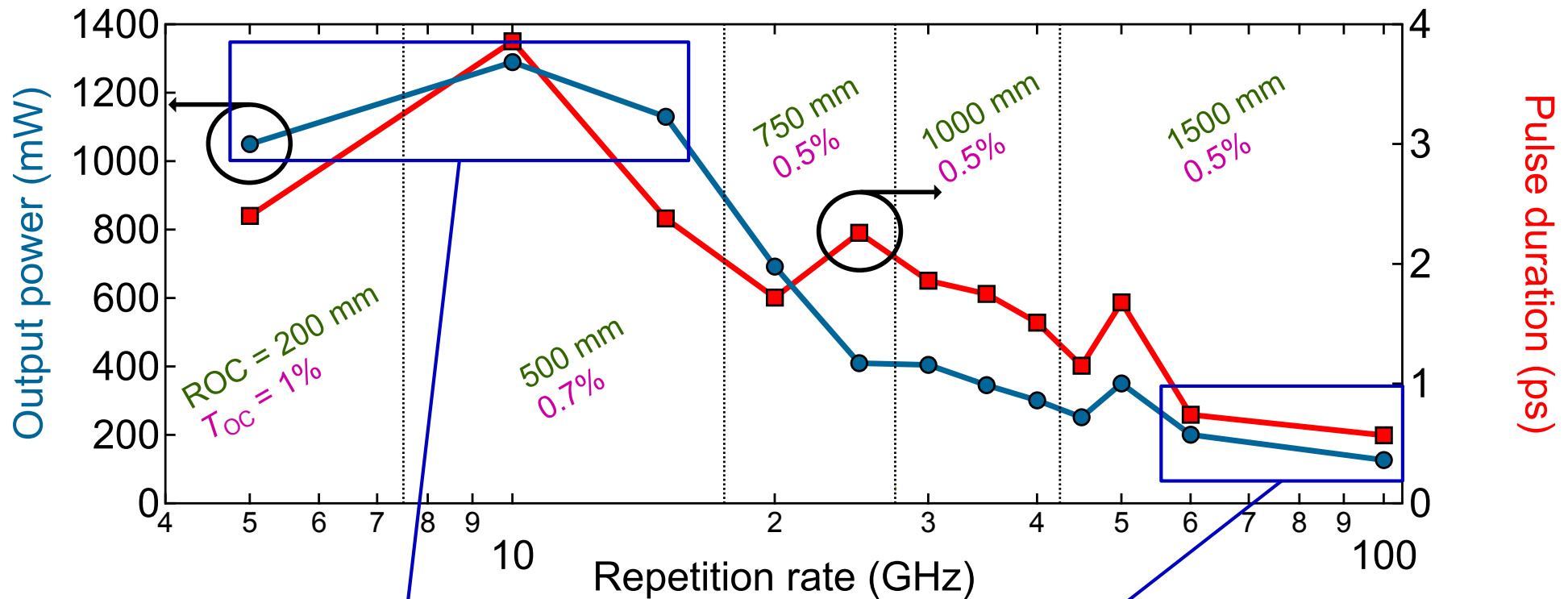
Pulse duration: **620 fs**
 Average output power: 101 mW
 Repetition rate: 4.83 GHz
 Center wavelength: 967.7 nm



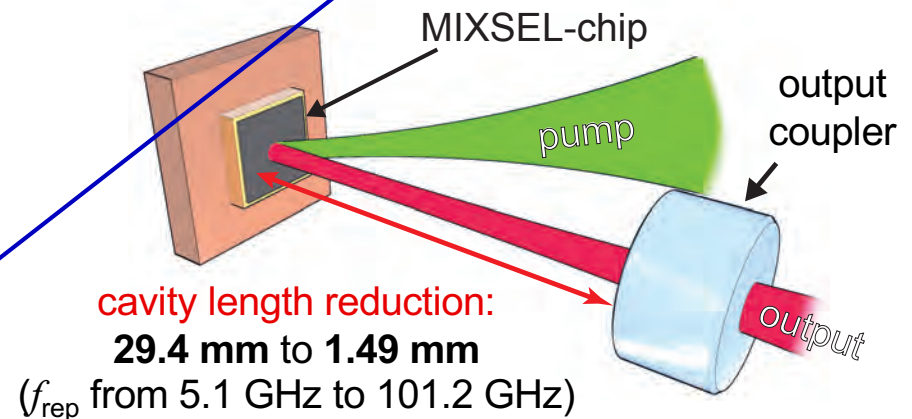
- Optical pumping **24.9 W** at **808 nm**
- Heat sink temperature: **+ 11 ° C**
- Output coupling: **0.35 % (ROC 200 mm)**
- Beam quality: **$M^2 < 1.05$**

**Shorter pulse duration enable
 scaling to higher repetition rates**

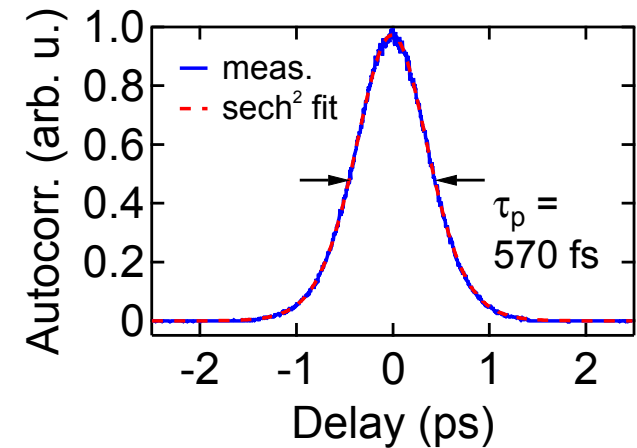
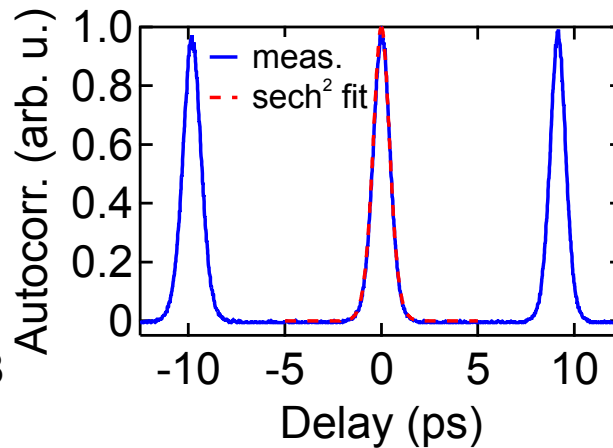
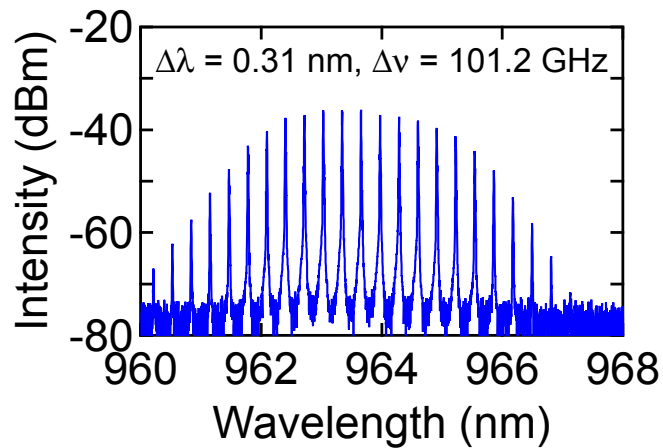
M. Mangold et al., *Opt. Express* **21**, 24904 (2013)



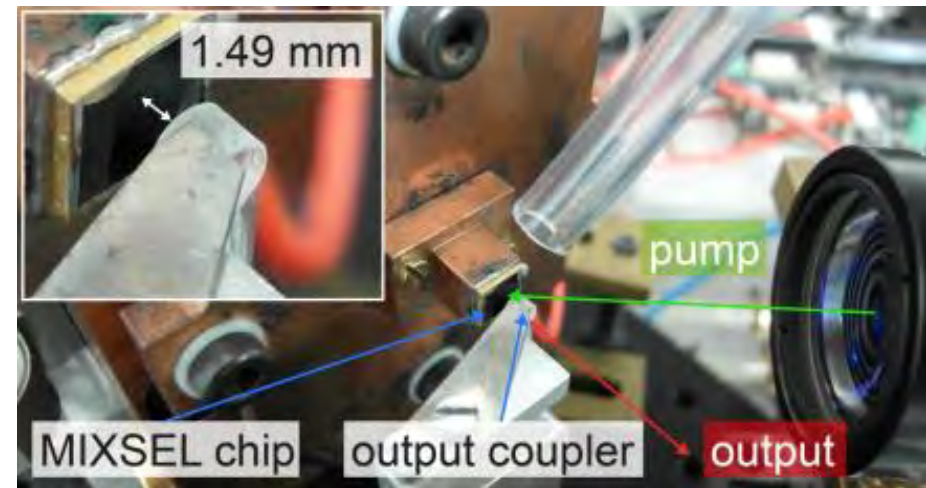
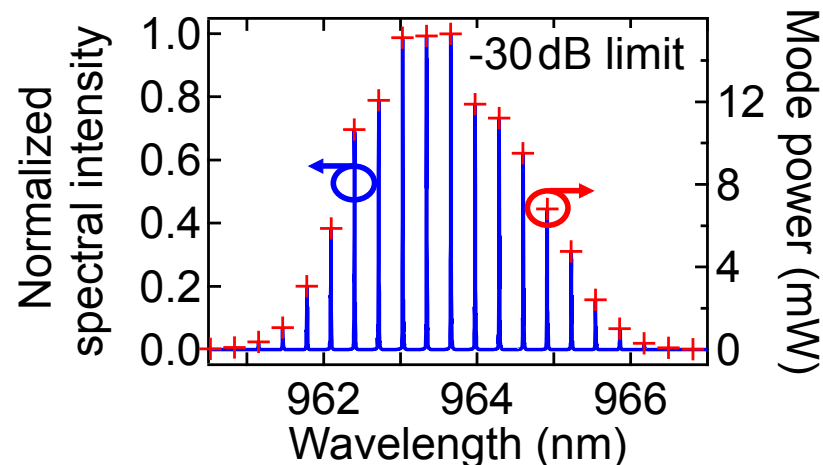
- Repetition rate-tuning from 5 GHz to 101 GHz with single MIXSEL structure
- Watt-level operation up to 15 GHz
- Femtosecond operation at 60 GHz and 101 GHz
- $M^2 < 1.1$ for all measurements



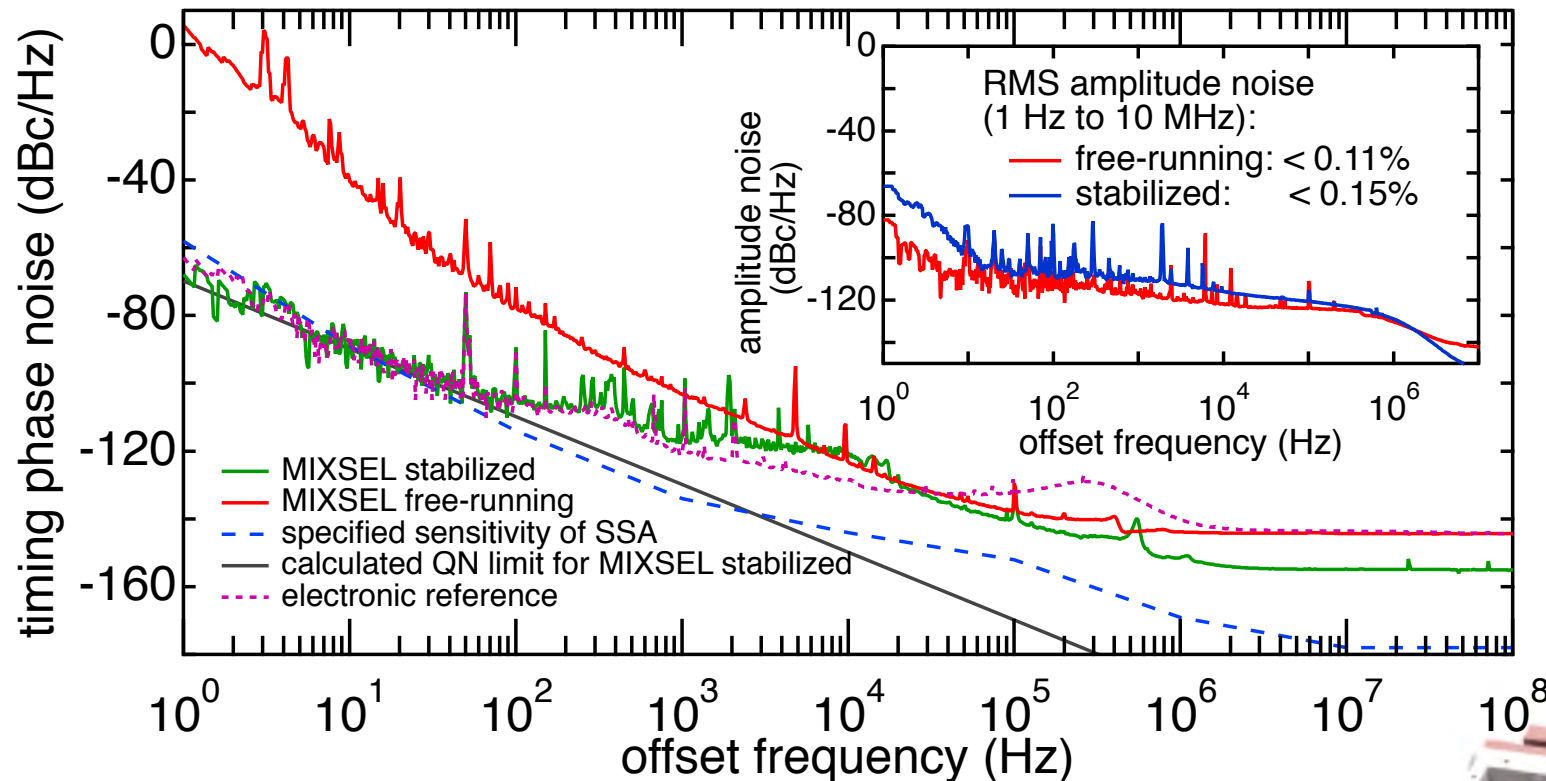
M. Mangold et al., *Opt. Express* **22**, pp. 6099 (2014)



Pulse duration: **570 fs**
Average output power: **127 mW**
Repetition rate: **101.2 GHz**
Av. mode power (-30 dB): **7.5 mW**



M. Mangold et al., *Opt. Express* **22**, pp. 6099 (2014)

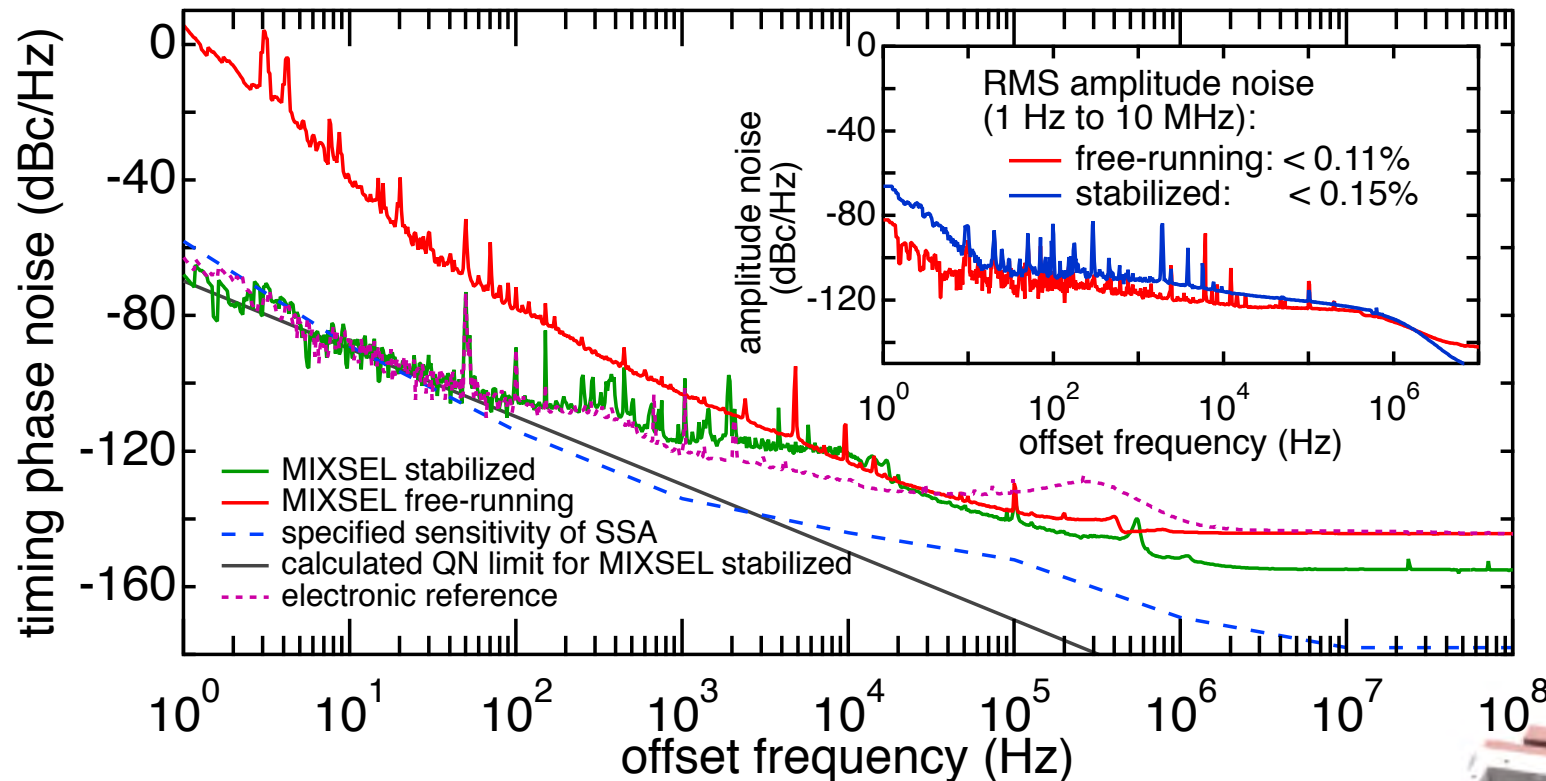


MIXSEL: >645 mW output power, 14.3 ps pulses, 2 GHz pulse replate

- **127 fs** timing jitter – free-running [100 Hz, 100 MHz]
- **31 fs** timing jitter – stabilized [100 Hz, 100 MHz]
- **< 0.15%** amplitude noise [1 Hz, 10 MHz]



M. Mangold, S. M. Link, A. Klenner, C. A. Zaugg, M. Golling, B. W. Tilma, U. Keller,
IEEE Photonics Journal **6**, 1500309 (2014)



MIXSEL: >645 mW output power, 14.3 ps pulses, 2 GHz pulse replate

- **127 fs** timing jitter – **free-running integrated over [100 Hz, 100 MHz]**
- Pulse repetition rate 2 GHz -> 0.5 ns between the pulses = $1 / (2 \text{ GHz})$
- $127 \text{ fs} / 0.5 \text{ ns} \approx 2.5 \cdot 10^{-4}$ **comb line spacing variations, integrated over $1 / (100 \text{ Hz}) = 10 \text{ ms}$!**



M. Mangold, S. M. Link, A. Klenner, C. A. Zaugg, M. Golling, B. W. Tilma, U. Keller,
IEEE Photonics Journal **6**, 1500309 (2014)

Optics Express **27**, 1786 (2019)

Dominik
Waldburger

Tightly locked optical frequency comb from a semiconductor disk laser

D. WALDBURGER,^{1,*} A. S. MAYER,¹ C. G. E. ALFIERI,¹ J. NÜRNBERG,¹ A. R. JOHNSON,² X. JI,³ A. KLENNER,² Y. OKAWACHI,² M. LIPSON,³ A. L. GAETA,² AND U. KELLER¹

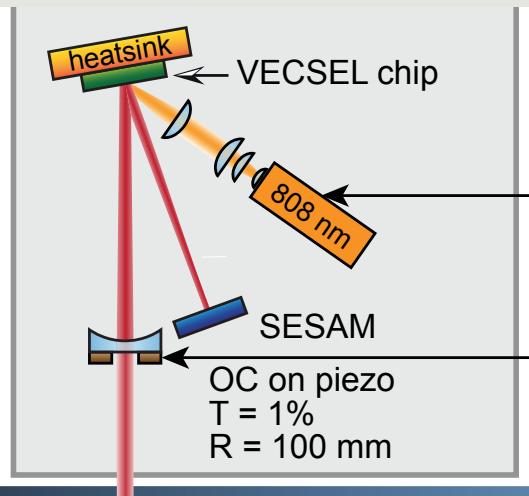
¹Department of Physics, Institute for Quantum Electronics, ETH Zurich, Auguste-Piccard-Hof 1, 8093 Zürich, Switzerland

²Department of Applied Physics and Applied Mathematics, Columbia University, New York, New York 10027, USA

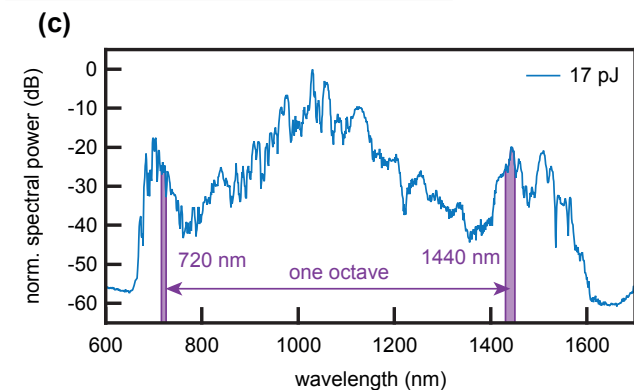
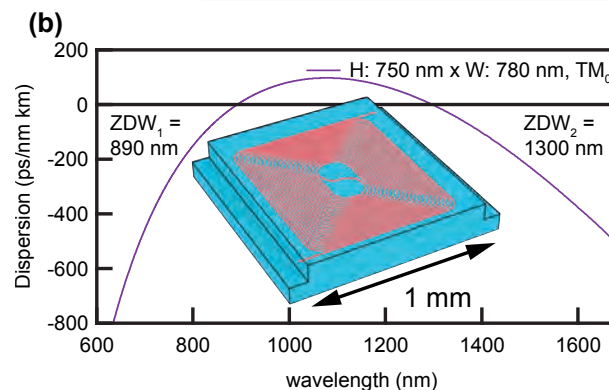
³Department of Electrical Engineering, Columbia University, New York, New York 10027, USA

*dominikw@phys.ethz.ch

122-fs pulses & 160-mW



No additional amplification and pulse compression with Silicon nitride waveguide



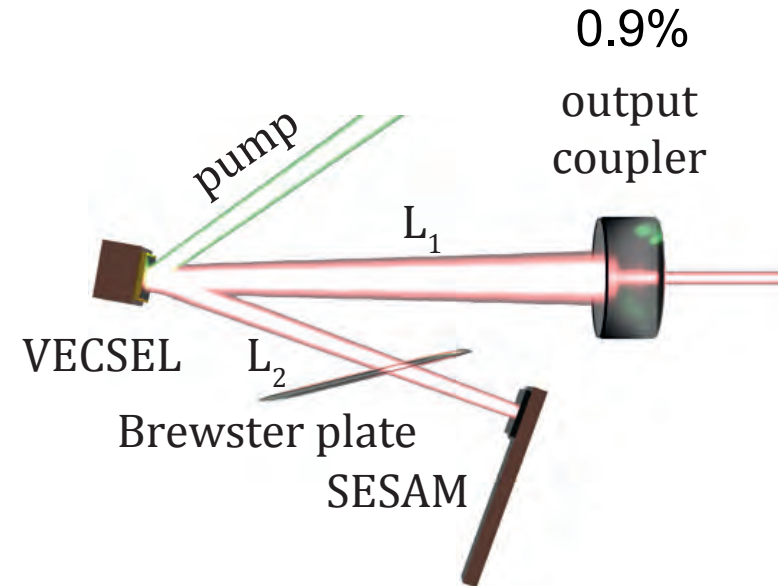
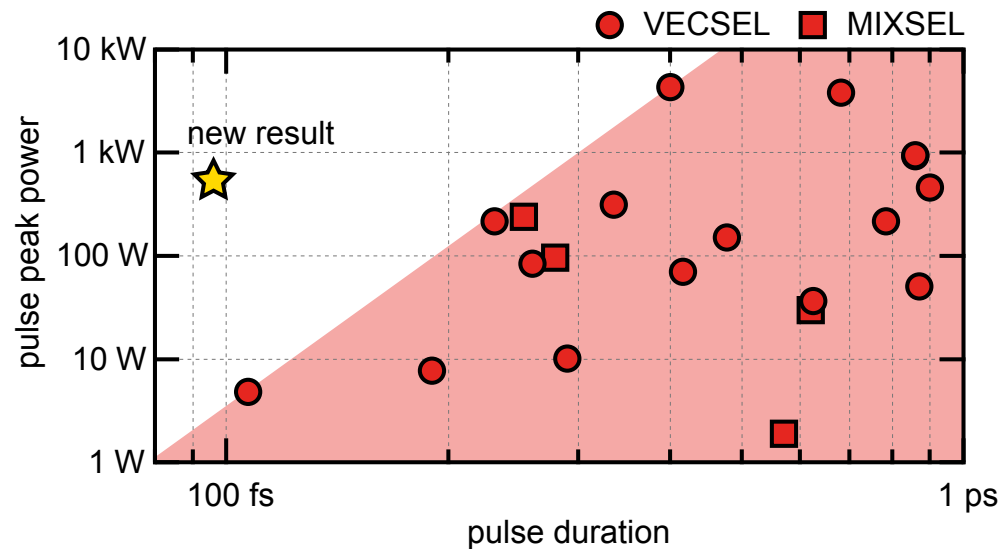
1. Introduction to ultrafast semiconductor disk lasers
2. SESAM-modelocked VECSELs
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6. Outlook



World-record 100-fs 100-mW 1.63-GHz VECSEL

FIRST 
Center for Micro- and Nanoscience

Pulse duration vs Power in near infrared (NIR)



Dominik
Waldburger



Dr. Matthias
Golling

QW-SESAM (single InGaAs)
LT (260 degrees) MBE grown in AlAs barriers
recovery times 560 fs/5.5 ps
SiN_x top coating for field enhancement 2
4.3 μJ/cm², ΔR = 2%

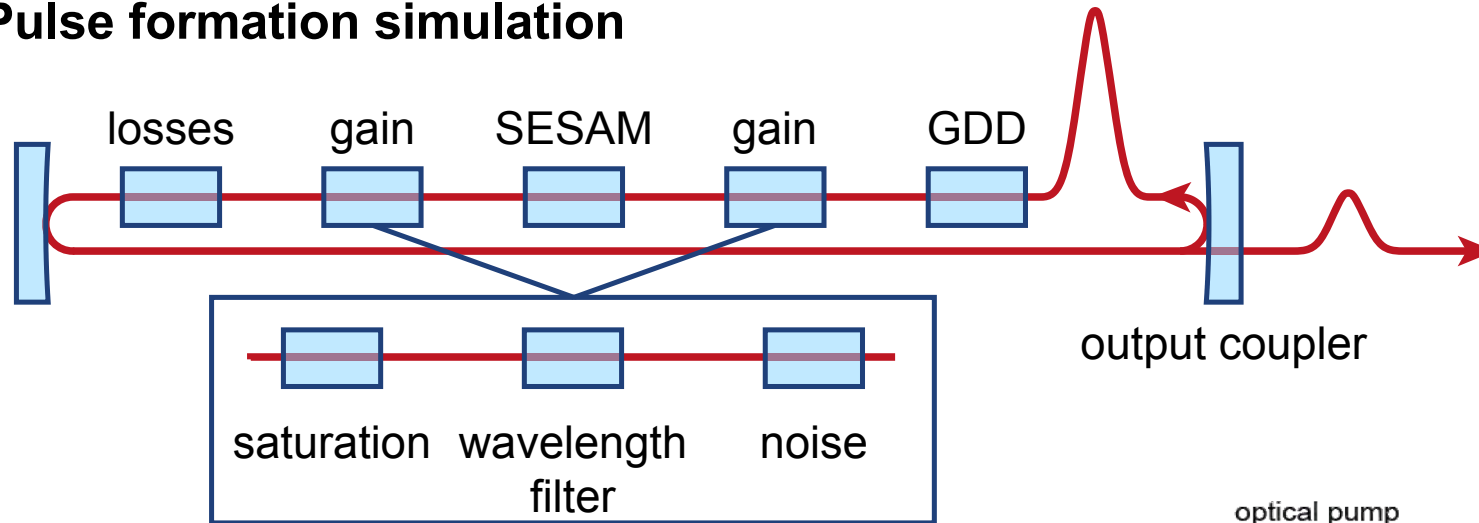
D. Waldburger, S. M. Link, M. Mangold, C. G. E. Alfieri, E. Gini, **M. Golling**, B. W. Tilma, U. Keller,
Optica **3**, 844–852 (2016)





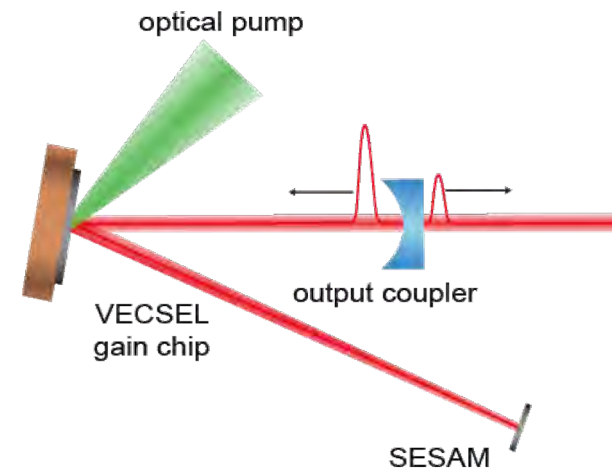
Oliver Sieber

Pulse formation simulation



Guidelines

- Broad gain bandwidth
- High gain saturation fluence
- Flat & zero group delay dispersion (GDD)

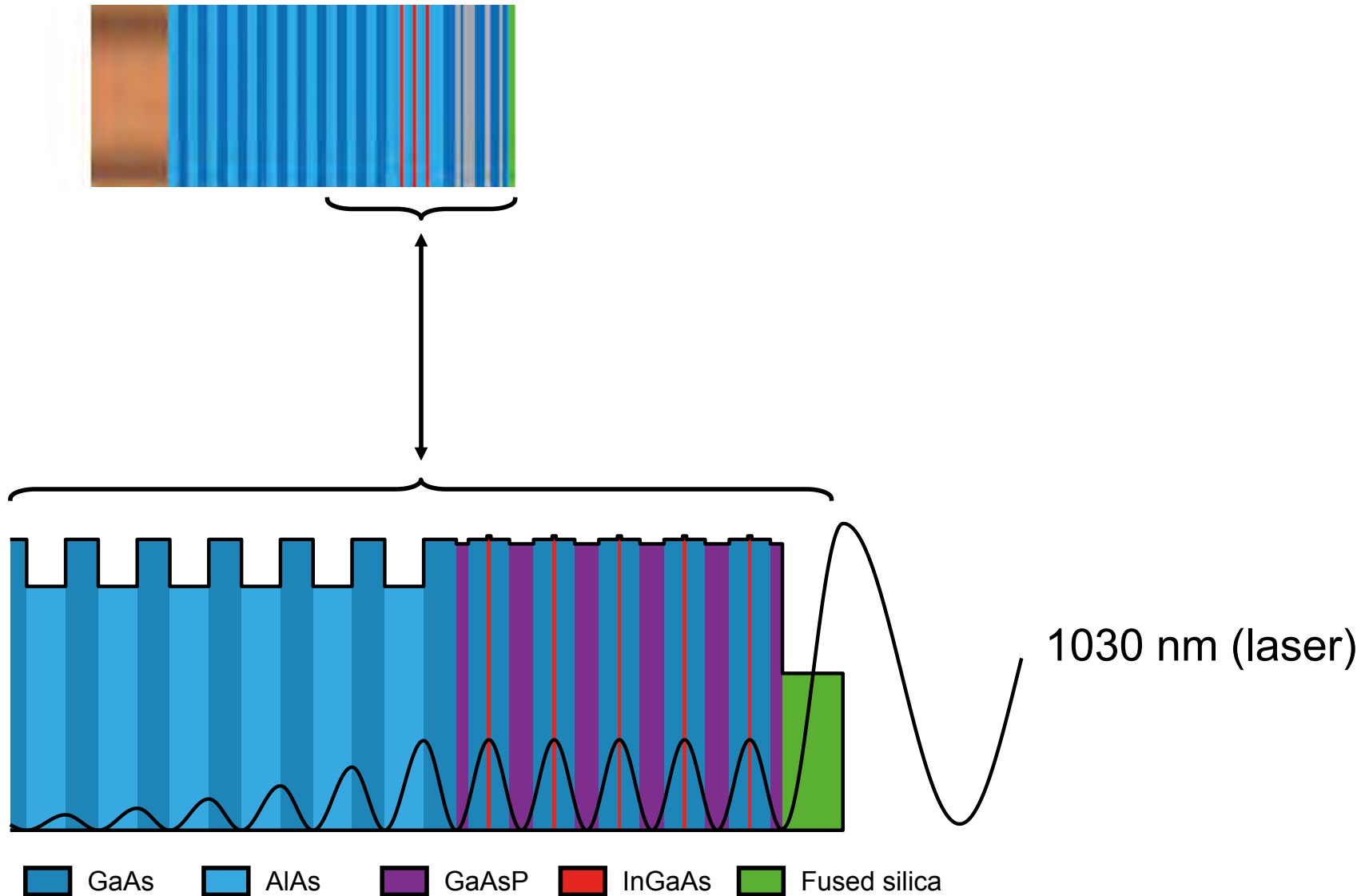


O. D. Sieber, M. Hoffmann, V. J. Wittwer, M. Mangold, M. Golling, B. W. Tilma, T. Südmeyer, U. Keller, *Appl. Phys. B* **113**, 133-145 (2013)



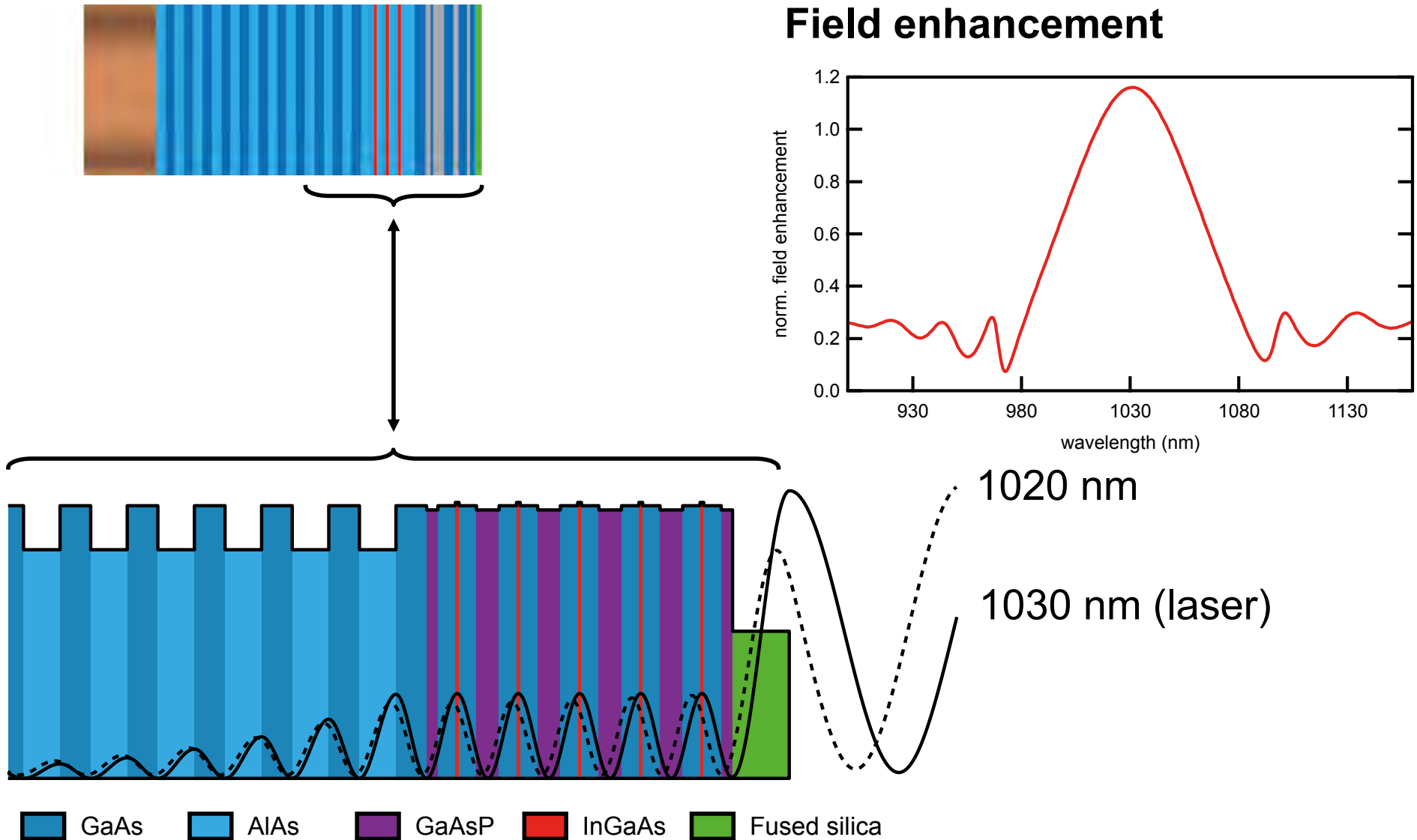
ETH InGaAs quantum well position in VECSEL chip

D. Waldburger et al., *Optica* 3, 844–852 (2016)



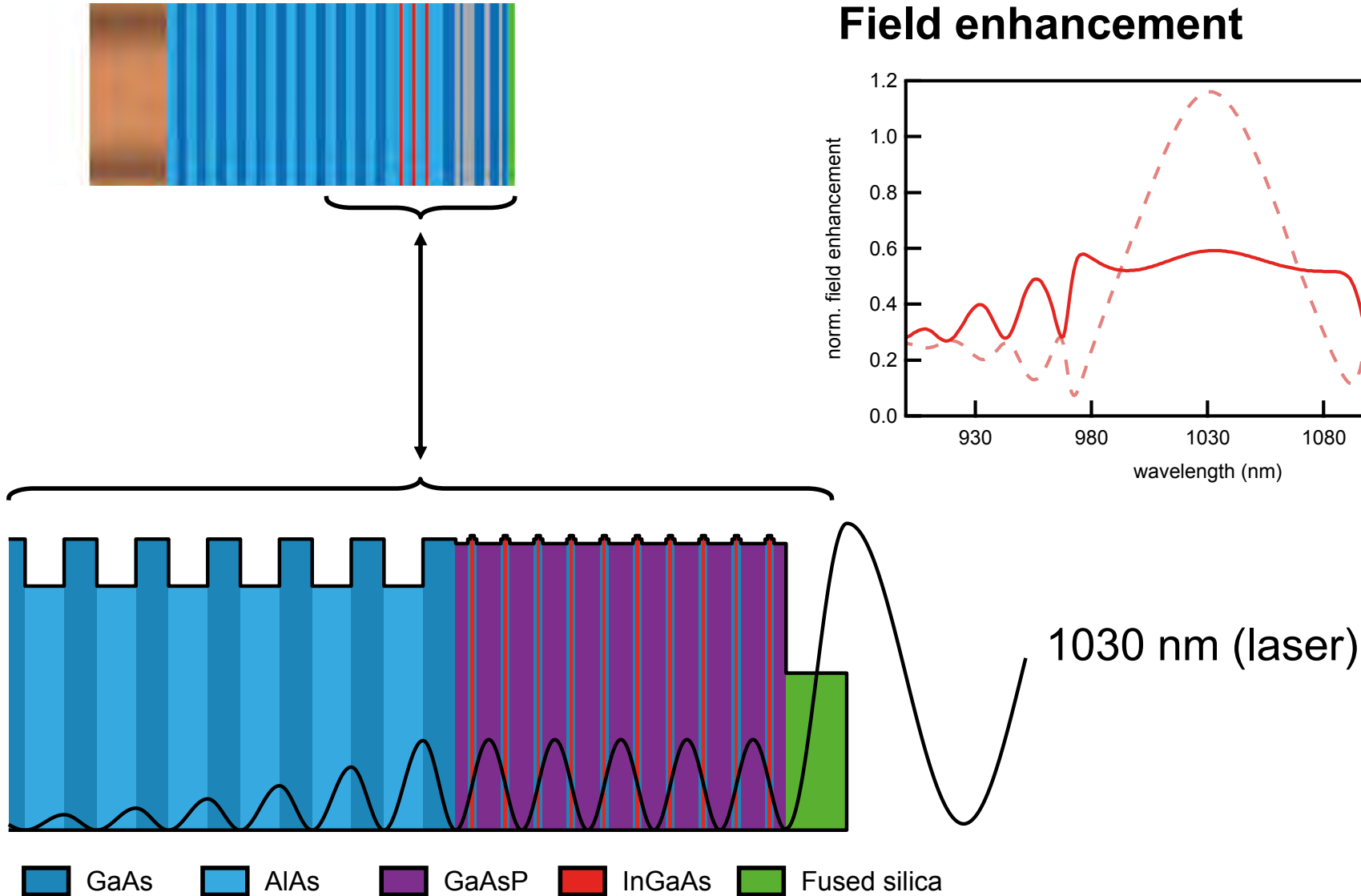
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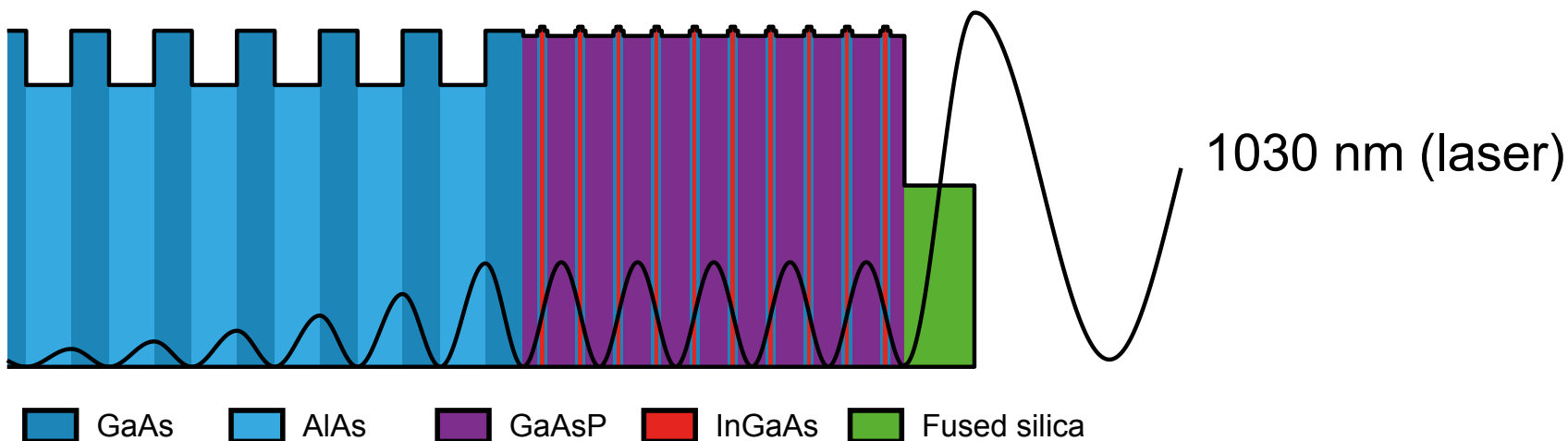
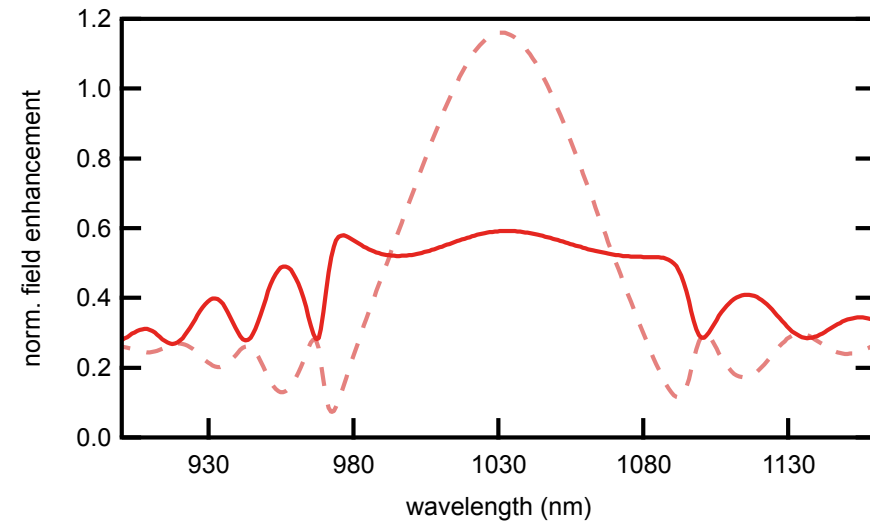
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Pulse formation simulation

- ✓ Broad gain bandwidth
- ✓ High gain saturation fluence
- ✗ Reduced overall gain

Field enhancement



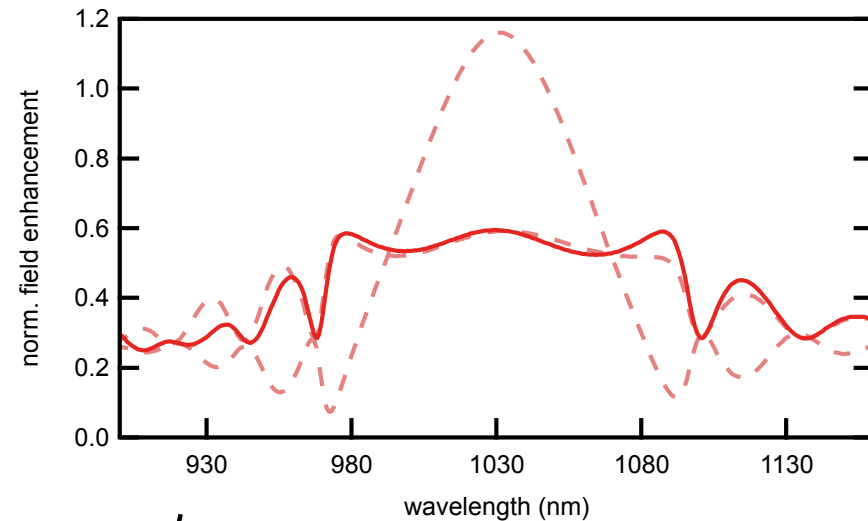
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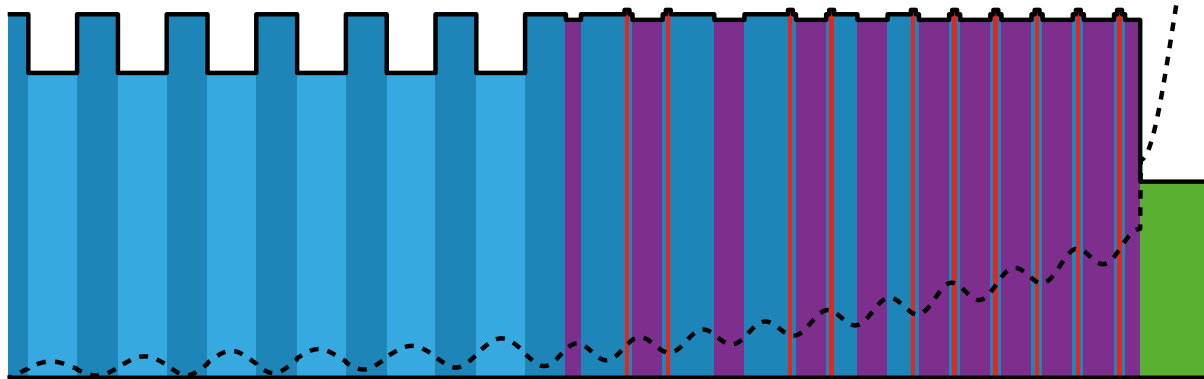
Pulse formation simulation

- ✓ Broad gain bandwidth
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- ✗ Reduced overall gain
- **Optimize pump absorption**

Field enhancement



808 nm (pump)

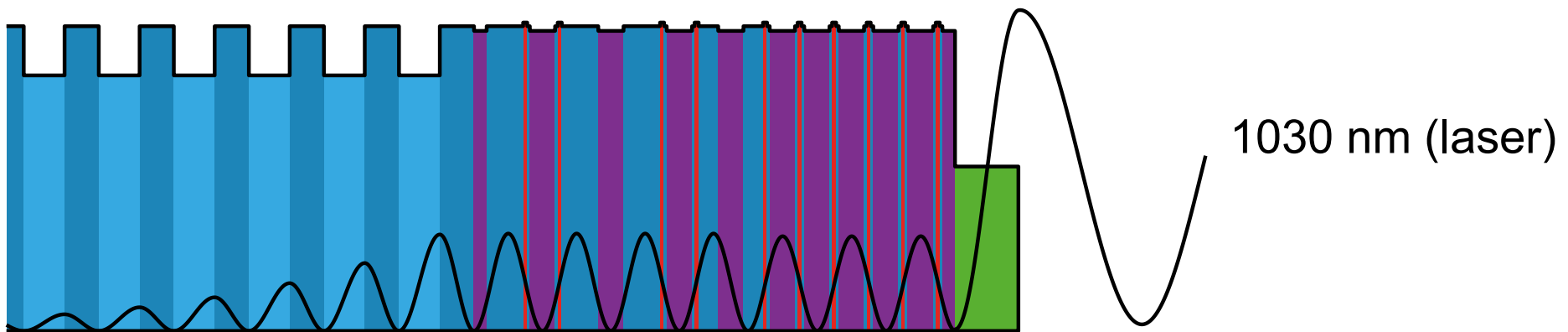
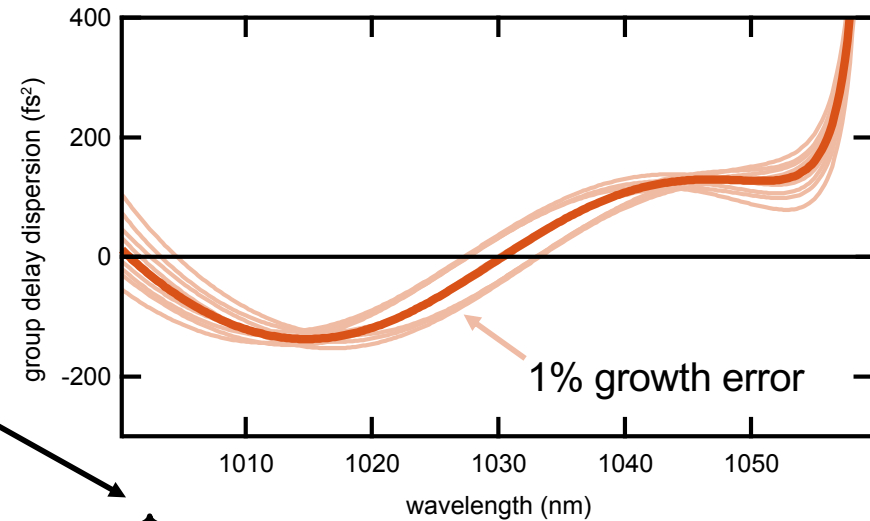


■ GaAs ■ AlAs ■ GaAsP ■ InGaAs ■ Fused silica



D. Waldburger et al., *Optica* 3, 844–852 (2016)

Group delay dispersion

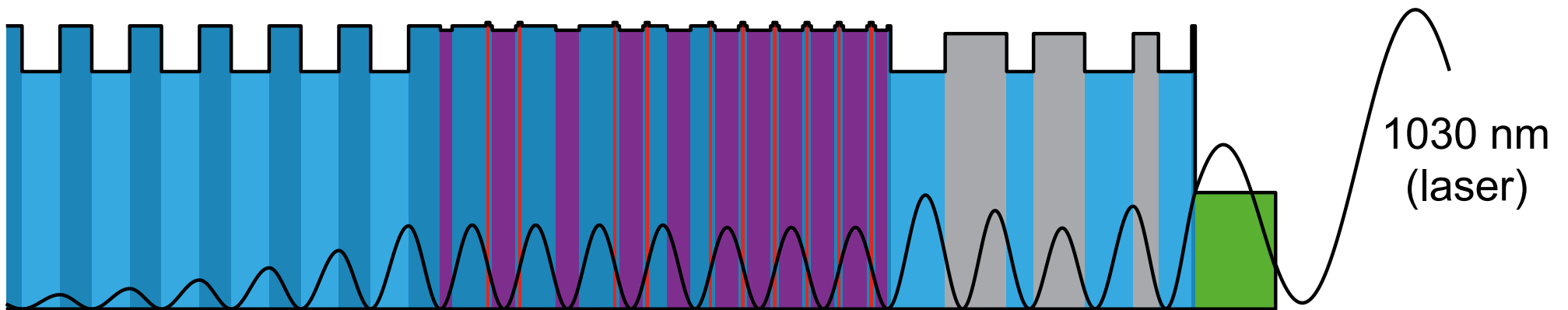
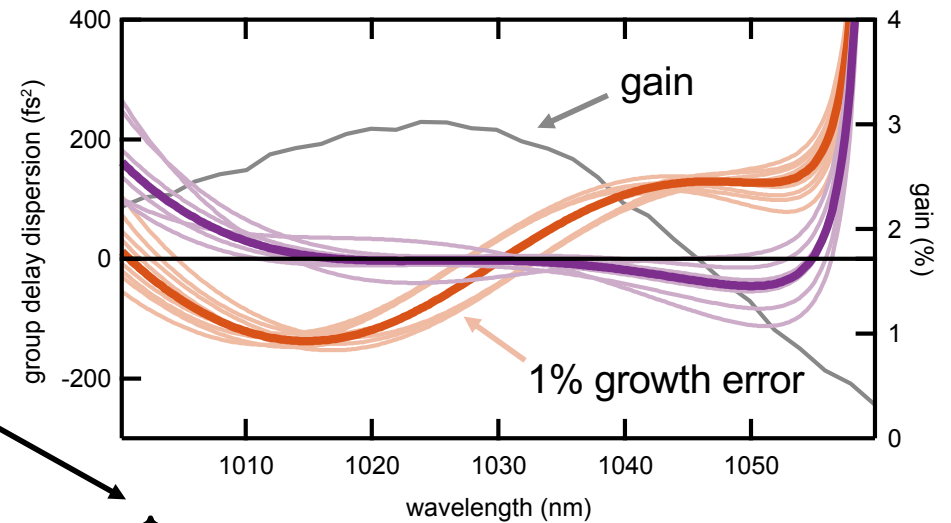


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Group delay dispersion



GaAs
 AlAs
 GaAsP
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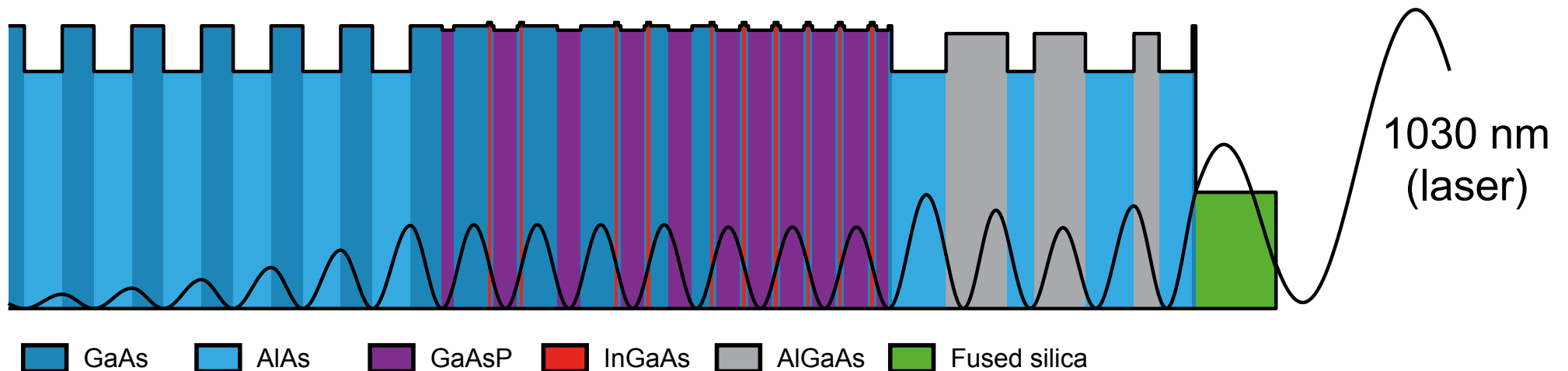
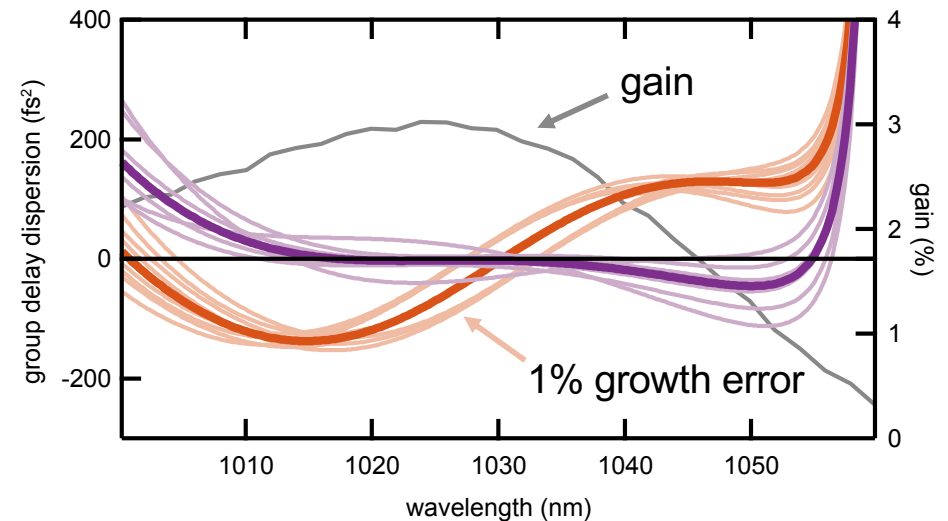


D. Waldburger et al., *Optica* **3**, 844–852 (2016)

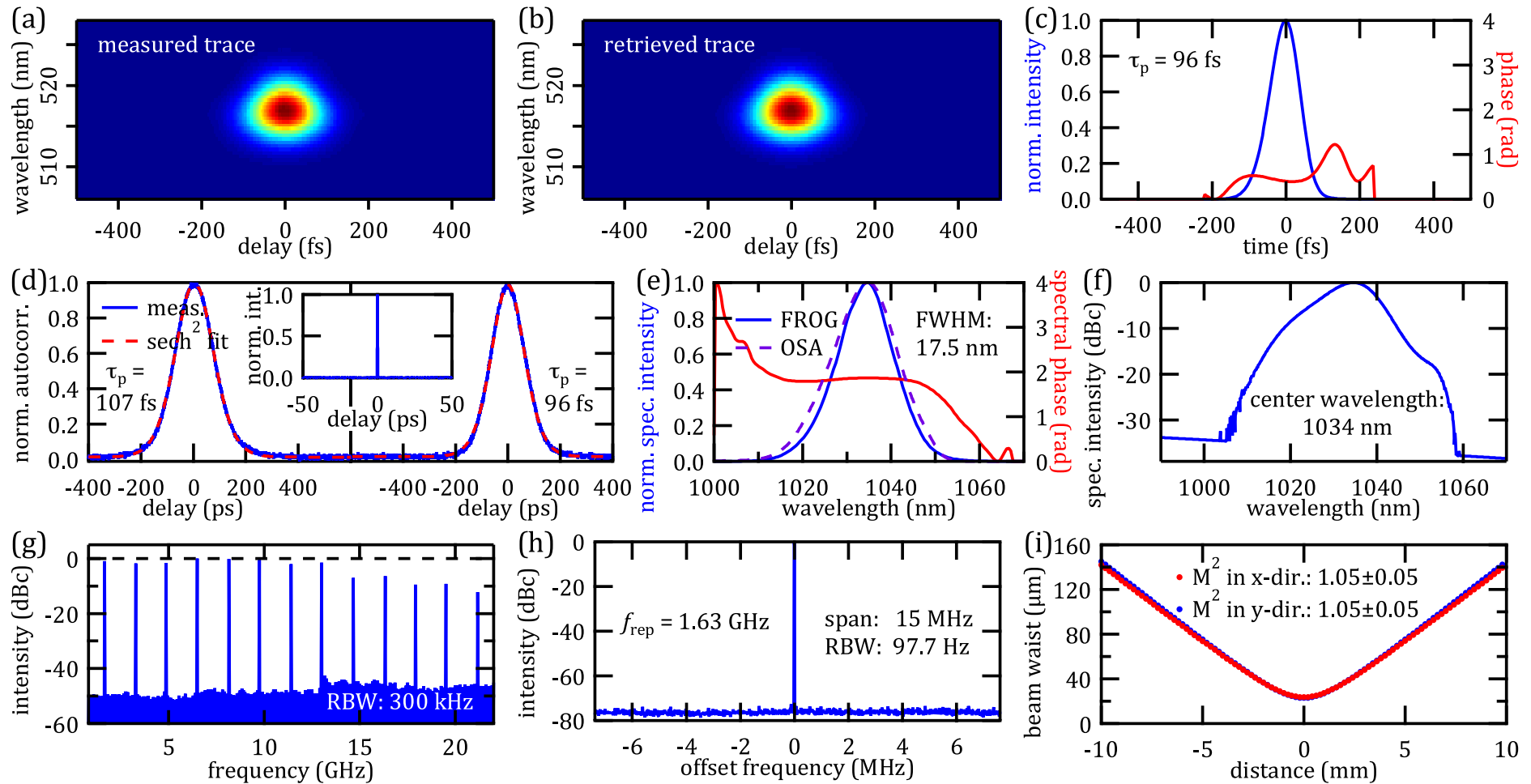
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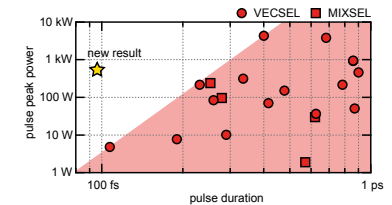
Group delay dispersion



ETH World-record 100-fs 100-mW 1.63-GHz VECSEL



Pulse duration 96 fs
 Pulse repetition rate 1.63 GHz
 Average power 100 mW
 Pulse peak power 560 W



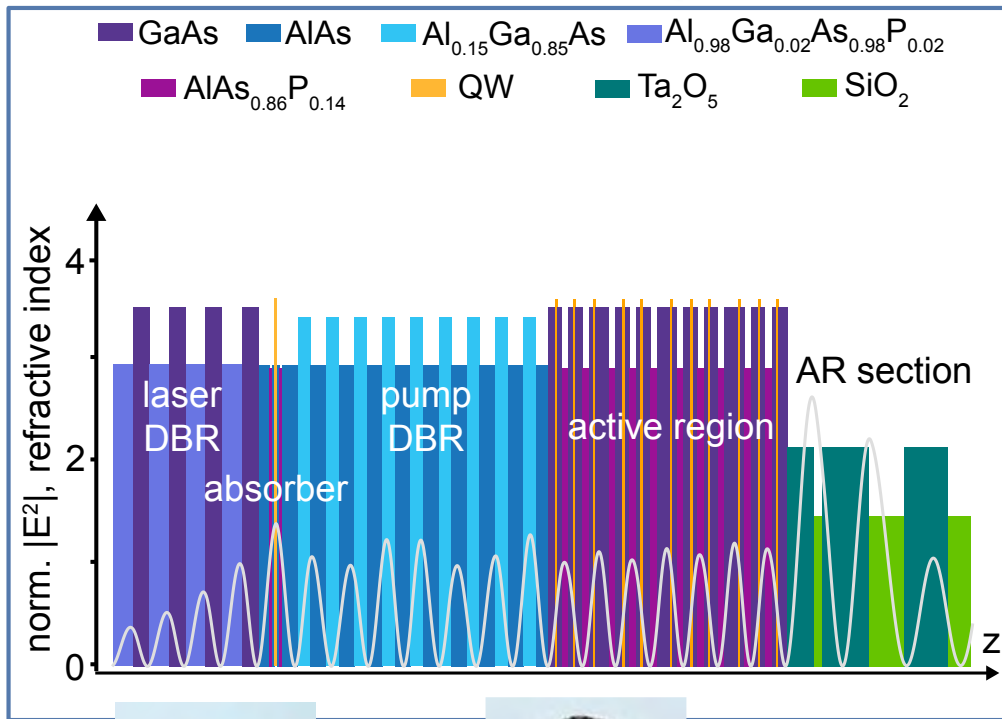
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139-fs NIR MIXSEL at 1.034 μm center wavelength



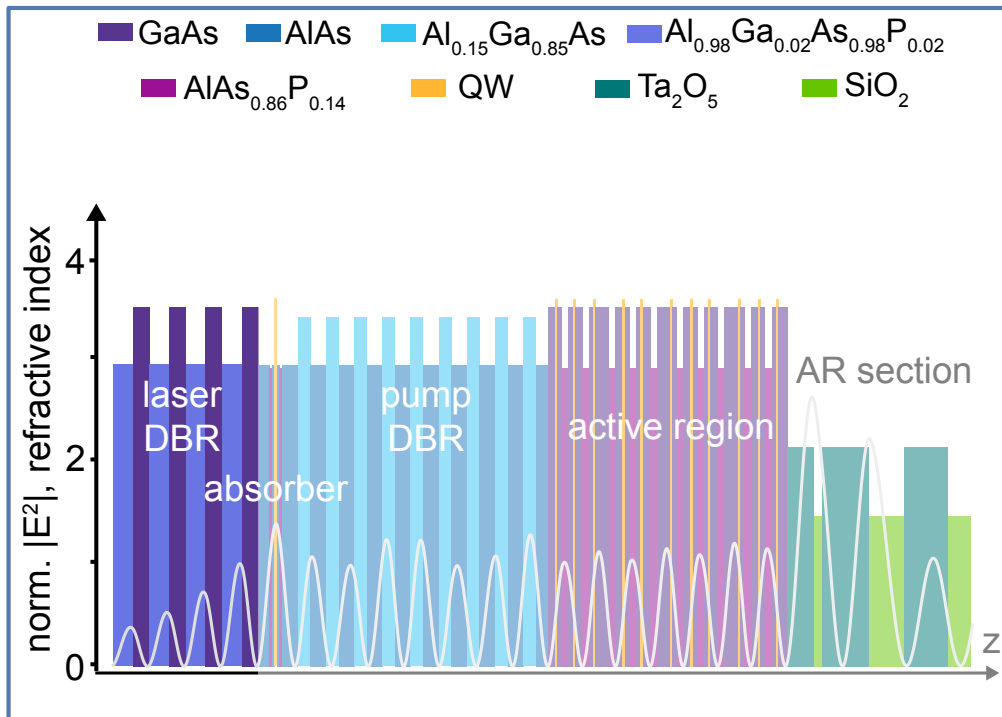
Cesare
Alfieri



Dominik
Waldburger

C. G. E. Alfieri*, D. Waldburger*, J. Nürnberg, M. Golling, U. Keller,
“Sub-150-fs from a broadband MIXSEL”, *Opt. Letters* **44**, 25 (2019)





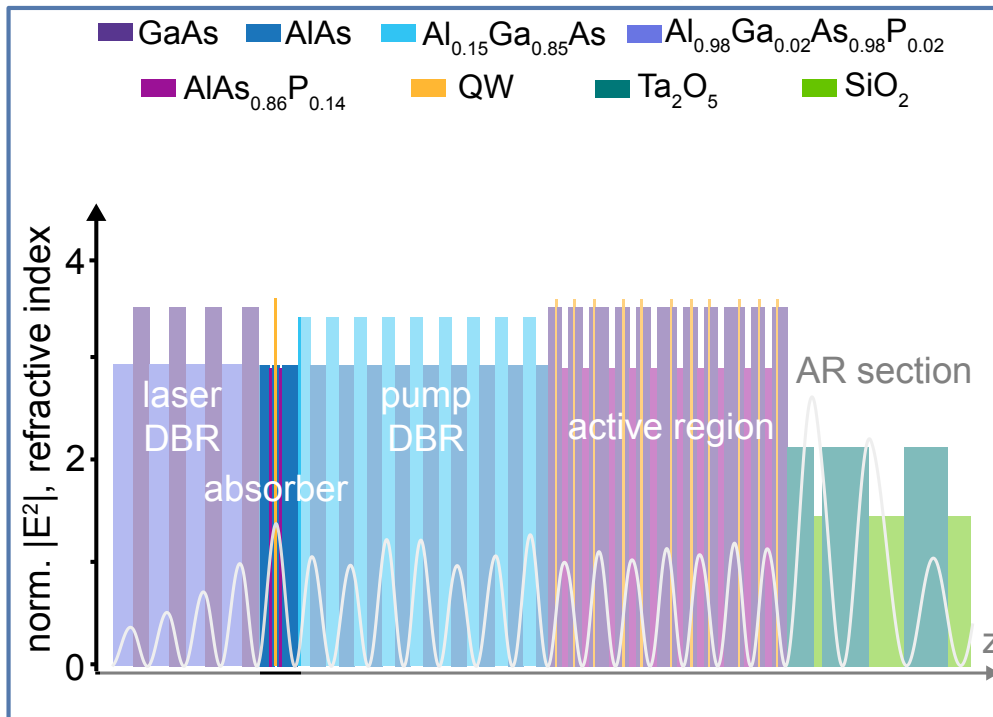
Design novelties

⇒ **Quaternary GaAs/AlGaAsP DBR**

⇒ Ga to decrease oxidation

⇒ P for strain compensation

C. G. E. Alfieri*, D. Waldburger*, J. Nürnberg, M. Golling, U. Keller,
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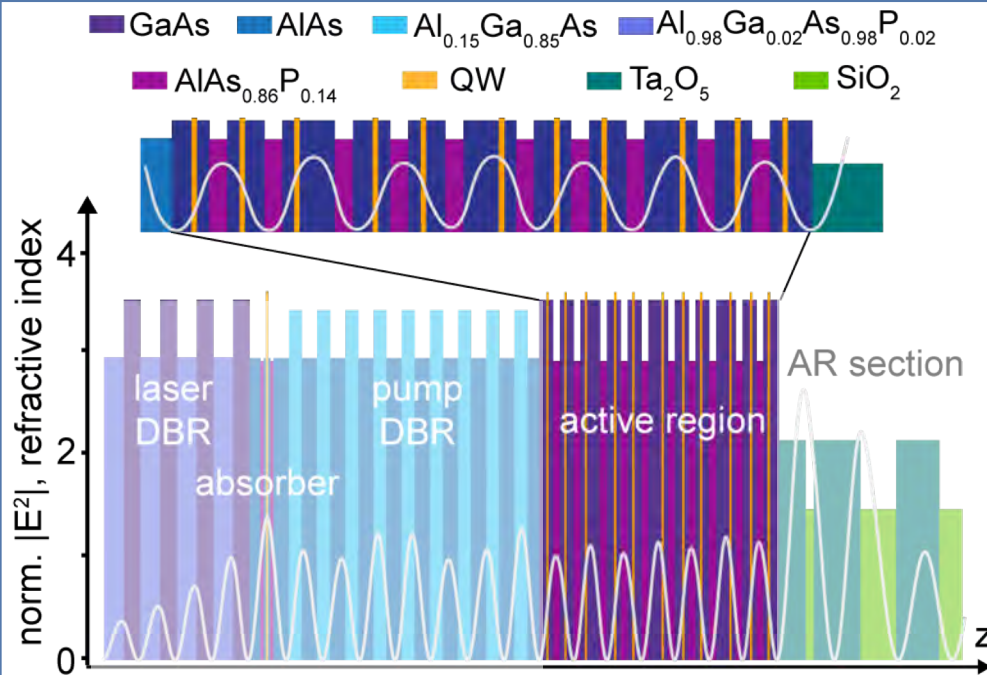
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⇒ **Strain-compensated absorber**
InGaAs QW in AlAsP/AlAs barriers

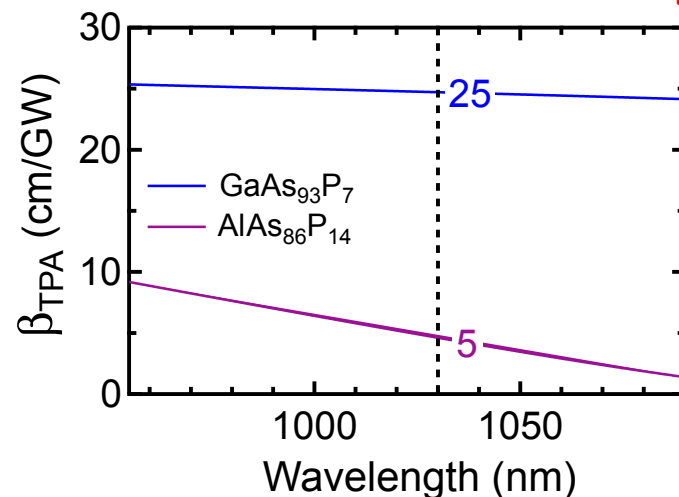
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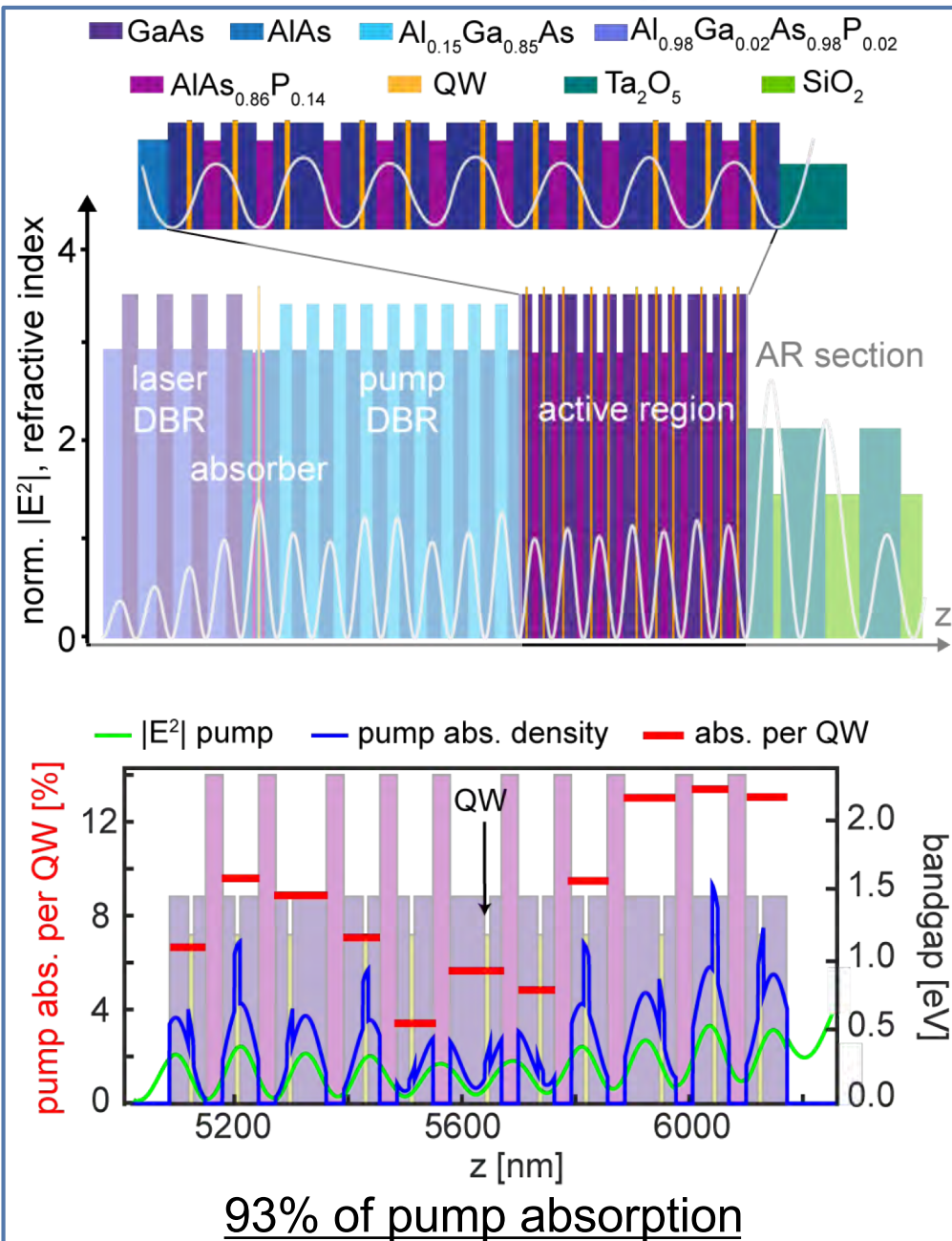
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- ⇒ Strain-compensated QW absorber
- ⇒ **Large-bandgap AlAsP strain-compensation for the active region:**
 - ⇒ **Reduced TPA losses**

Two-photon absorption (TPA) losses $\propto \frac{\beta_{TPA}}{\tau_{pulse}}$ [1]

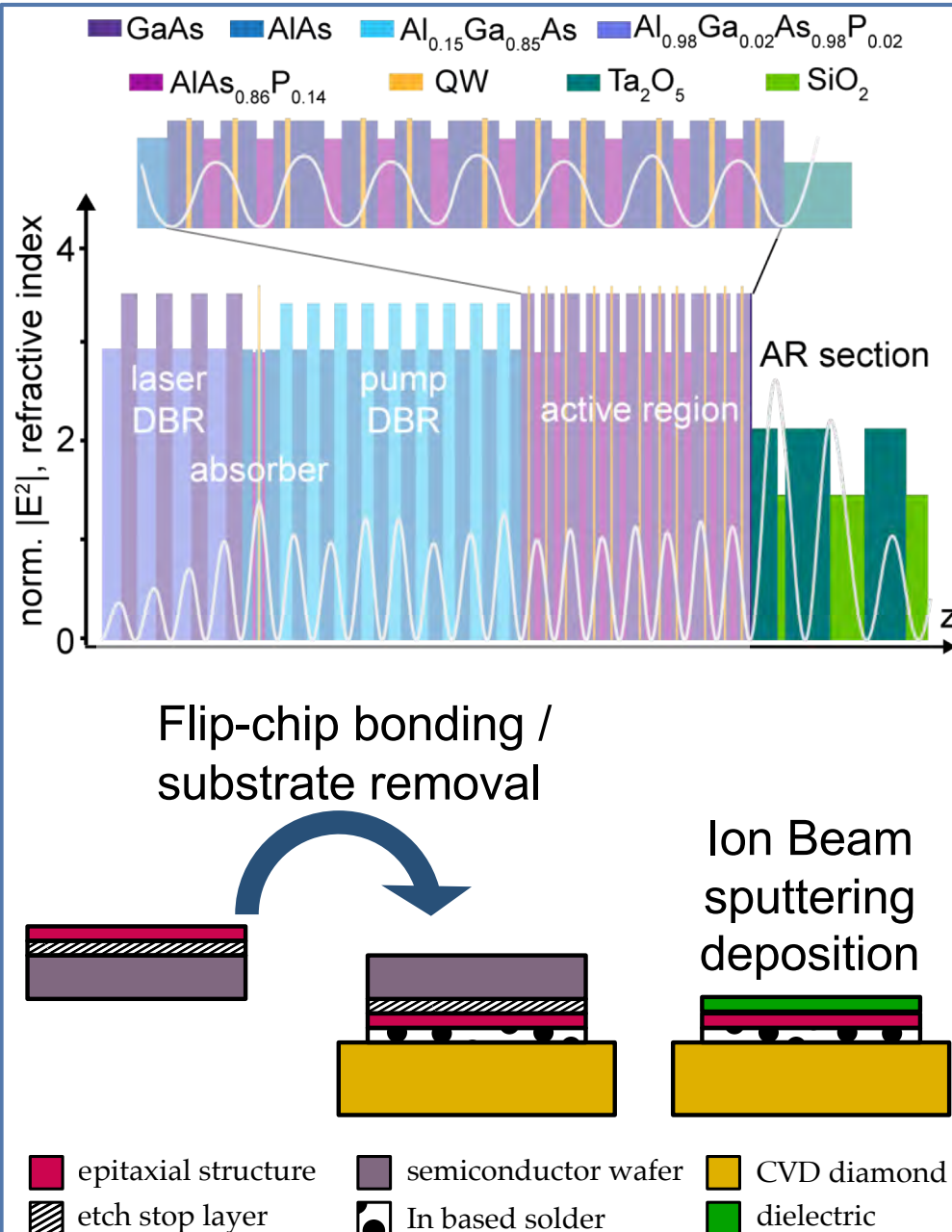


C. G. E. Alfieri, A. Diebold, F. Emaury, E. Gini, C. J. Saraceno, U. Keller.
Opt. Express 24, 27587-27599 (2016)



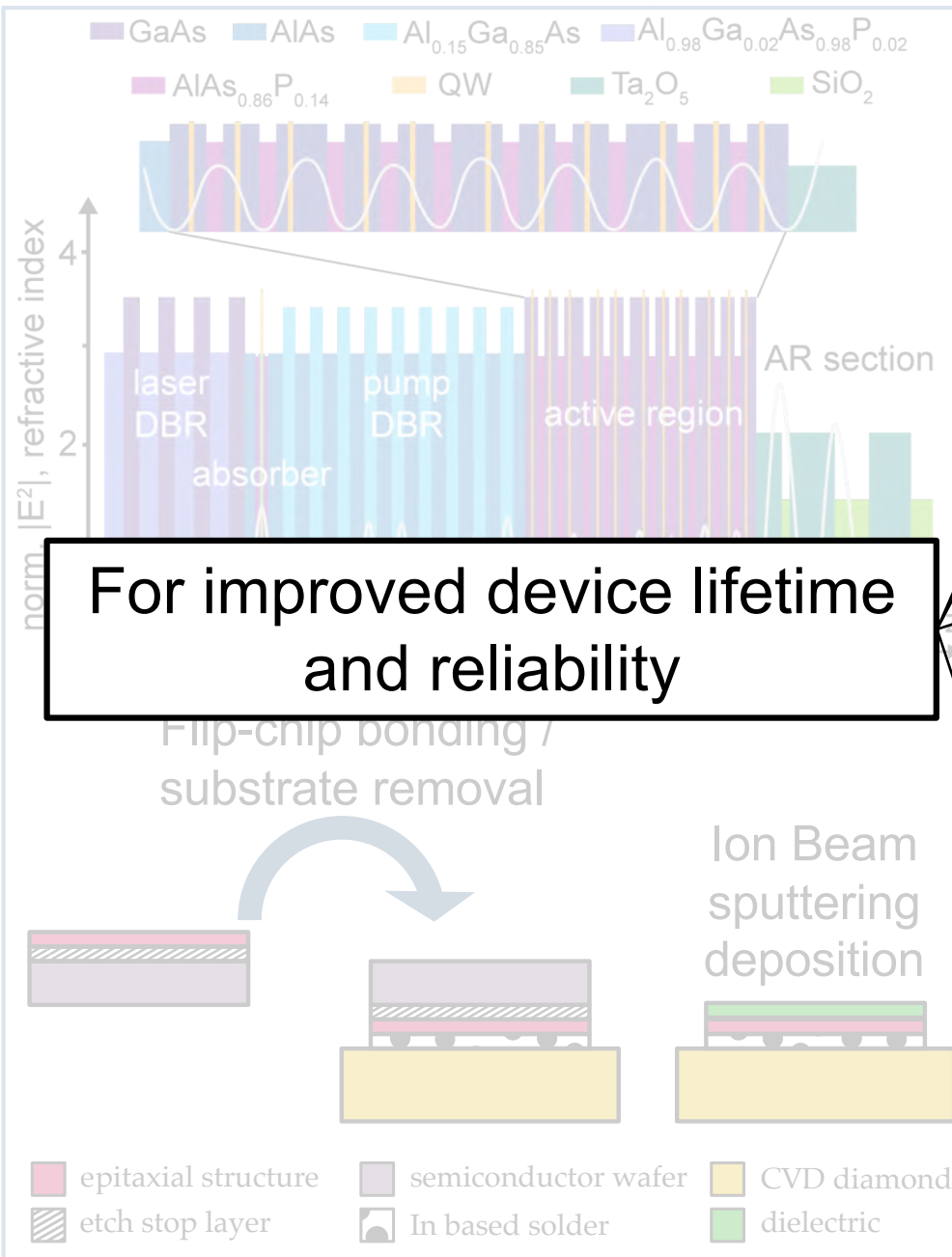
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 - ⇒ **Optimized pump absorption**
 - ⇒ **Better carrier confinement**
 - ⇒ **No spectral filtering**



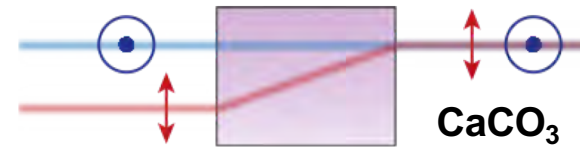
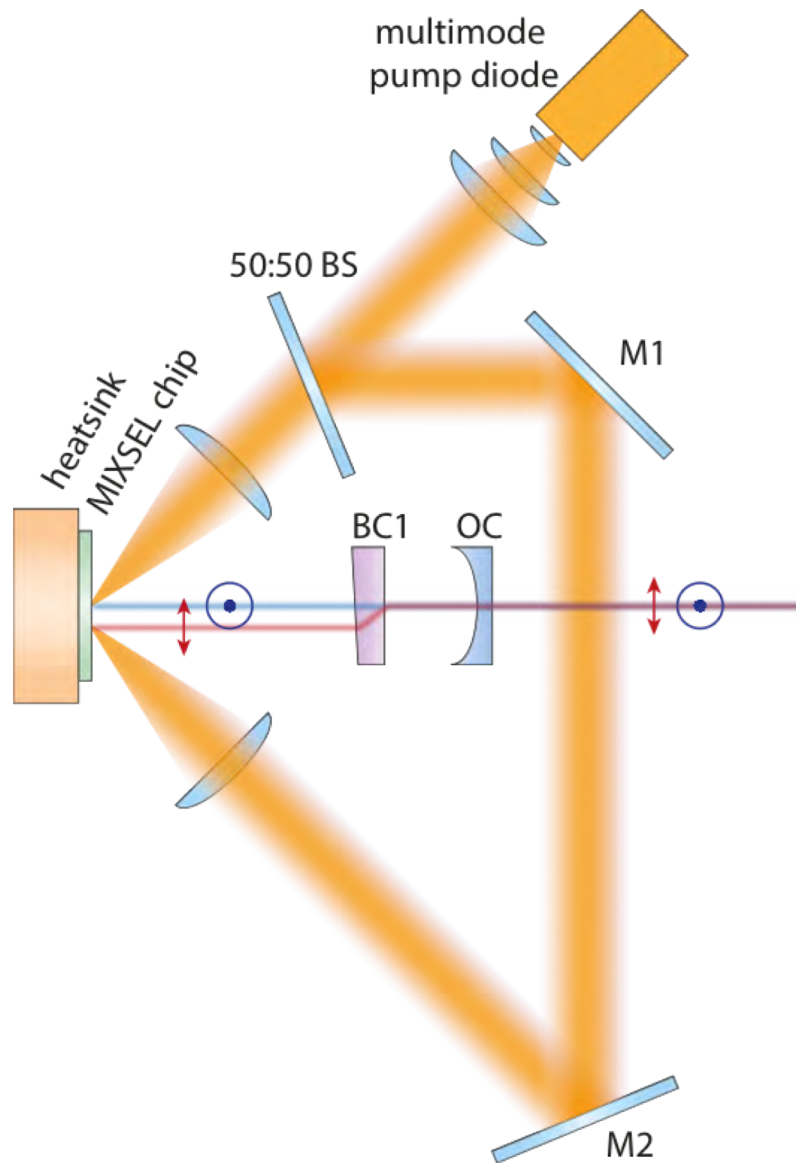
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- ⇒ **Dielectric IBS top coating:**
 - ⇒ Precise layer thickness
 - ⇒ Protection against oxidation
 - ⇒ Reduced TPA losses



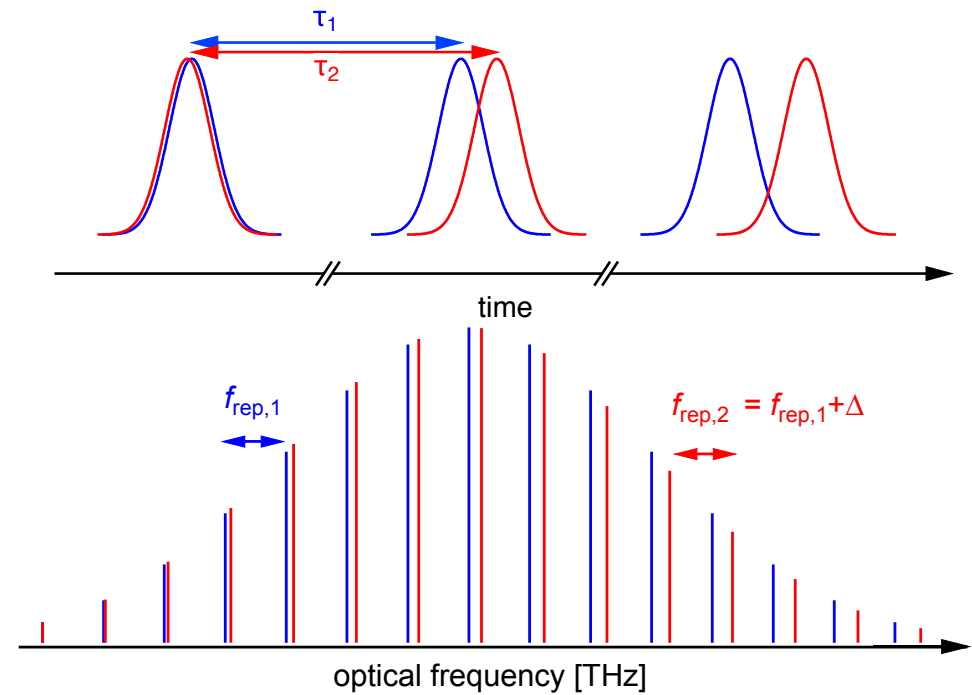
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Intracavity birefringent crystal (BC)

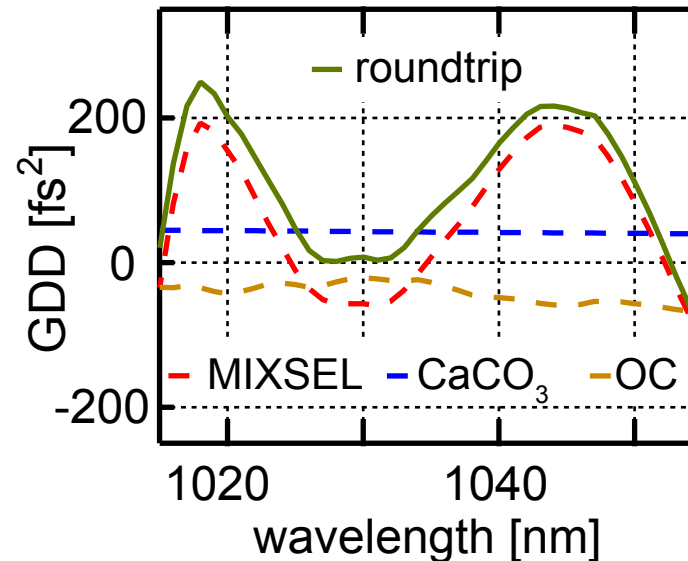
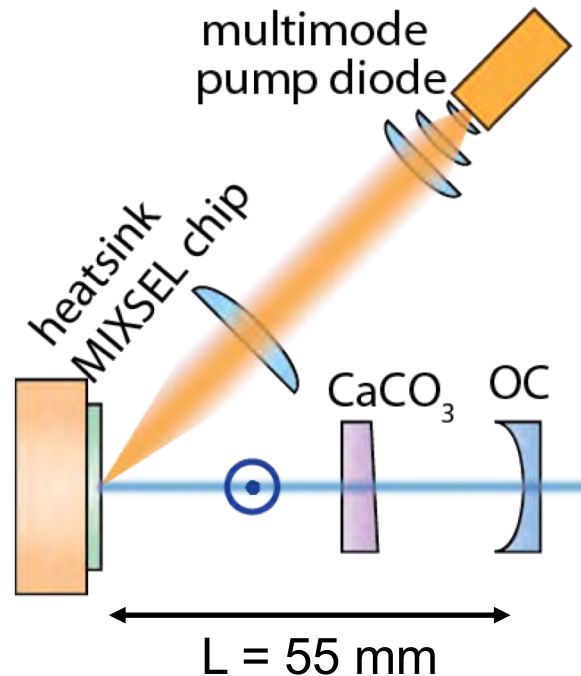
- Two spatially separated beams
- Orthogonal polarizations
- Different optical path length



S. M. Link, A. Klenner, M. Mangold, C. A. Zaugg, M. Golling, B. W. Tilma, and U. Keller, *Opt. Express* **23**, 5521 (2015).
 S. M. Link, D. J. H. C. Maas, D. Waldburger, U. Keller, *Science* **356**, 1164 (2017).

ETH zürich Group delay dispersion (GDD) optimization

To reach short sub-200-fs pulses, small but positive cavity dispersion ($0 \text{ fs}^2 < \text{GDD} < 50 \text{ fs}^2$) is required over a large spectral range

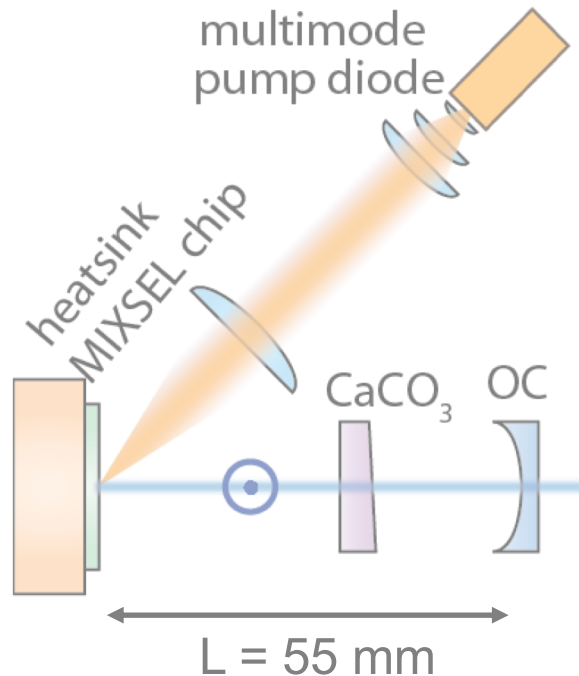


- + GDD from the MIXSEL (**IBS top-coating**)
- + GDD from the output coupler
- + $2 \times$ GDD from a **1-mm thick Calcite crystal**

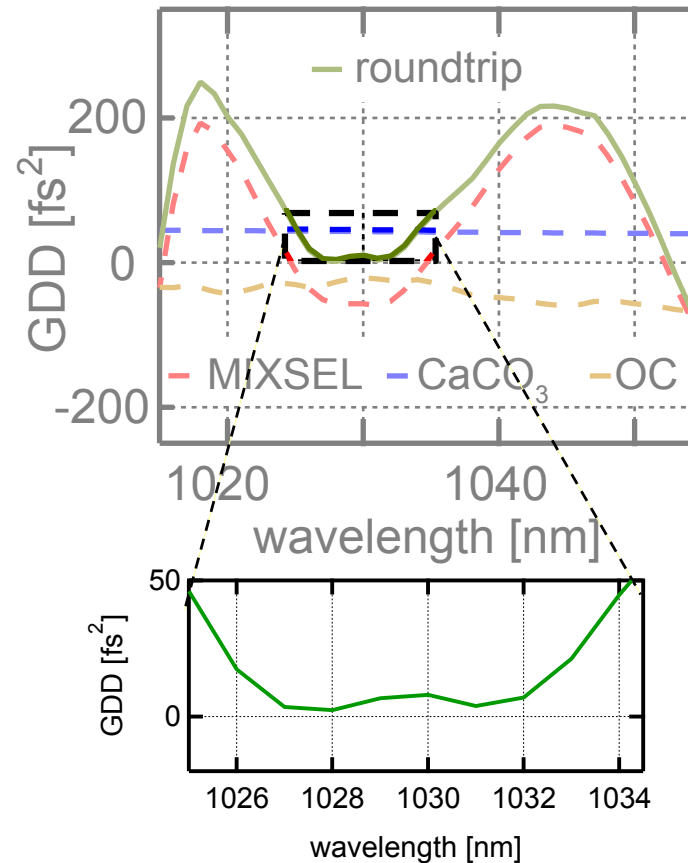


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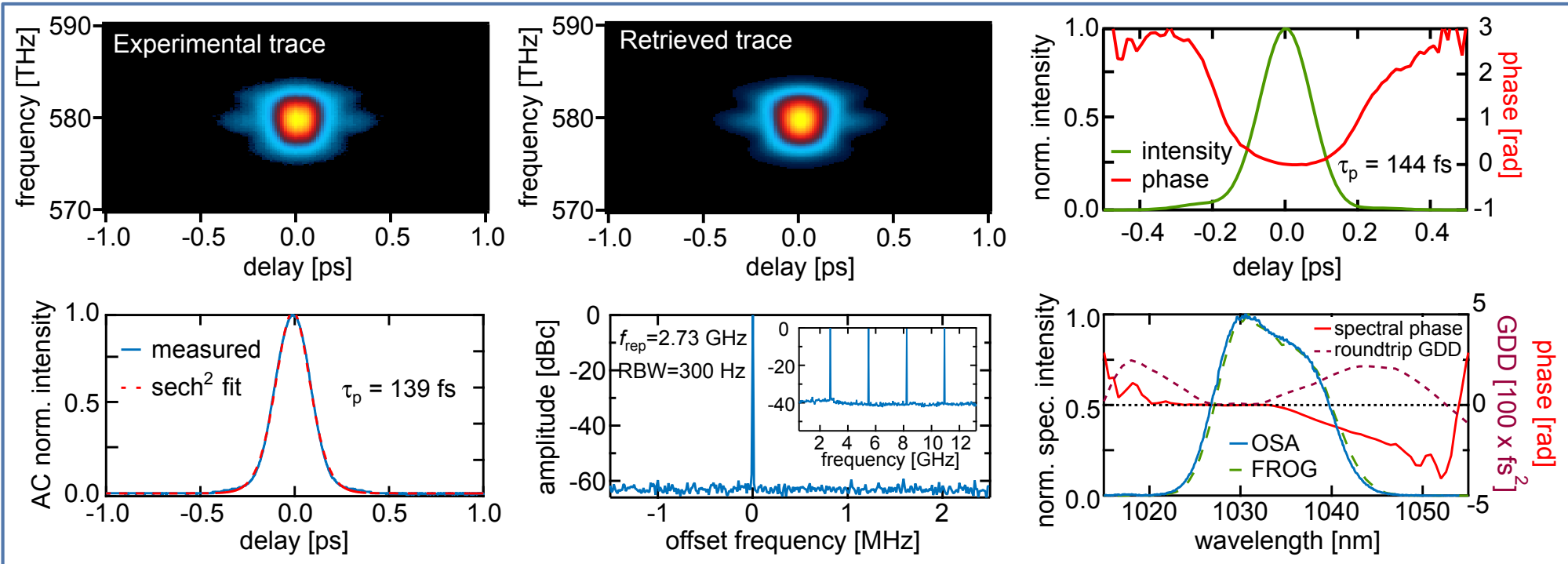


- + GDD from the MIXSEL (**IBS top-coating**)
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= **Cavity GDD balanced in the 1025-1035 nm region**



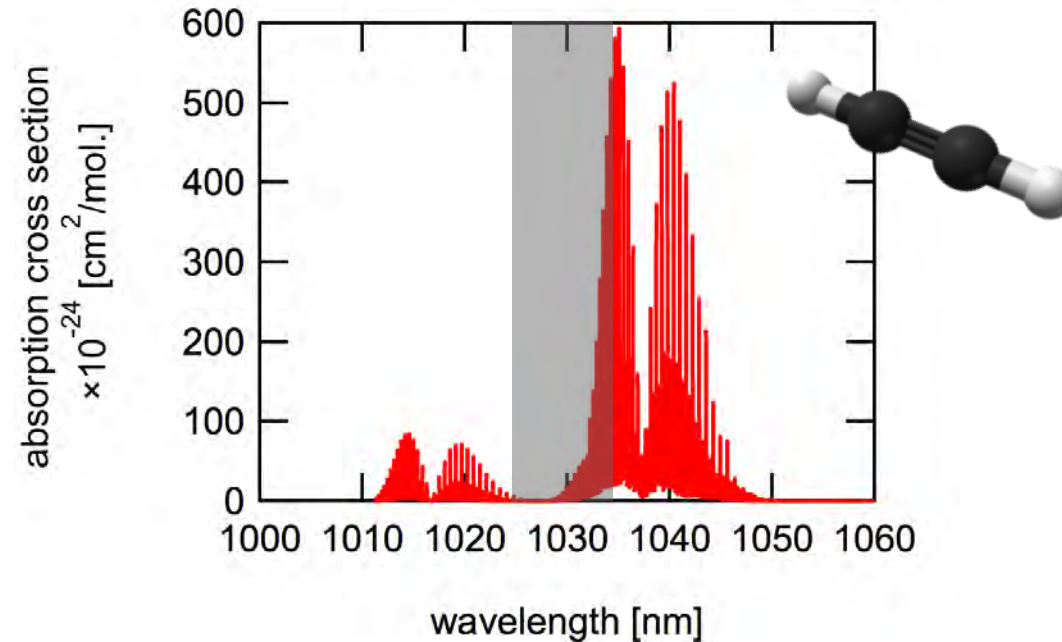


center wavelength [nm]	1033
bandwidth [nm]	13
pulse duration [fs]	139
average output power [mW]	30
pulse repetition rate [GHz]	2.73
Dual-comb operation	✓

- ✓ 13 nm of FWHM bandwidth (prev. 7.4 nm)
- ✓ Central wavelength tuned to C₂H₂
- ✓ First sub-150-fs MIXSEL
- ✓ Sufficient output power for spectroscopy
- ✓ Sufficient resolution for spectroscopy
- ✓ Turn-key for hundreds of hours

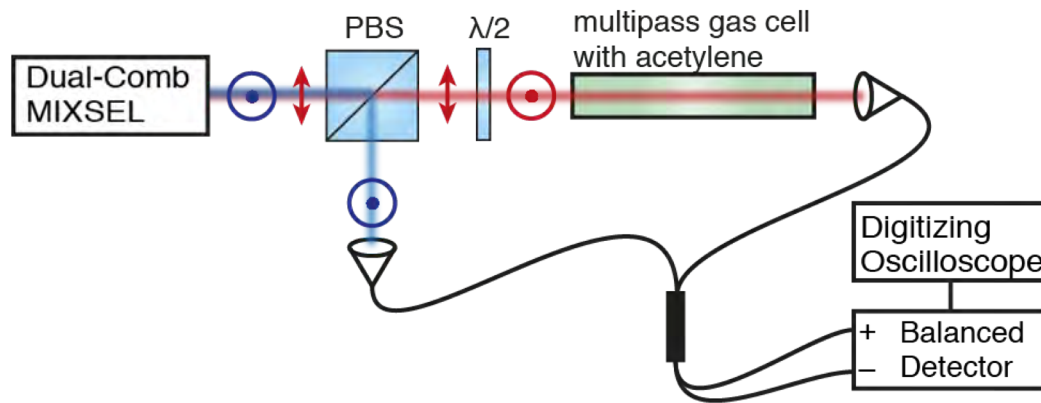


I. E. Gordon et. Al., J. Quant. Spectrosc. Radiat. Transf. **203**, 3 (2017).

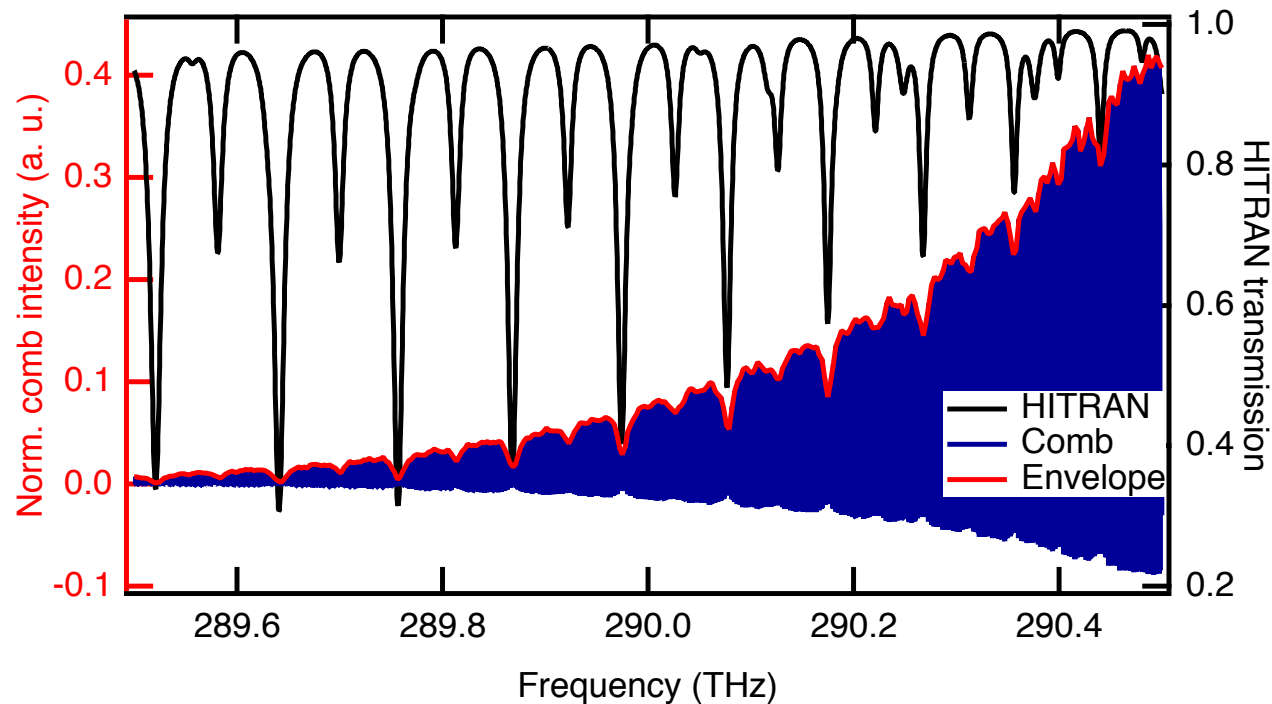


- Acetylene absorption lines (HITRAN 2016)
- Weak absorption in the near IR
- MIXSEL spectrum not perfectly matched

J. Nürnberg*, C. G. E. Alfieri*, Z. Chen, D. Waldburger, N. Picqué, U. Keller, *Optics Express* **27**, 3190 (2019)



- Absorption in commercial fiber coupled multipass gas cell*
*Manufacturer: Wavelength References
- 740 Torr pressure of acetylene (C_2H_2)
- 80 cm absorption path length
- *A posteriori* calibration to optical domain



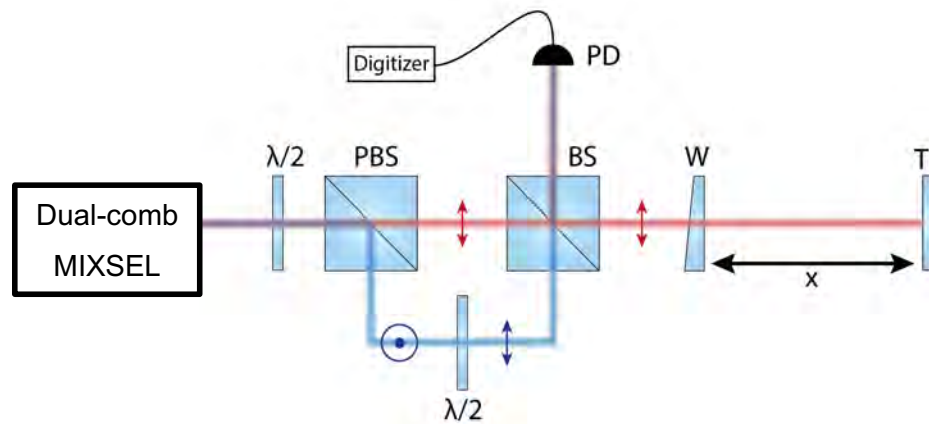
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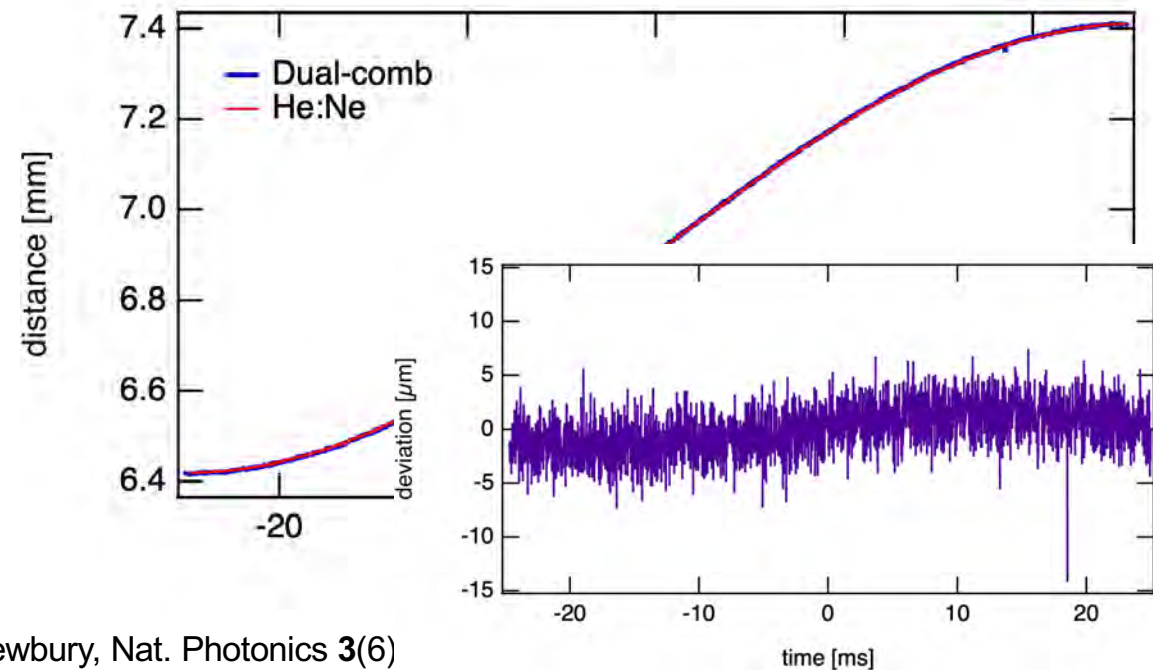




- Signal reflects of reference and target
- Beatnote contains two interferograms
- Time delay encodes distance

Motion tracking

- Measure displacement of a 10 Hz shaker
- Reference to He-Ne-interferometer
- RMS deviation < 5 μm



I. Coddington, W. C. Swann, L. Nenadovic, N. R. Newbury, Nat. Photonics 3(6)

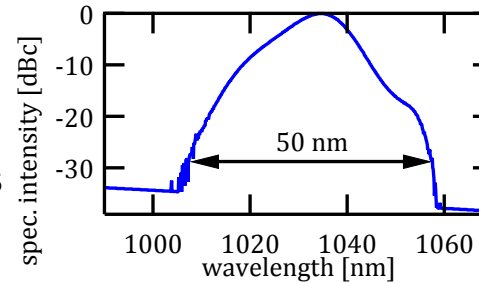
Near infrared InGaAs SDLs

Pulse shortening of VECSELs and MIXSELs [1,2]

- ps dual-comb MIXSEL
Science **356**, 1164 (2017)
- small optical bandwidth



100 fs
pulses



- fs dual-comb MIXSEL with broader spectrum
- nonlinear broadening in Si_3N_4 waveguides [3, 4]

[1] D. Waldburger et al., *Optica* **3**, 844 (2016); [2] C. G. E. Alfieri*, D. Waldburger* et al., *Opt. Letters* **44**, 25 (2019)
 [3] A. S. Mayer et. al., *Opt. Express* **23**, 15440 (2015); [4] D. Waldburger et al., *Opt. Express* **27**, 1786 (2019)



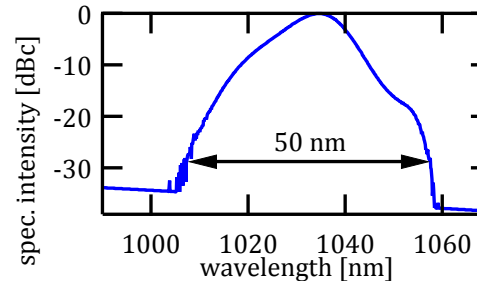
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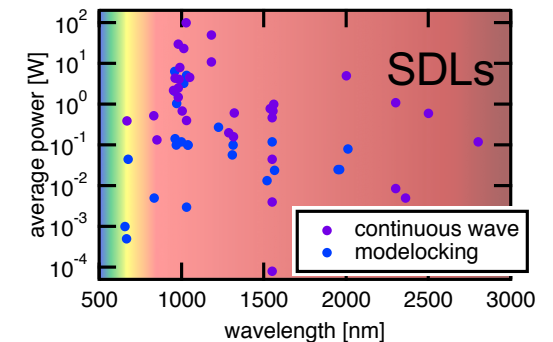
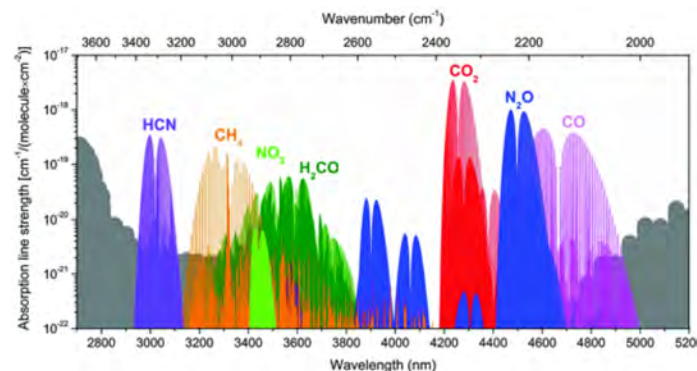
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Bandgap engineering

- 960 nm
→ water
- 1030 nm
→ acetylene



- UV-Visible
→ electronic transitions
- Mid-IR fingerprint region
→ ro-vibrational transition



- second harmonic generation
→ UV-Visible
- bandgap engineering
→ Mid-IR

ERC adv. grant

